



# Microplasmas:

**The Little Plasmas that Matter!**

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**Department of Physics**

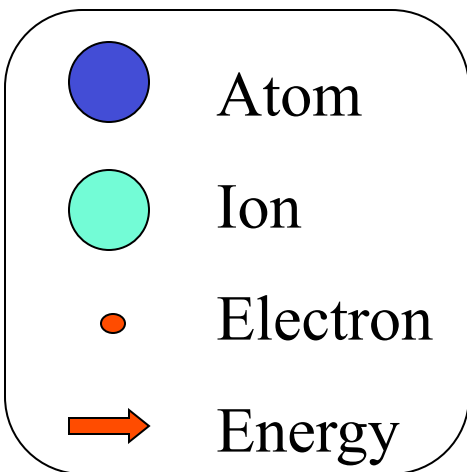
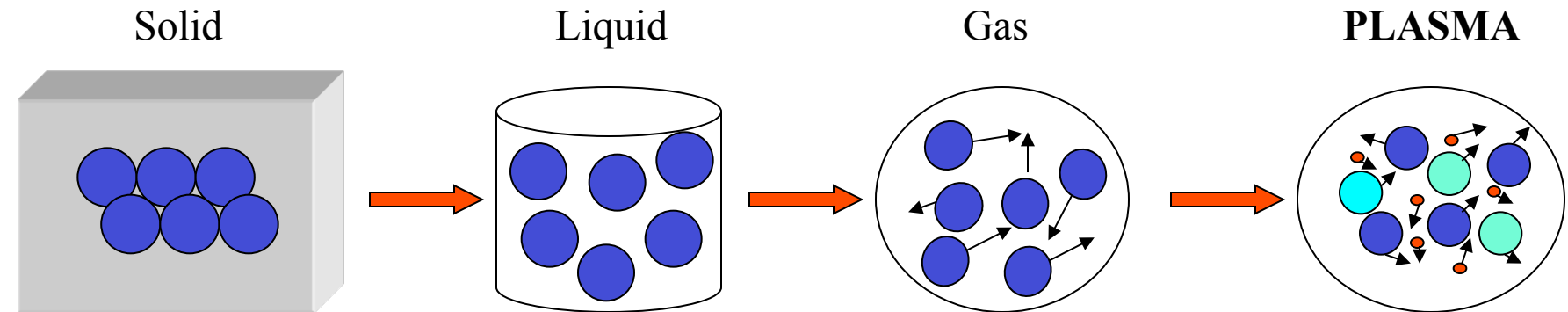
**South Orange, New Jersey (USA)**





# What is a Plasma?

**The *Plasma* state is ‘The Fourth State of Matter’ (99%)**



**A *Plasma* is a collection of neutrals, ions, and electrons characterized by a *collective behavior*.**

S. Eliezer and Y. Eliezer. *The Fourth State of Matter: An Introduction to Plasma Science*. Bristol, UK: IOP Publishing (2001)





# Where is Seton Hall?





# New Jersey – The birth place of Plasma Science



**Irving Langmuir**

## Birth of Plasma Science

**Birthplace: Hoboken, New Jersey**

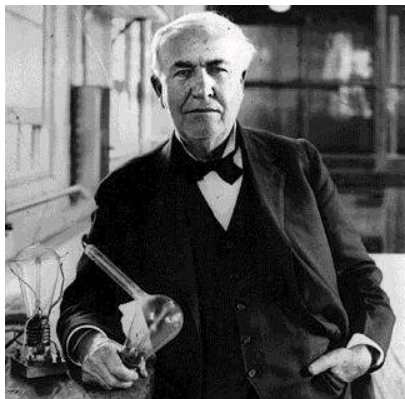
Irving Langmuir was one of the first scientists to work on plasmas and the first to refer to this 4<sup>th</sup> state of matter as ***plasmas***, because their similarity to blood plasma



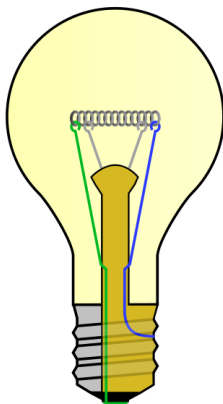




# Plasma Lighting Technology



**Thomas Edison**



**Daniel McFarlan Moore**

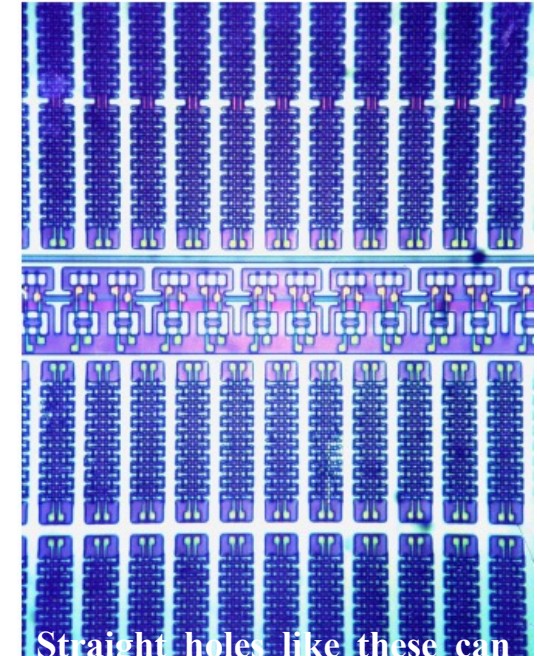
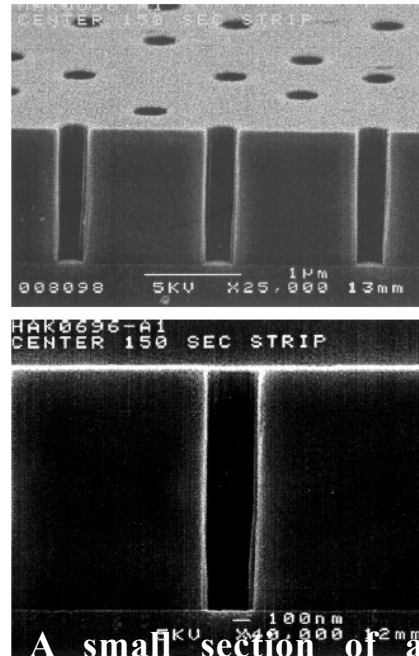
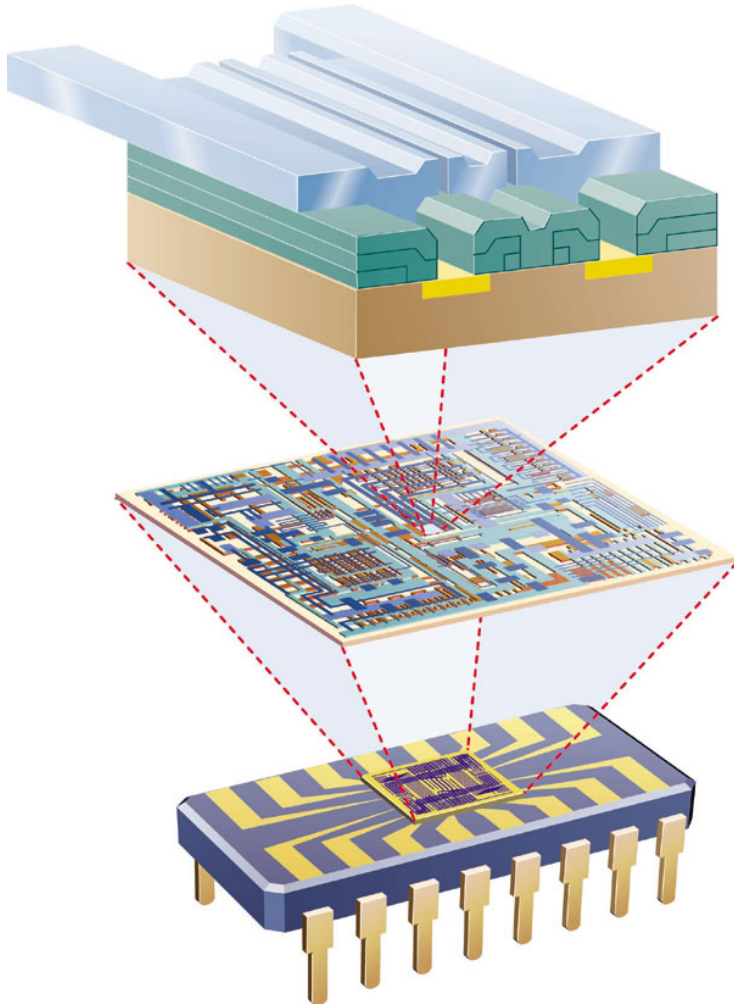


**Birthplace of the Fluorescent Light Bulb: Edison (Menlo Park) / West Orange, NJ**





# Plasma Enhanced Technology

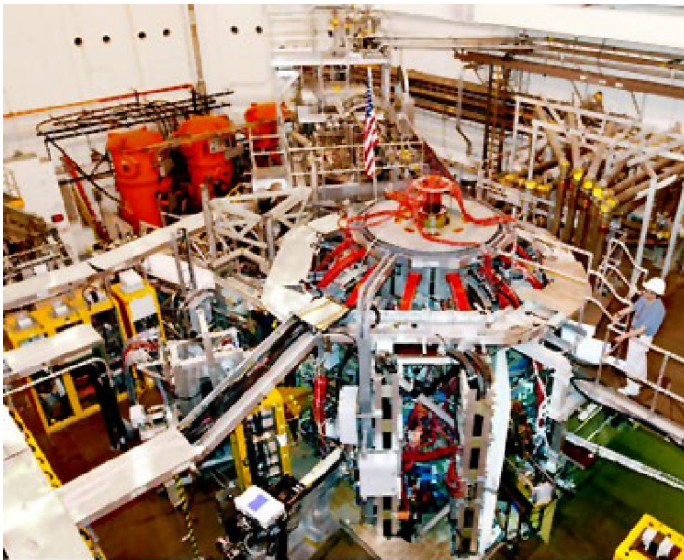


**Birthplace of solid-state microelectronics:  
Bell Laboratories, Murray Hill, NJ**

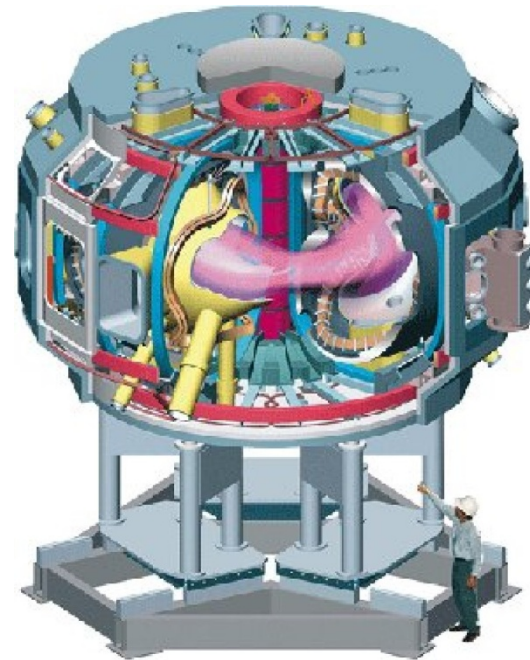




The U.S. Department of Energy's Princeton Plasma Physics Laboratory (PPPL) is a collaborative national center for plasma and fusion science. Its primary mission is to develop the scientific understanding and the key innovations which will lead to an attractive fusion energy source. Associated missions include conducting world-class research along the broad frontier of plasma science and technology, and providing the highest quality of scientific education.



National Spherical Torus Experiment (NSTX)

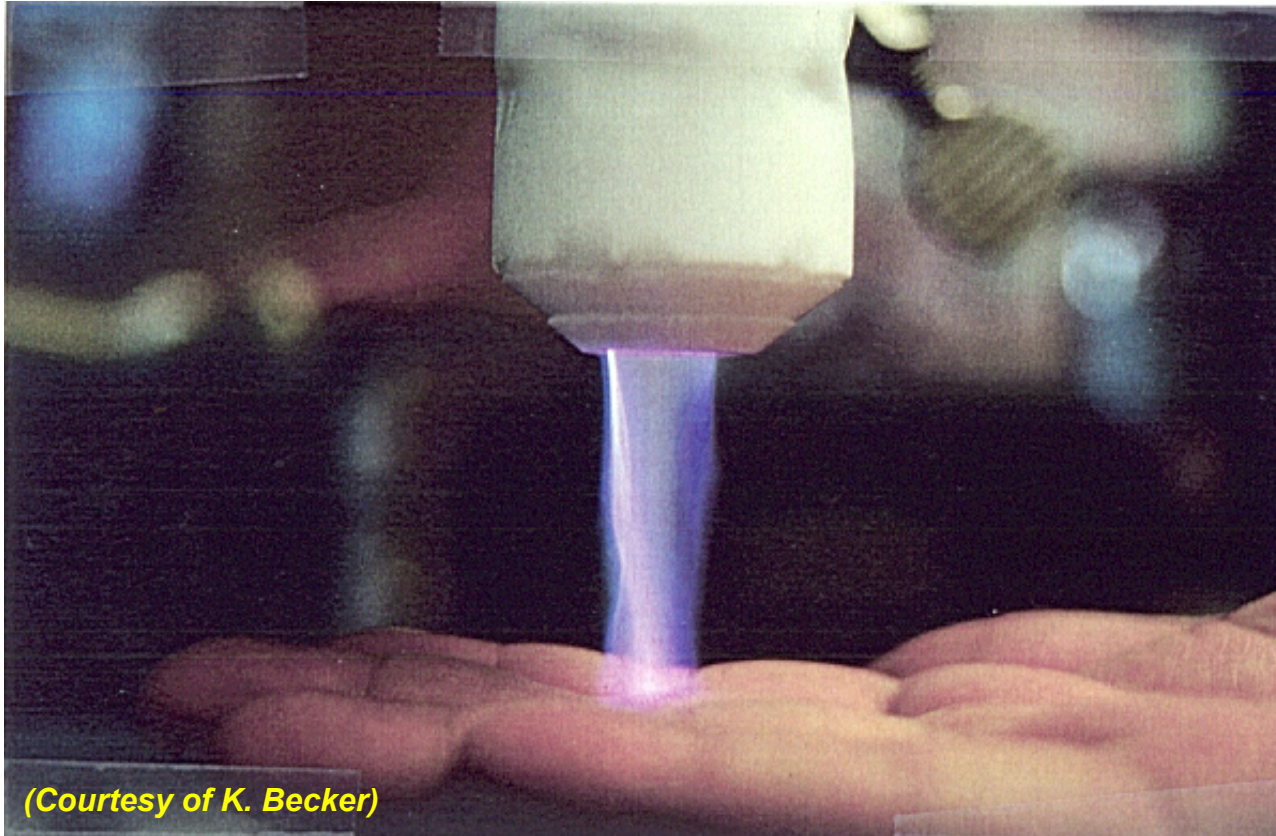




# Atmospheric Cold Plasmas

Erich Kunhardt & Kurt Becker

**STEVENS**  
Institute of Technology



*(Courtesy of K. Becker)*

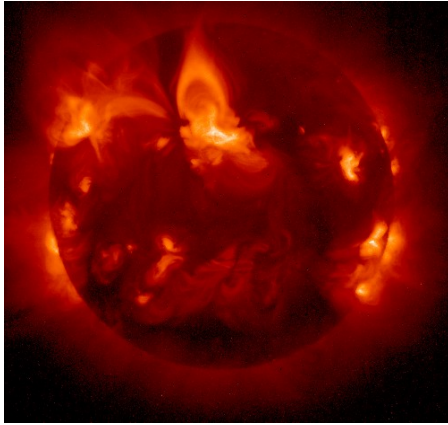
**An Atmospheric Pressure Plasma Generated with a  
Capillary-Plasma-Electrode Discharge**







# Plasmas in Nature



The Sun



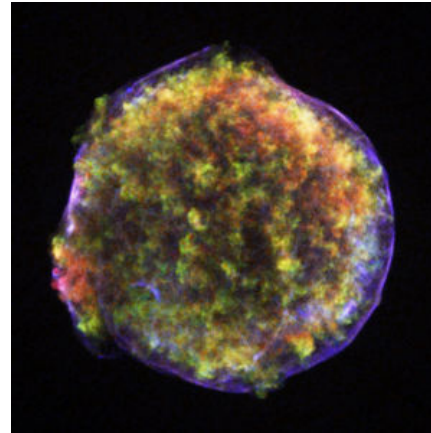
Aurora



Lightning



The Comet

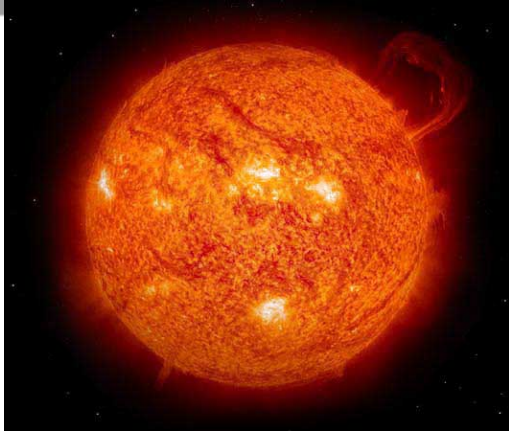


Supernova





# Plasmas are everywhere!!!



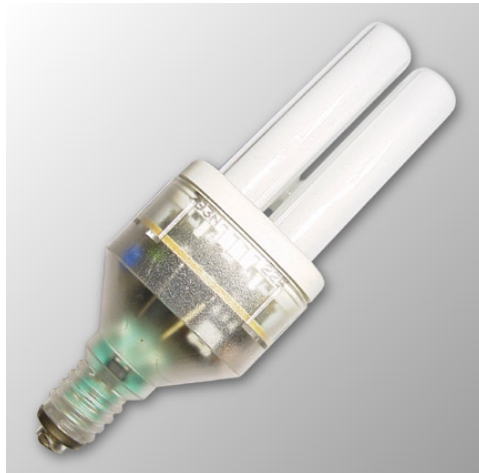
**Sun**



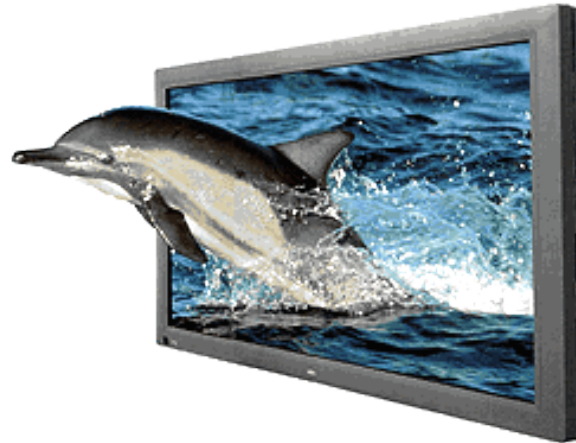
**Aurora Borealis (Northern Lights)**



**Lightning**



**Fluorescent Lamps**



**Plasma Display Televisions**



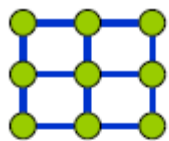


# Plasmas 101

## Solid, Liquid, Gas and ...Plasma -The 4<sup>th</sup> State of Matter

### SOLID

- Molecules fixed in lattice
- Electrons bound to molecules or lattice



ENERGY

### LIQUID

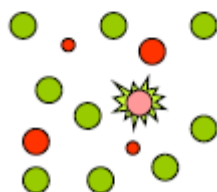
- Molecule bonds are flexible
- Electrons close to molecules



ENERGY

### GAS

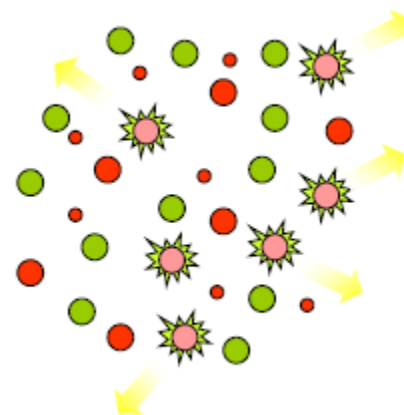
- Molecules free to move
- Few electrons and ions that are free to move
- Some excited molecules are present



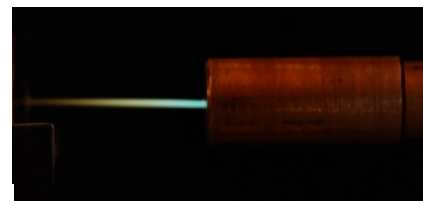
ENERGY

### PLASMA

- Molecules free to move
- Many electrons, ions and excited molecules, all free to move
- often accompanied by light



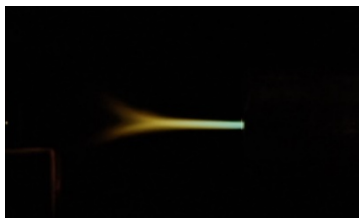
>99% in Universe



- Molecules
- Excited molecules
- Ions
- Electrons

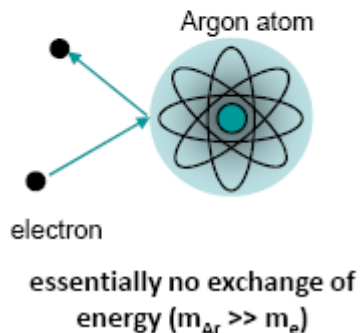


# The Eventful Plasma World



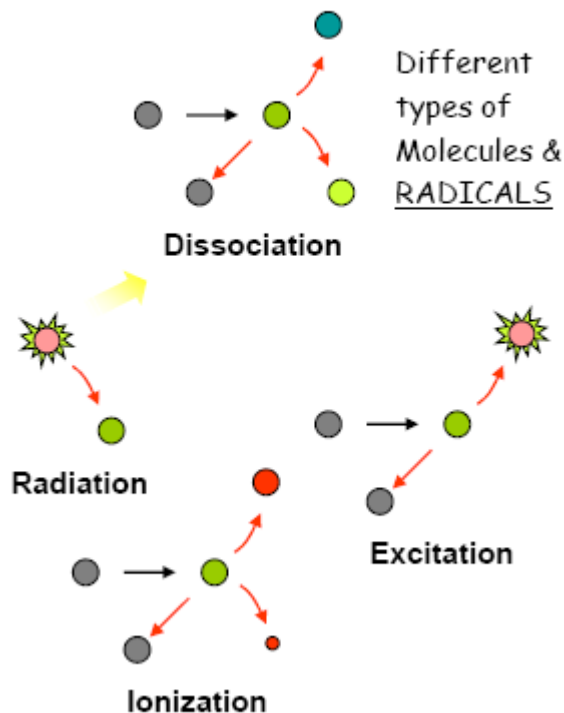
## Elastic collisions

Elastic collisions are frequent in gases  
No energy exchange



## *Collisions in a plasma*

### Inelastic collisions



- Molecules
- Excited molecules
- Ions
- Electrons

Gas  
  
 Plasma

Therefore more and stronger collisions leading to more

ionization, excitation, dissociation and radiation





# Two Types of plasmas

## High-temperature plasmas (Hot Plasmas)

$$T_i \approx T_e \geq 10^7 \text{ K}$$

e.g., fusion plasmas

$$T_i \approx T_e \approx T_g \leq 2 \times 10^4 \text{ K}$$

e.g. arc plasma at normal pressure

## Low-temperature plasmas (Cold Plasmas)

$$T_i \approx T_g \approx 300 \text{ K}$$

$$T_i \ll T_e \leq 10^5 \text{ K}$$

e.g. low-pressure glow discharge

high-pressure cold plasma





# Hot vs. Cold Plasmas

## Thermal vs. Non-Thermal Plasmas

The plasma components (electrons, ions, neutrals) are characterized by energy distribution functions or alternatively by an “average” energy or temperature ( $T_e$ ,  $T_i$ ,  $T_n$ ) – not quite correct, only true for Maxwell-Boltzmann distributions !!!

**Electrons in general have more complicated energy distributions !!!**

Thermal Plasma:  $T_e \approx T_i \approx T_n$  (a few thousand Kelvin for e.g. torches to  $>10^6$  Kelvin for e.g. fusion plasmas)

Non-Thermal Plasma:  $T_e \gg T_i, T_n$  with  $T_i \approx T_n$

- high electron temperature (10,000 – 50,000 K)
- low gas temperatures (300 – 1,500 K)
- “high-temperature chemistry” at low ambient temperatures  
(through dissociation and ionization & vibrational non-equilibrium)







# Low-Temperature (“Cold”) Plasmas [Non-equilibrium, Non-Thermal]

$$\longrightarrow T_e \gg T_i, T_n \text{ with } T_i \approx T_n \longleftarrow$$

- **High “electron temperature” (10,000 – 100,000 K)**
  - ❖  $T_e$  from 0.5 eV to 10 eV
  - ❖ Often highly non-Maxwellian EEDF; “bulk” and “beam” electrons
- **Low gas temperature (350 – 2,500 K)**
- **“High-temperature chemistry” at low ambient temperatures**
  - ❖ Electron-driven ionization and dissociation (in molecular plasmas) create reactive radicals
  - ❖ Electron interactions (in molecular plasmas) create a vibrational non-equilibrium



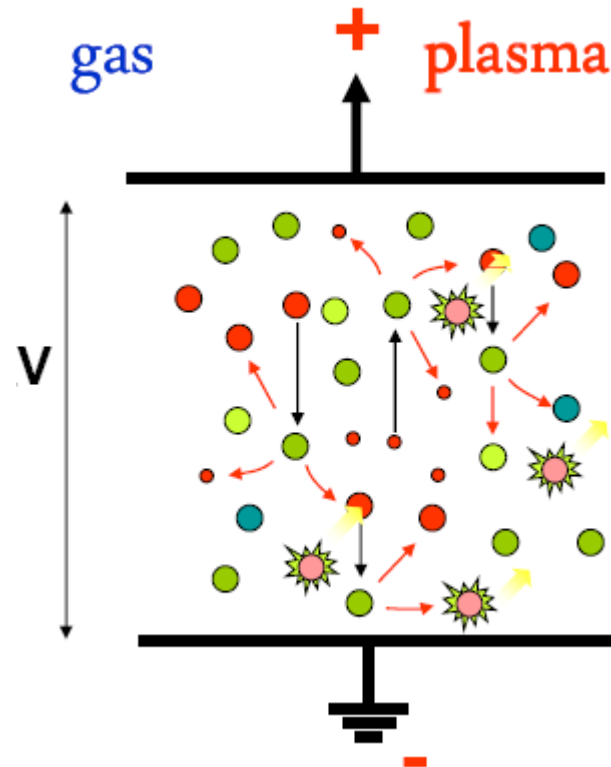
# How do we make plasmas?

Supply Energy!!  
e.g. Heat transfer, radiation,  
electric power...

For many plasma applications,  
an Electric Field is applied to a  
gaseous environment

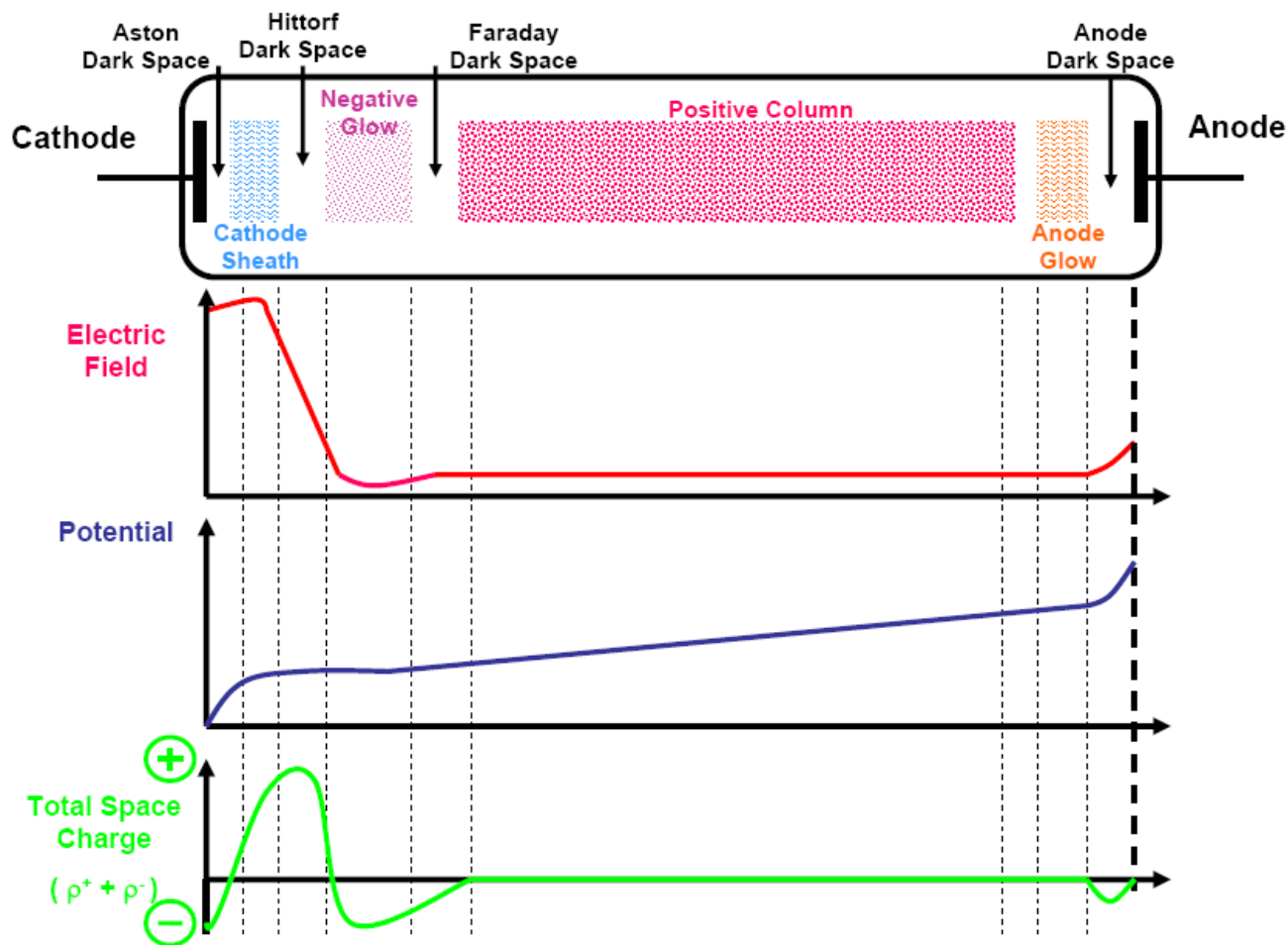
## Plasma or Gaseous Discharge

- Molecules
- ☀ Excited molecules
- Ions
- Electrons





# Low-Pressure Glow Discharge Plasmas



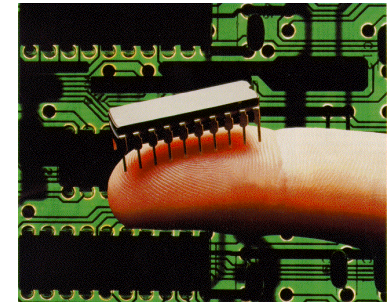
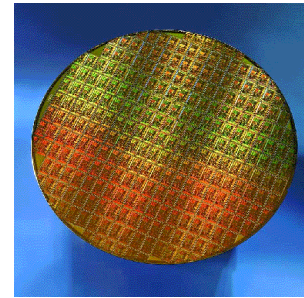


# Plasmas are easier to be generated at low pressures

## Low pressure plasmas

(1 mTorr ~ a few Torr)

- are well understood
- are used extensively nowadays (e.g. in semiconductor industry for computer chips manufacturing)



However, to generate low pressure plasmas:

- vacuum chambers
- expensive vacuum pumps
- pressure monitoring and pressure control devices



+



+



=



***Generate Plasmas at Atmospheric Pressure!!***

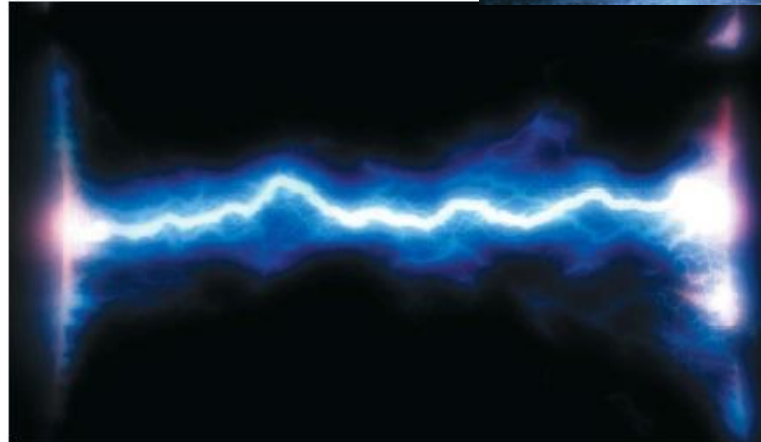


# What happens at air pressure?

- No vacuum is involved
- Difficult to generate and sustain
- Run into some challenges such as glow to *arc* transition – Non controllable

Arc Discharge: thermal plasma

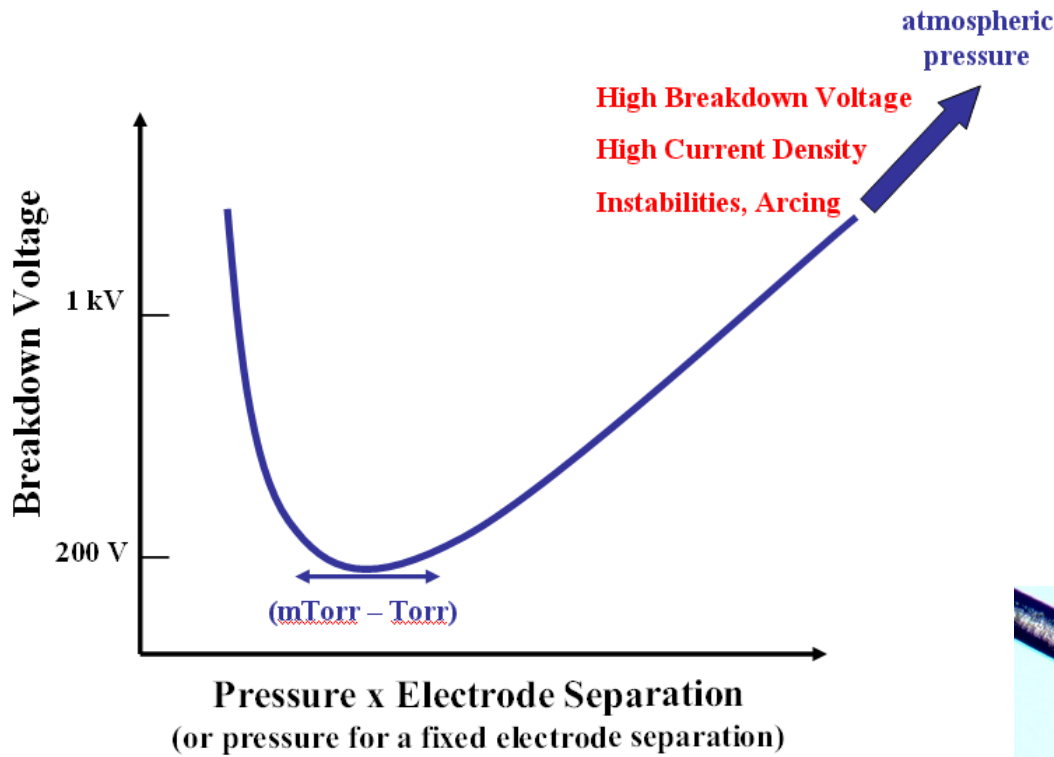
- It's hot and detrimental
- Gas temperature can reach as high as  $2 \times 10^4$  K
- Low voltage drop at cathode
- High cathode current density







# High Pressure Microplasmas



**Paschen Breakdown Curve**

Stabilization of high-pressure plasmas: “pd scaling”: “p”  $\uparrow$ , so “d”  $\downarrow$  to keep breakdown voltage low and minimize instabilities after breakdown -

## Microplasmas

Dimension: a few millimeter down to and below **100  $\mu\text{m}$**



Human Hair: 60 – 100  $\mu\text{m}$





# How do we solve this problem?

**Transient (pulsed) plasmas:** *In atmospheric plasmas, for efficient gas heating at least 100-1000 collisions are necessary. Thus, if the plasma duration is shorter than  $10^{-6} - 10^{-5}$  s, gas heating is limited. Of course, for practical purposes such plasma has to be operated in a repetitive mode, e.g., in trains of microsecond pulses with millisecond intervals.*

**Micro-confinement:** Gas heating occurs in the plasma volume, and the energy is carried away by thermal diffusion/convection to the outside. If the plasma has a small volume and a relatively large surface, gas heating is limited.

**Dielectric Barrier Discharges:** These plasmas are typically created between metal plates, which are covered by a thin layer of dielectric or highly resistive material. The dielectric layer plays an important role in suppressing the current: the cathode/anode layer is charged by incoming positive ions/electrons, which reduces the electric field and hinders charge transport towards the electrode. DBD also has a large surface-to-volume ratio, which promotes diffusion losses and maintains a low gas temperature.



# Advantages of Microplasmas

- Low-cost of implementation
- System flexibility
- Atmospheric pressure operation
- High densities and high reaction rates
- Fast and efficient processes
- Easy to generate and sustain for a variety of gas mixtures
- Glow-like and diffuse
- Non-equilibrium ( $T_e > T_g$ ) *to thermal*
- Unique chemistry

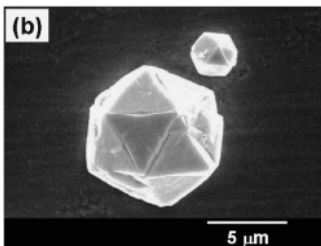
... a new realm of plasma science





# What can we do with it?

Material Synthesis



Plasma display



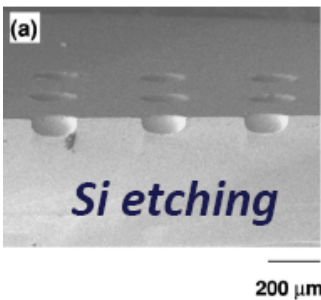
Surface Treatment



Lighting



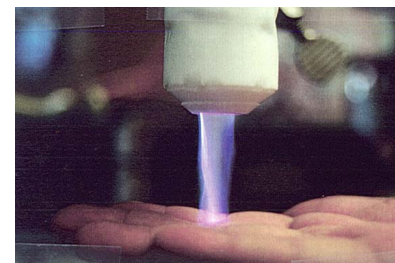
Material processing



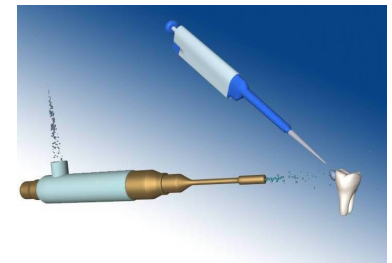
Ozone generation for water cleaning



**Bio-application**



**Dental application**



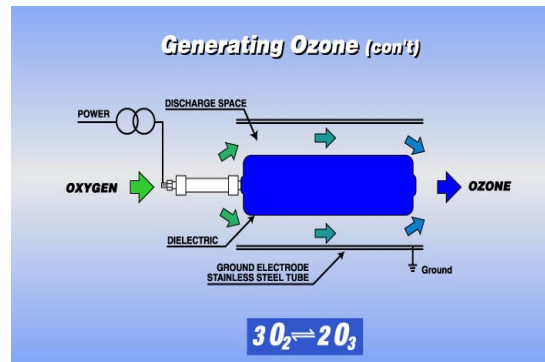
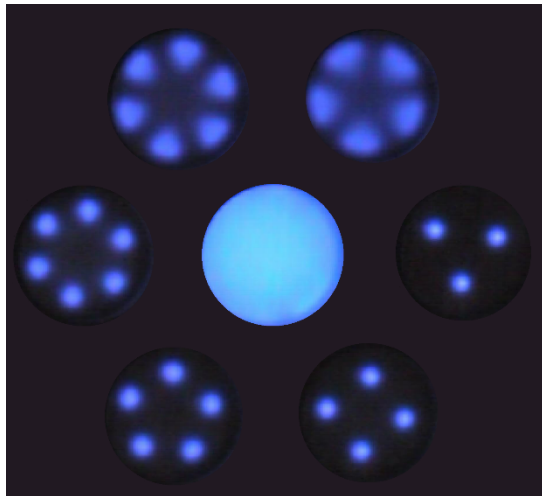
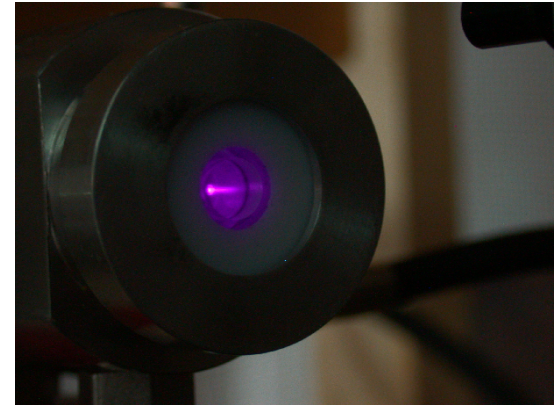
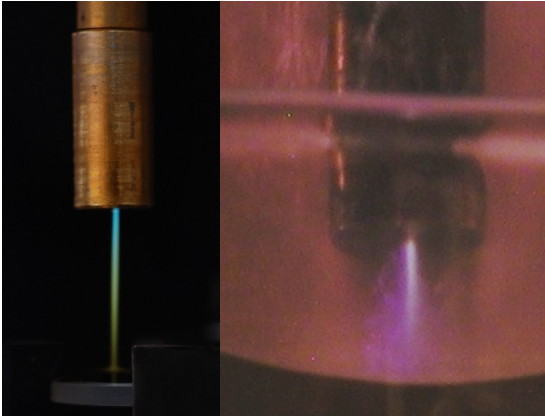
and Many more...







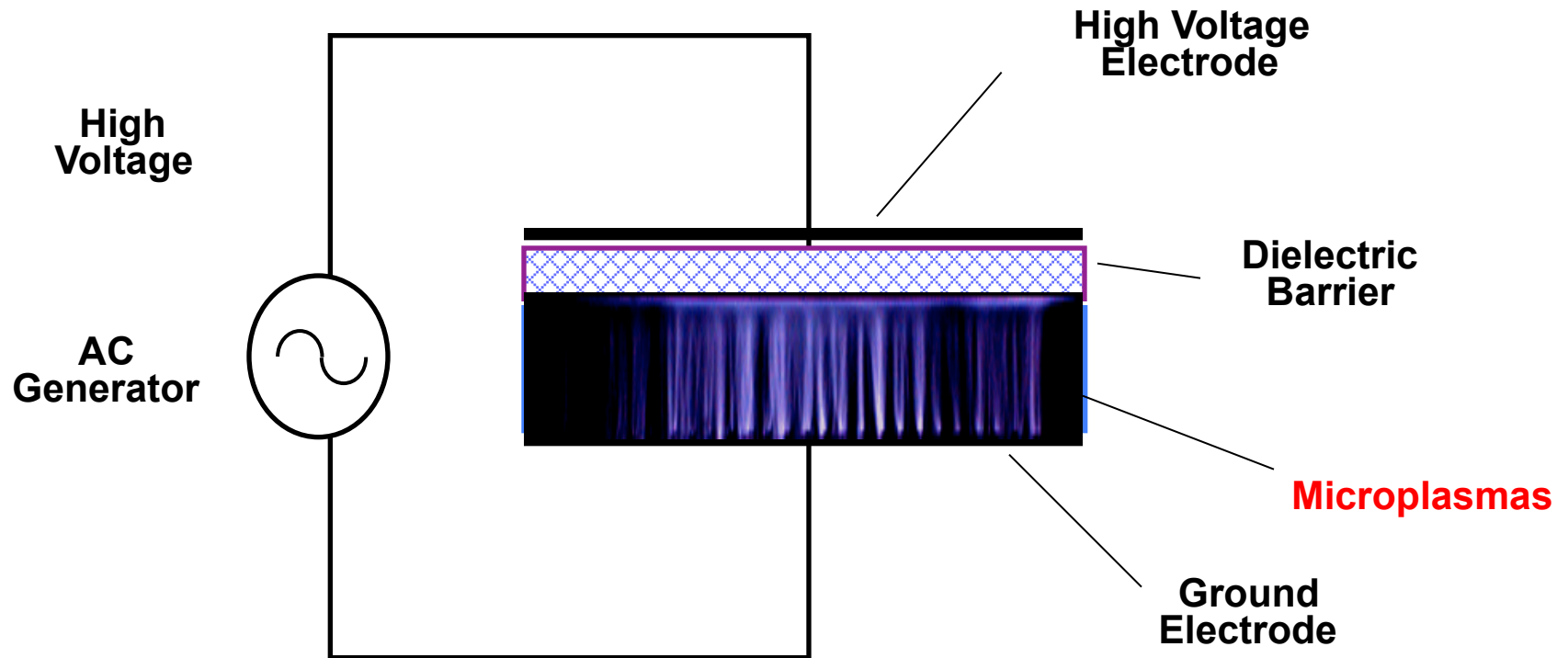
# Some examples...







# Atmospheric Pressure Cold Plasma





# Role of the Dielectric (Insulator)

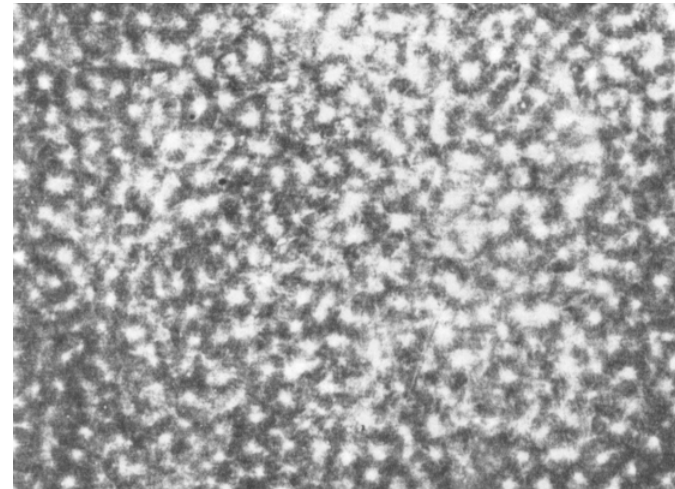
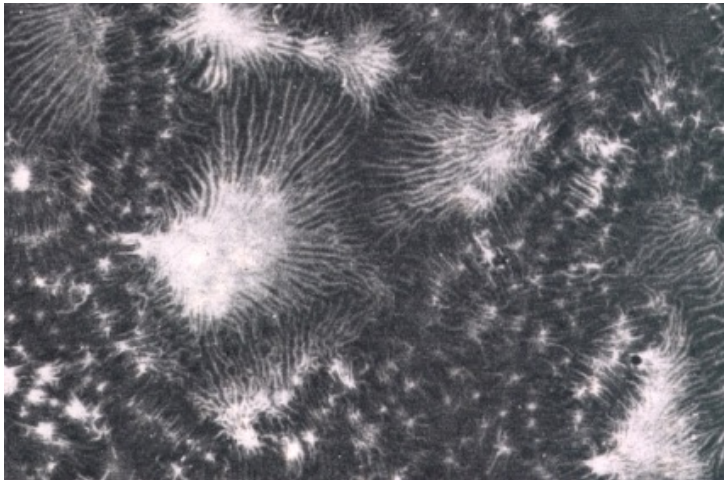
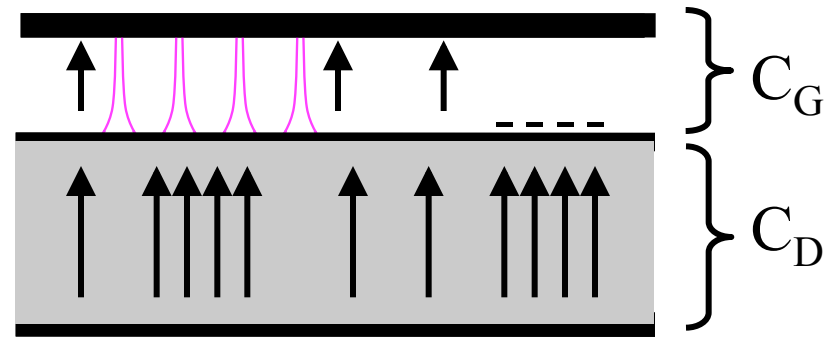
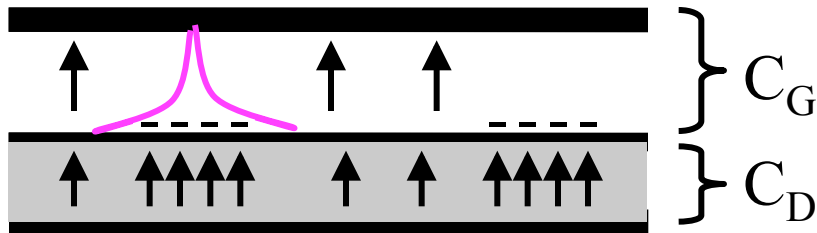
The dielectric is the key for the proper functioning of the discharge.

Serves two functions:

1. Limits the amount of charge transported by a single microplasma
2. Distributes the microplasmas over the entire electrode surface area



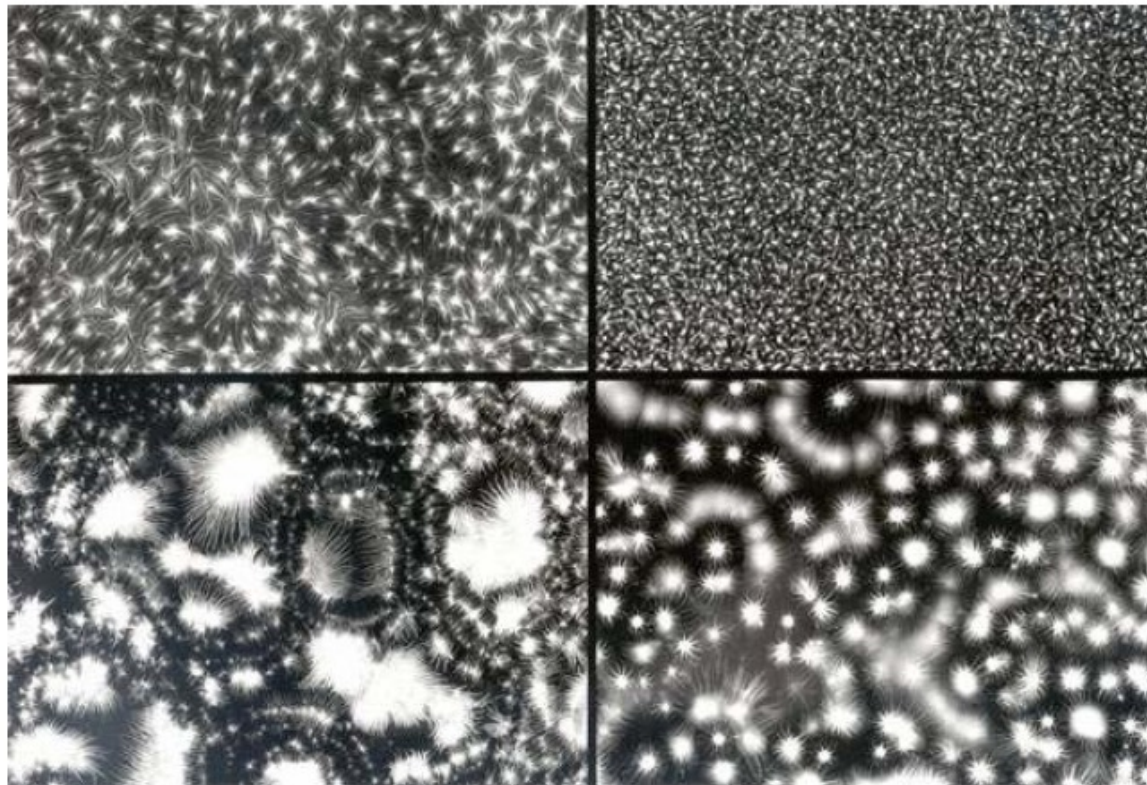
# Principals of DBD Microplasmas





# Principals of DBD Microplasmas

Four Different Gap Widths

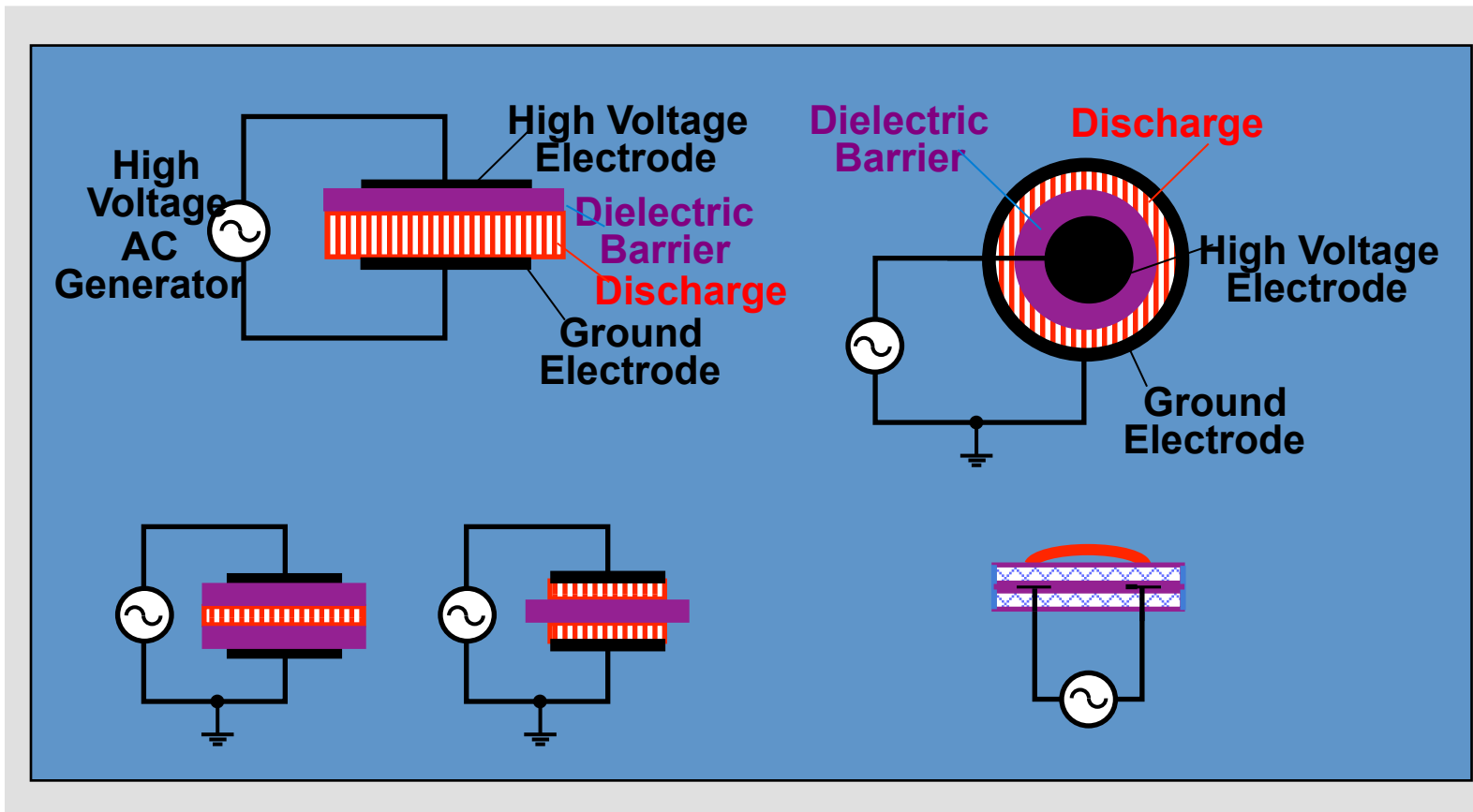


B. Eliasson and U. Kogelschatz. *IEEE Trans Plasma Sci.* 19(2) p309 (1991)





# Dielectric Barrier Discharge

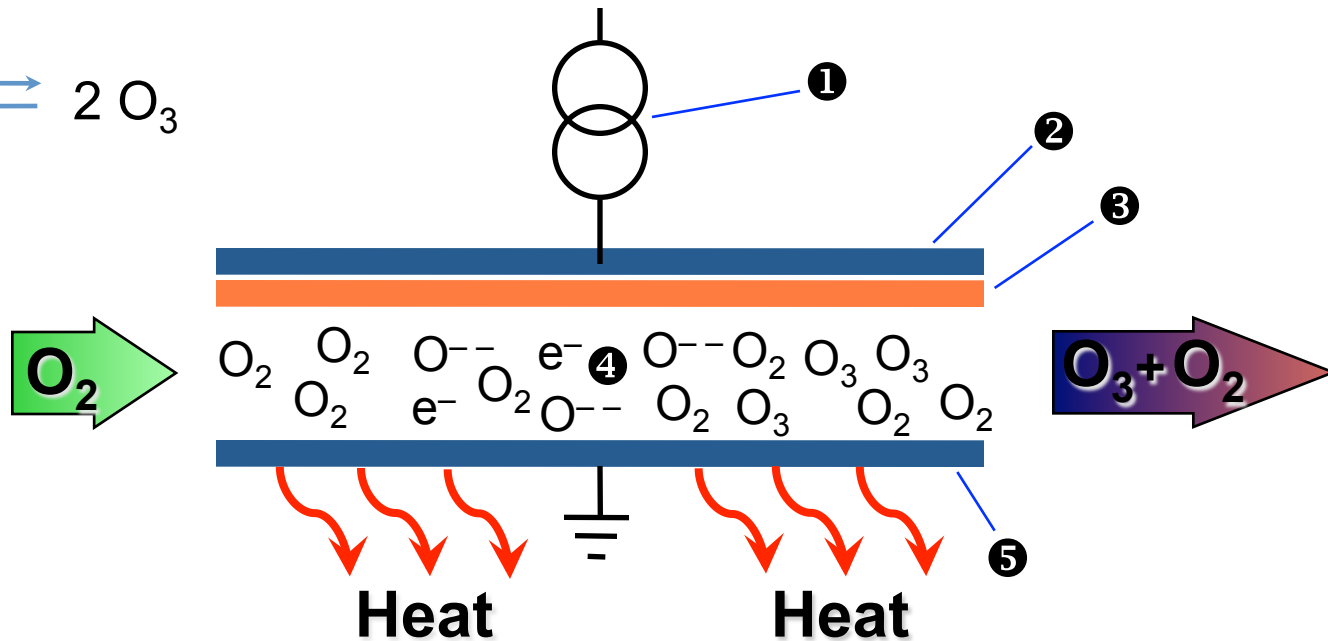


H.E. Wagner, R. Brandenburg, et. al. 'The barrier discharge: basic properties and applications to surface treatment'. *Vacuum*. 71 p417-436 (2003).



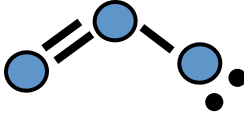
# Ozone Generator

## Dielectric Barrier Discharge





# Properties of Ozone ( $O_3$ )

- Tri-atomic form of oxygen. 
- Most powerful commercial oxidizing agent
- Unstable - must be generated and used onsite
- Limited solubility in water, but more so than oxygen
- Leaves a dissolved residual which ultimately converts back to oxygen



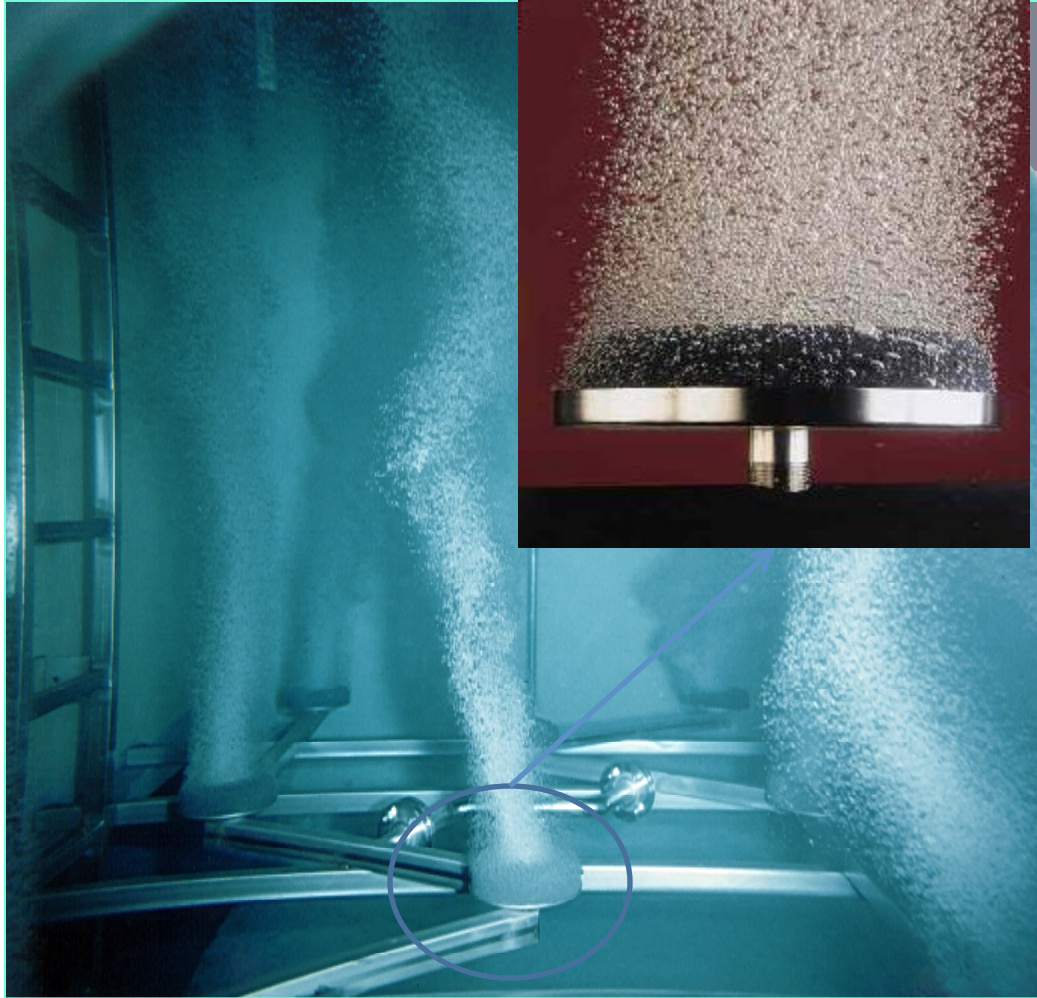
# Ozonia Advanced Technology Ozone Generator







# Ozone Water Treatment



## Bubble Diffusion

**Easy to use**

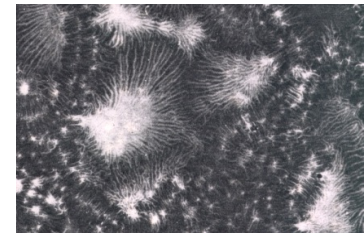
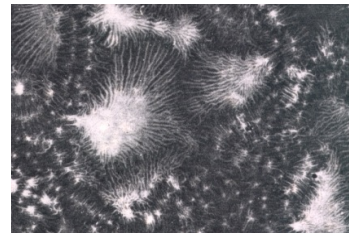
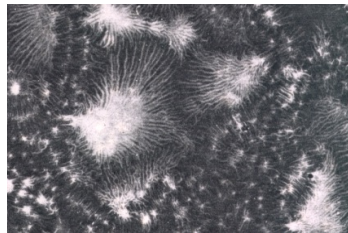
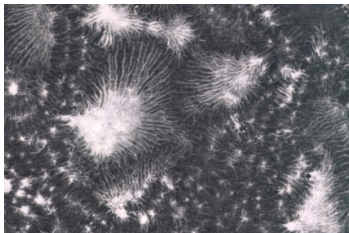
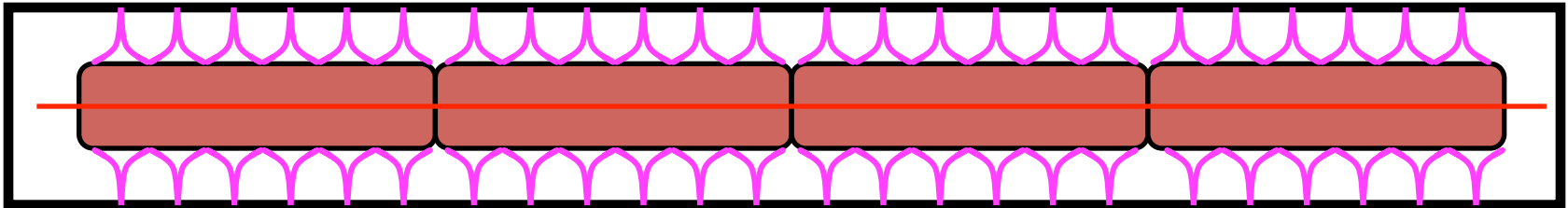
**Low energy usage**

**Mass transfer efficiencies to  $> 90\%$**



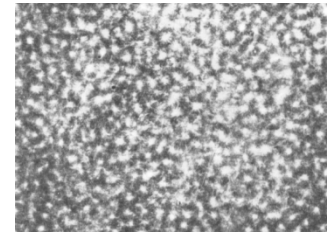
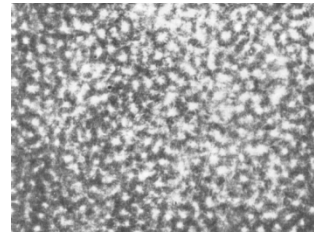
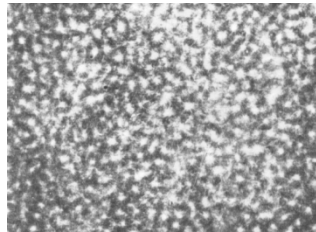
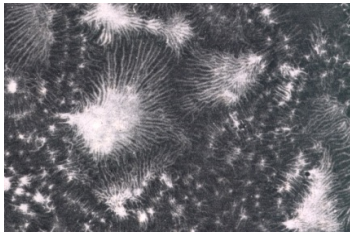
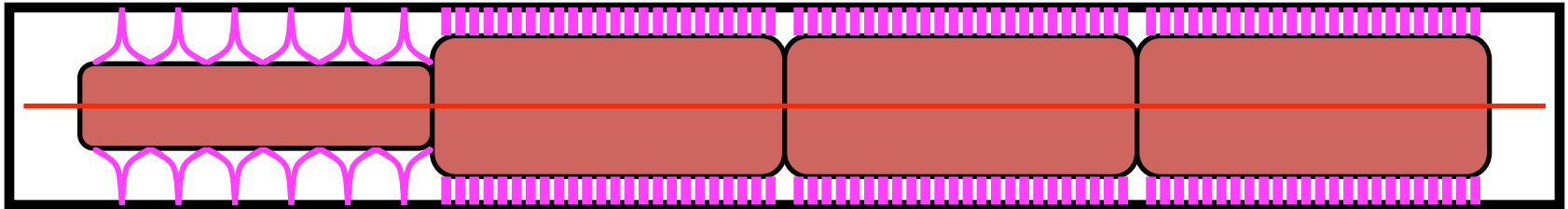


# Reference (Traditional) Arrangement



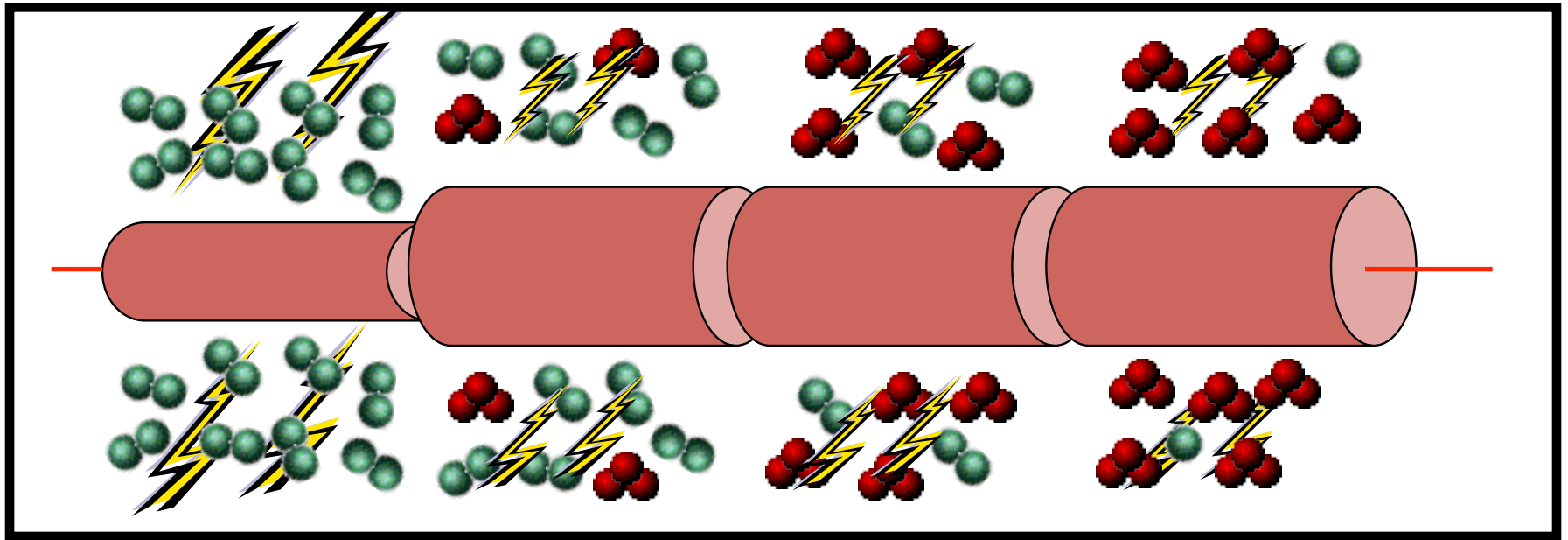


# Optimized Arrangement





# Intelligent Gap System (IGS)



O<sub>2</sub>

O<sub>3</sub>



Molecular Oxygen (O<sub>2</sub>)



Ozone (O<sub>3</sub>)





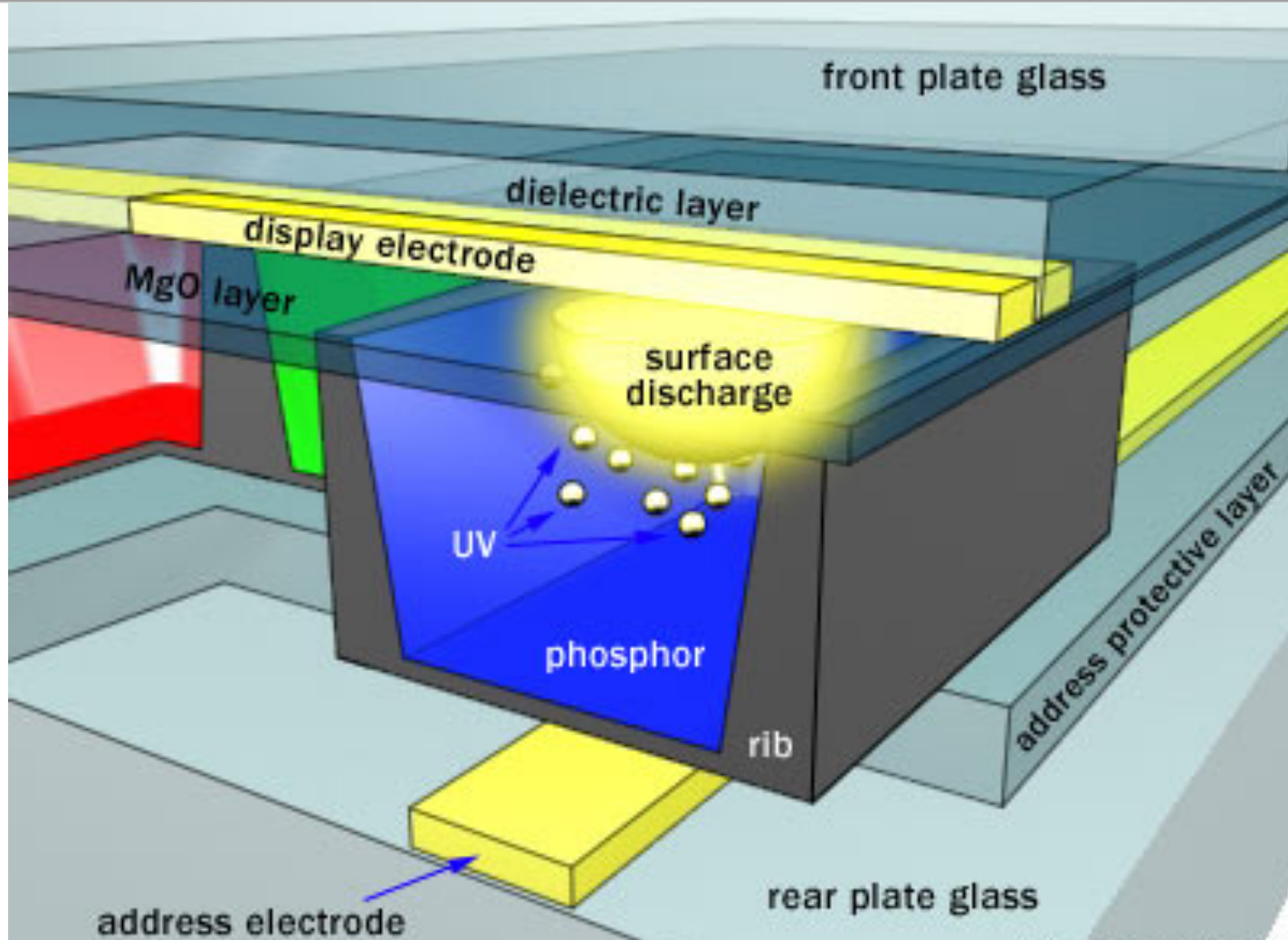


# Degrémont Technologies – Ozonia Intelligent Gap System





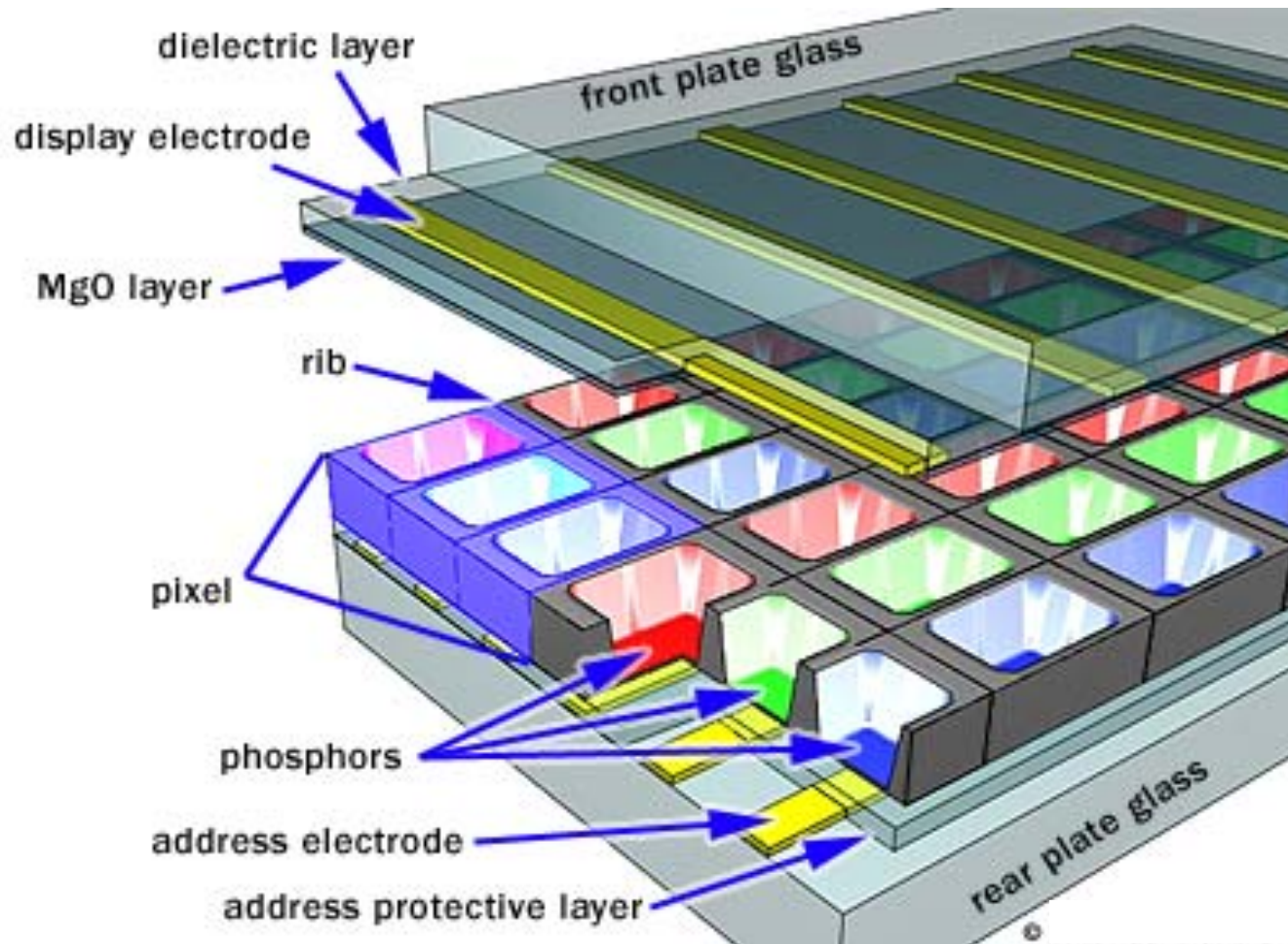
# How A Plasma Display Works!







# How A Plasma Display Work!





# Plasma Display Televisions







# Applications of High-Pressure Microplasmas: Light Sources, Photonics, Sensors

## **Excimer and other non-coherent VUV/UV light sources**

- **efficiency**
- **intensity**
- **wavelength selectivity and control; monochromaticity**
- **lifetime and stability**
- **arrays**

## **Photonic devices**

- **semiconductor devices**
  - **photodetectors**
  - **flexible devices and arrays**
  - **devices approaching cellular dimensions**
  - **nano-devices**

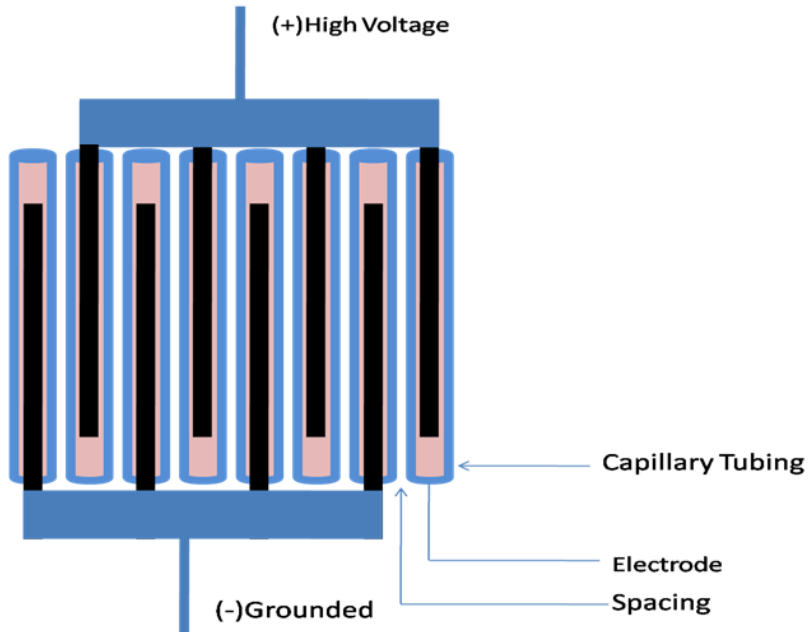
## **Sensors**

- **sensor for chemical and biological agents**
- **sensor for explosives**



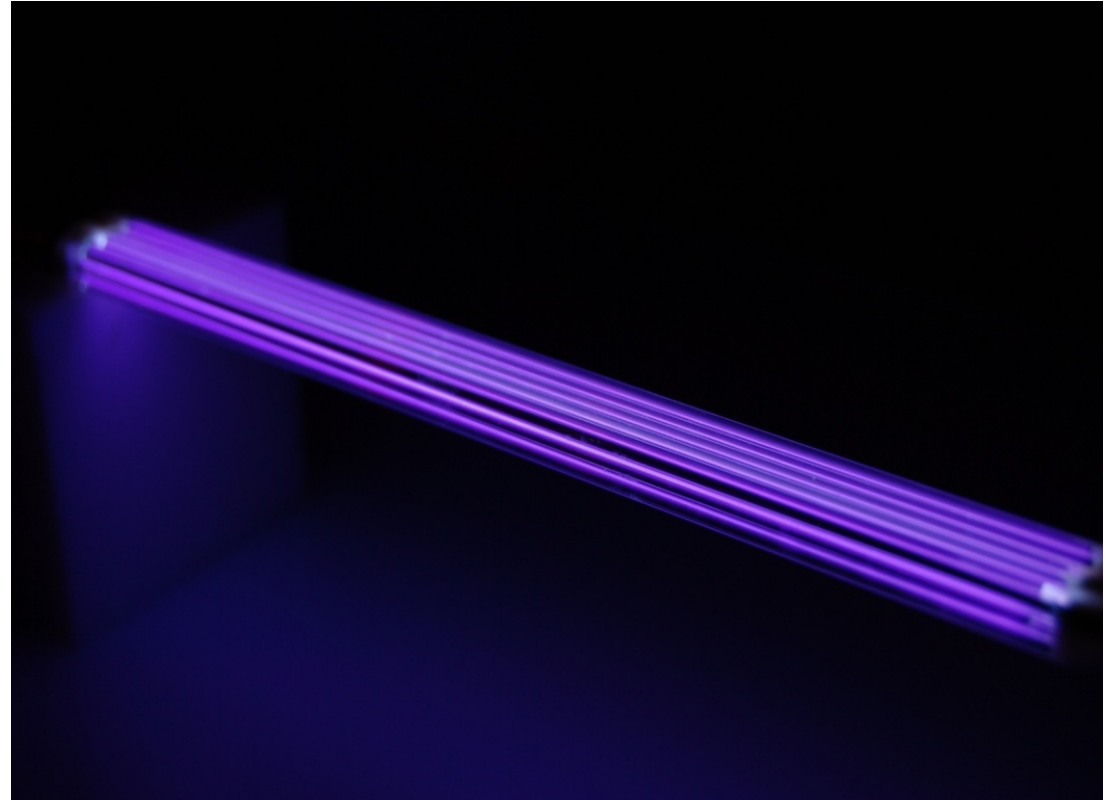
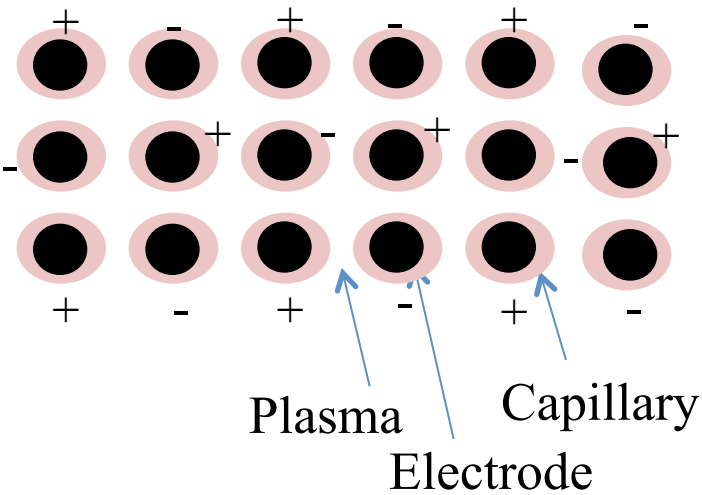


# Capillary Dielectric Barrier Discharge



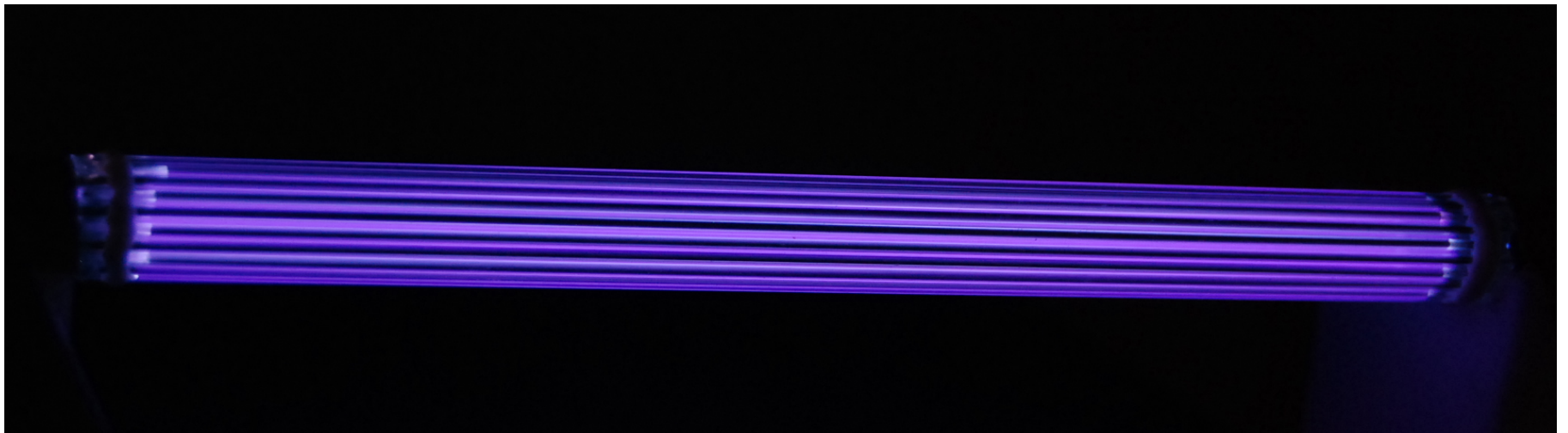
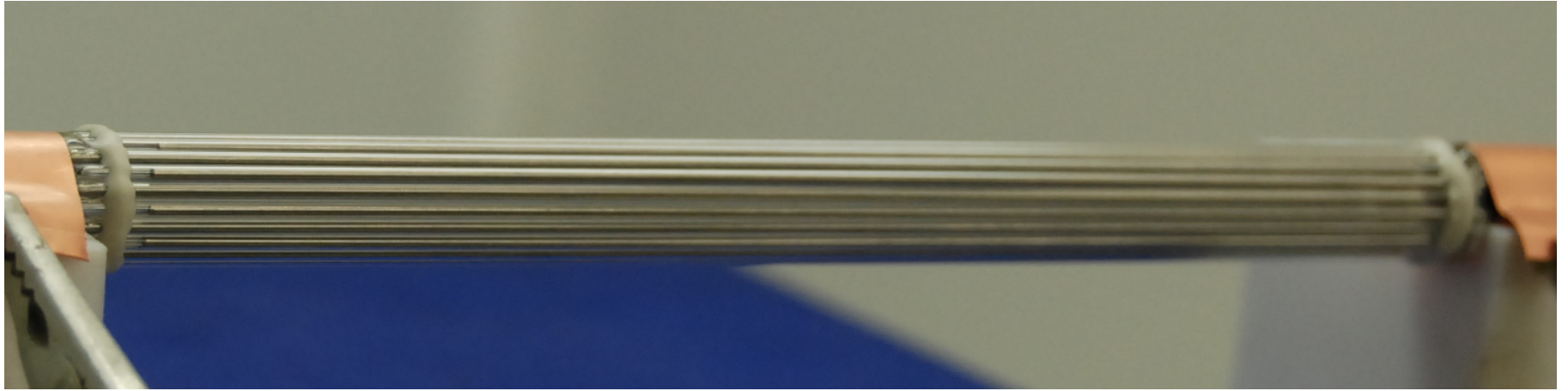


# 3-D Expansion





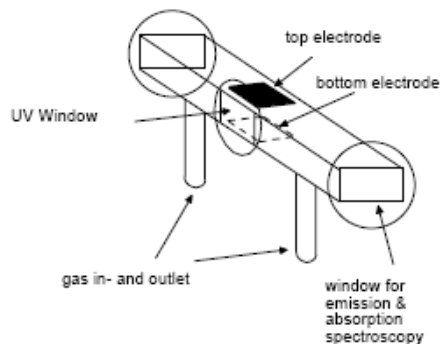
# Cylindrical Arrangement



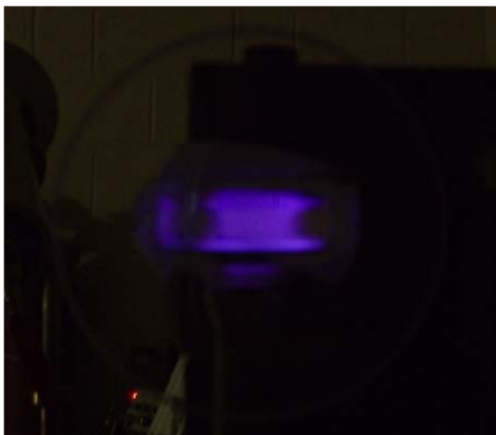




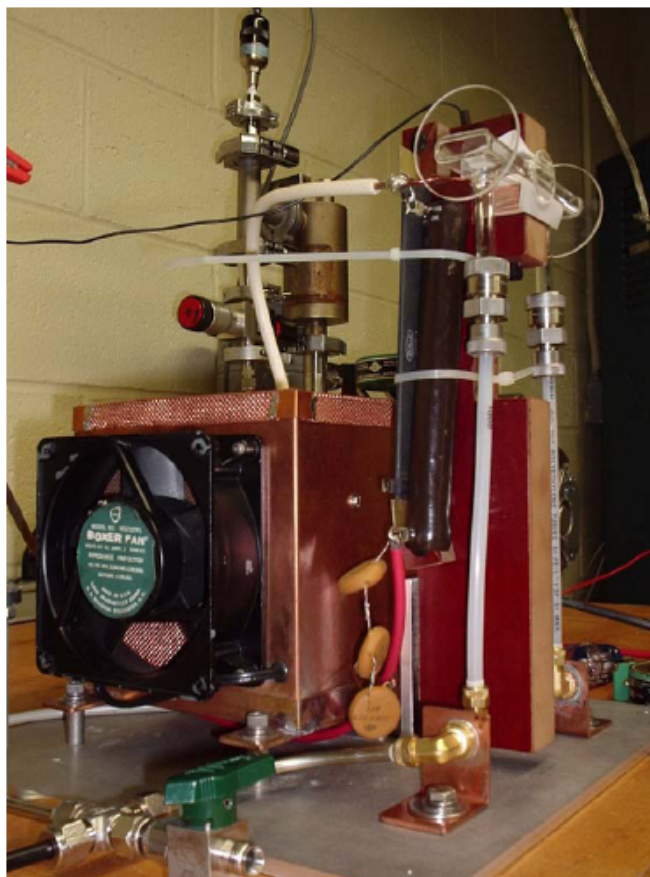
# Pulsed DC Homogeneous DBD



The Dielectric Barrier Discharge (DBD) cell.



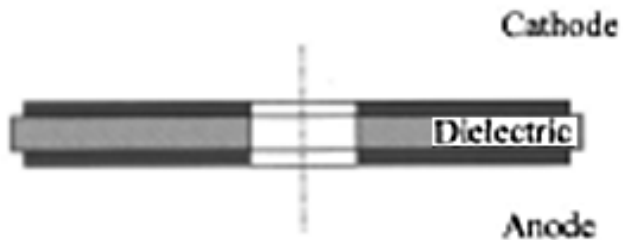
A typical plasma in pure nitrogen environment.



Side view of the DBD cell experiment with the fast high voltage transistor switch connected to the bottom electrode.



# Micro Hollow Cathode Discharge (MHCD)



Sandwich Structure:  
Electrode – Dielectric - Electrode

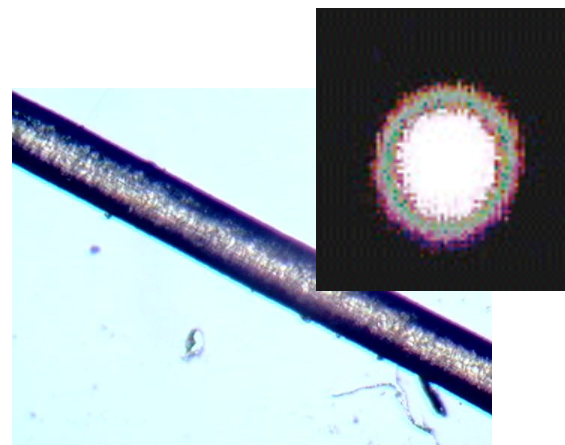
Critical dimensions at atmospheric pressure  
(static operation):

$d$ :  $< 500 \mu\text{m}$

$D$ :  $10 - 300 \mu\text{m}$

(assuming at room temperature)

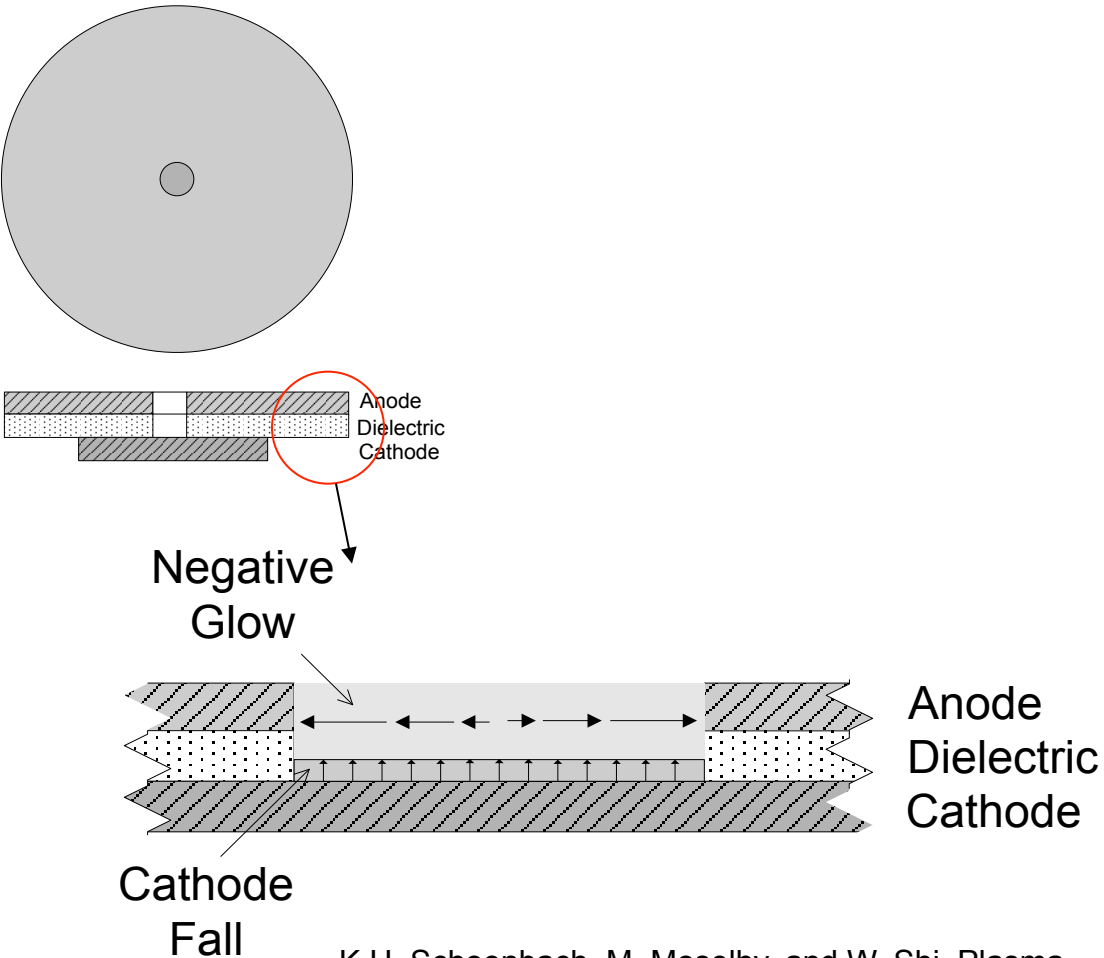
Most of the experimental studies are in rare gases  
and rare gas halide mixtures, with an increasing  
interest on atmospheric pressure air .



Human Hair:  $60 - 100 \mu\text{m}$



# Cathode Boundary Layer Discharges (CBLD)



## Materials:

Electrodes: Molybdenum

Dielectric: Alumina

## Dimensions:

Electrode Thickness: 100  $\mu\text{m}$  to 250  $\mu\text{m}$

Dielectric Thickness: 100  $\mu\text{m}$  to 250  $\mu\text{m}$

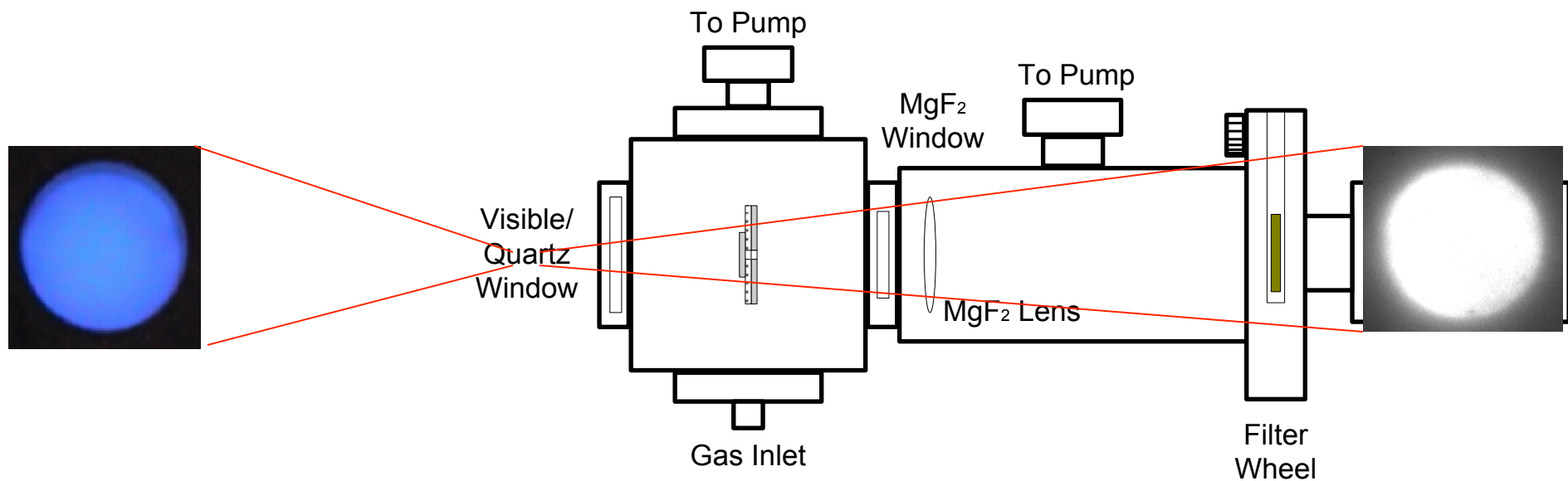
Opening Diameter: 300  $\mu\text{m}$  to 4.5 mm

K.H. Schoenbach, M. Moselhy, and W. Shi, Plasma Sources Sci. Technol. 13, 177 (2004)

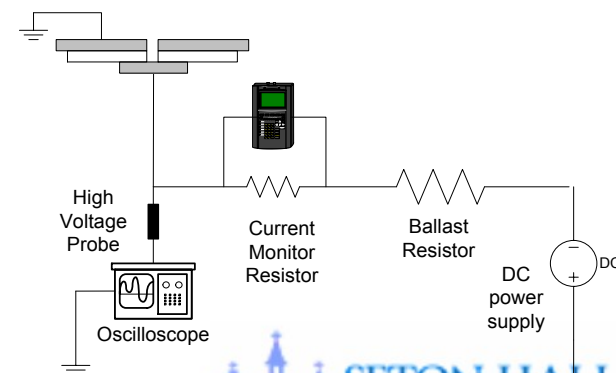




# Visible imaging



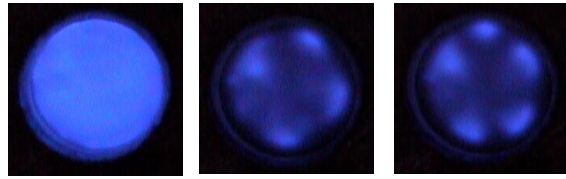
- Gas: Xenon (Scientific grade)
- Spectral filter: 170 nm with FWHM of 26.8 nm
- Sample: Either mechanically assembled at Old Dominion University or plasma sprayed at University of Minnesota







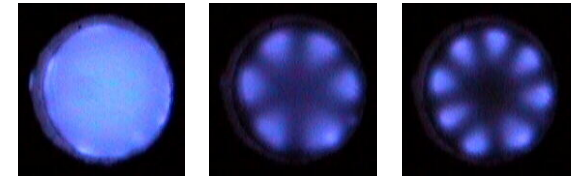
# Self-organization on different cathode materials



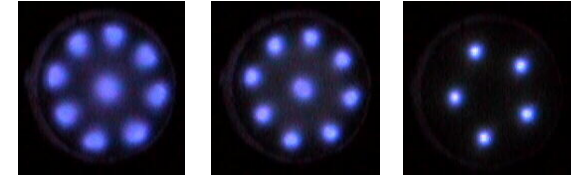
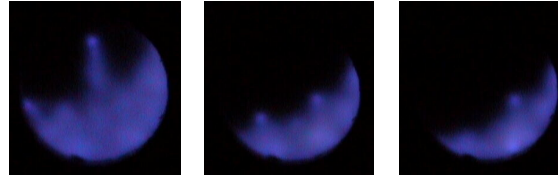
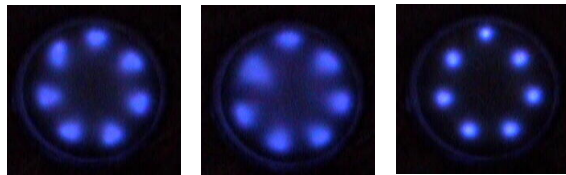
Titanium



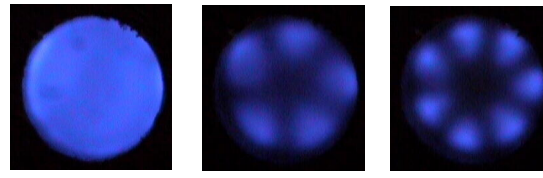
Aluminum



Molybdenum



Hafnium



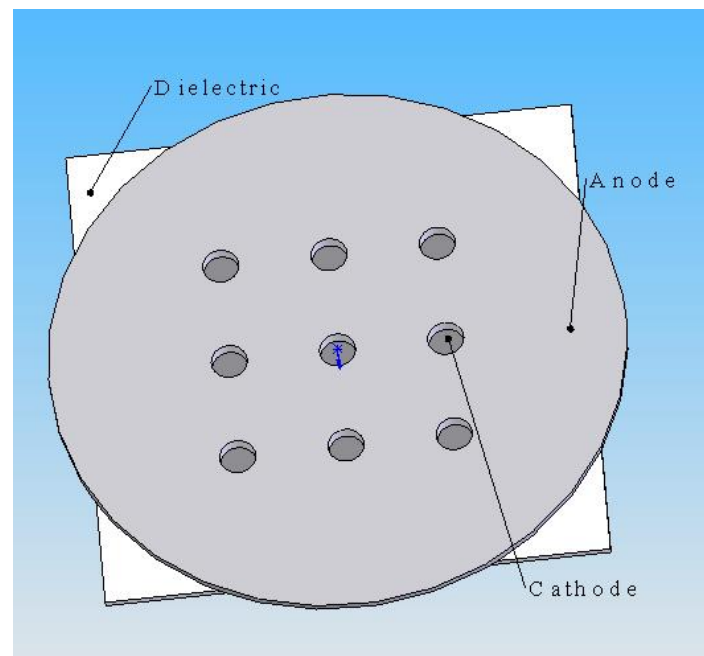
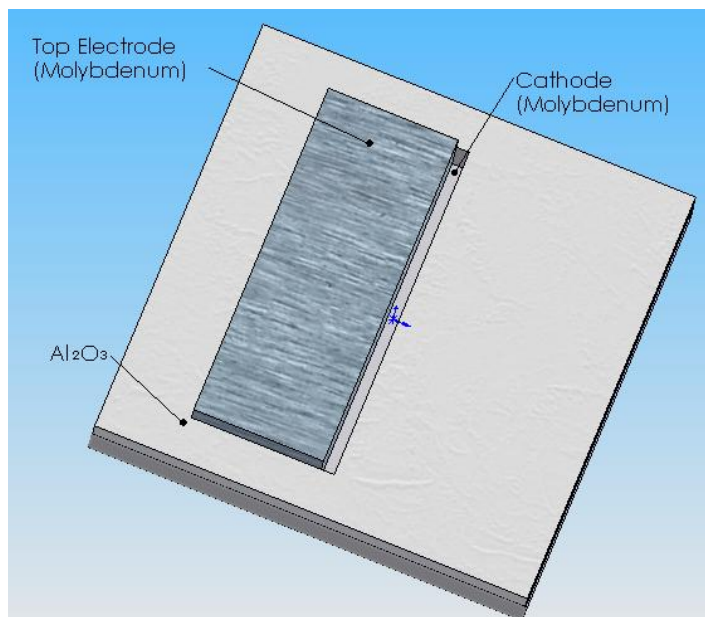
Tungsten





# Up Scaling

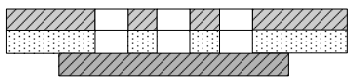
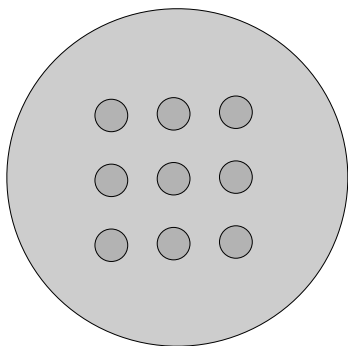
Maintain the sandwich structure and scale up in one direction  
– **Micro-slit structure**



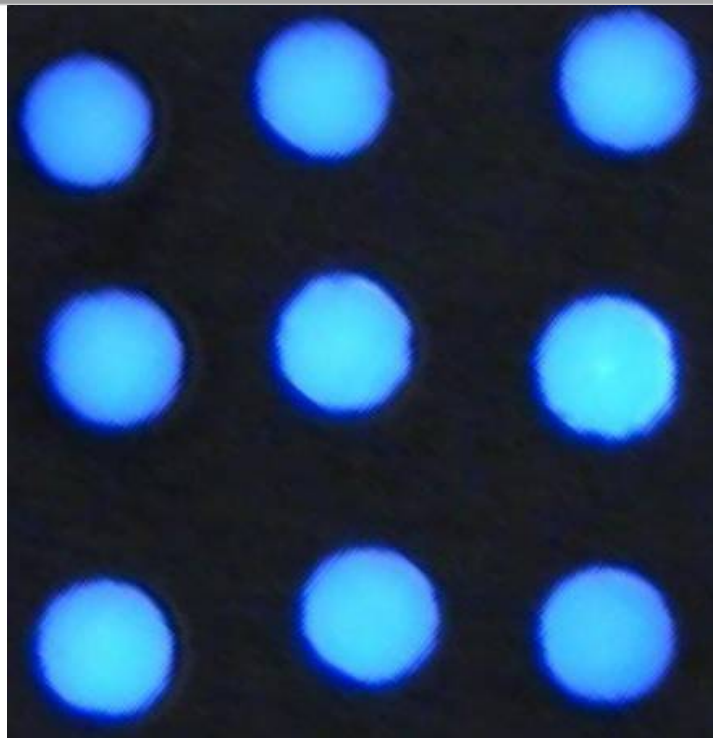
Parallel operation of multiple openings – **Multi-CBL structure**



# Parallel operation without individual ballast



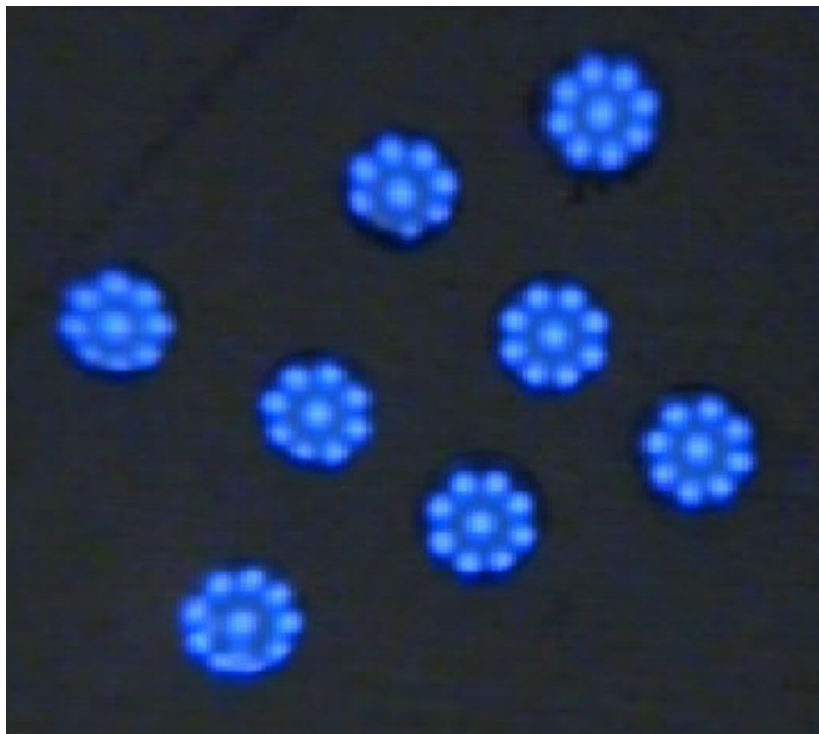
- Cathode: Mo ~0.25 mm thick
- Dielectric:  $\text{Al}_2\text{O}_3$  ~0.25 mm thick
- Anode: Mo ~0.25 mm thick
- Hole diameter: ~0.75 mm
- Center to center distance: ~1.5 mm



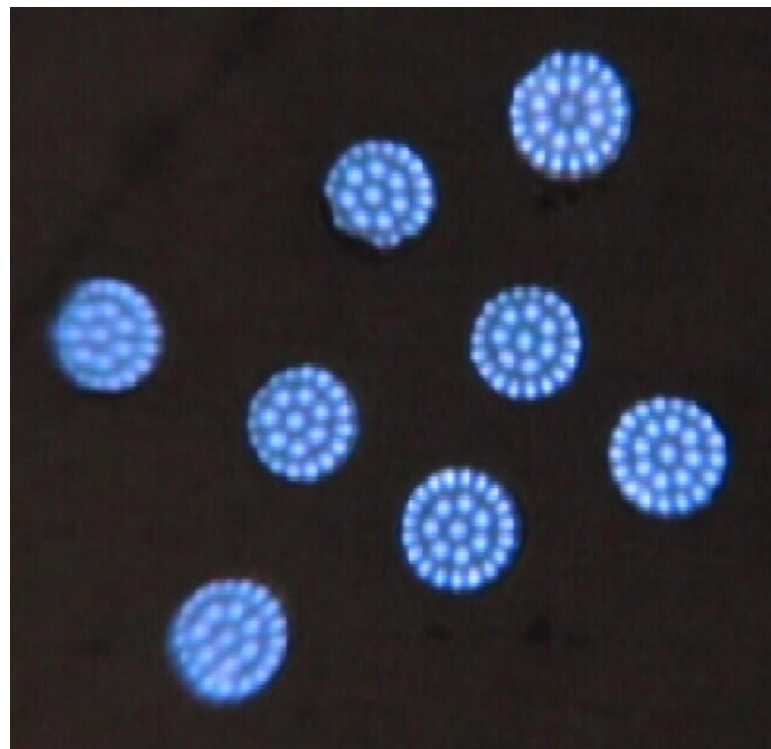
Visible Picture of parallel operation of 9 holes  
(Operating gas: xenon (scientific grade)  
Base pressure: ~1 mTorr; Working pressure: 200 Torr  
Cathode voltage: -398 V; Discharge current: 6 mA)



# Self-organization



Xenon (100 Torr)

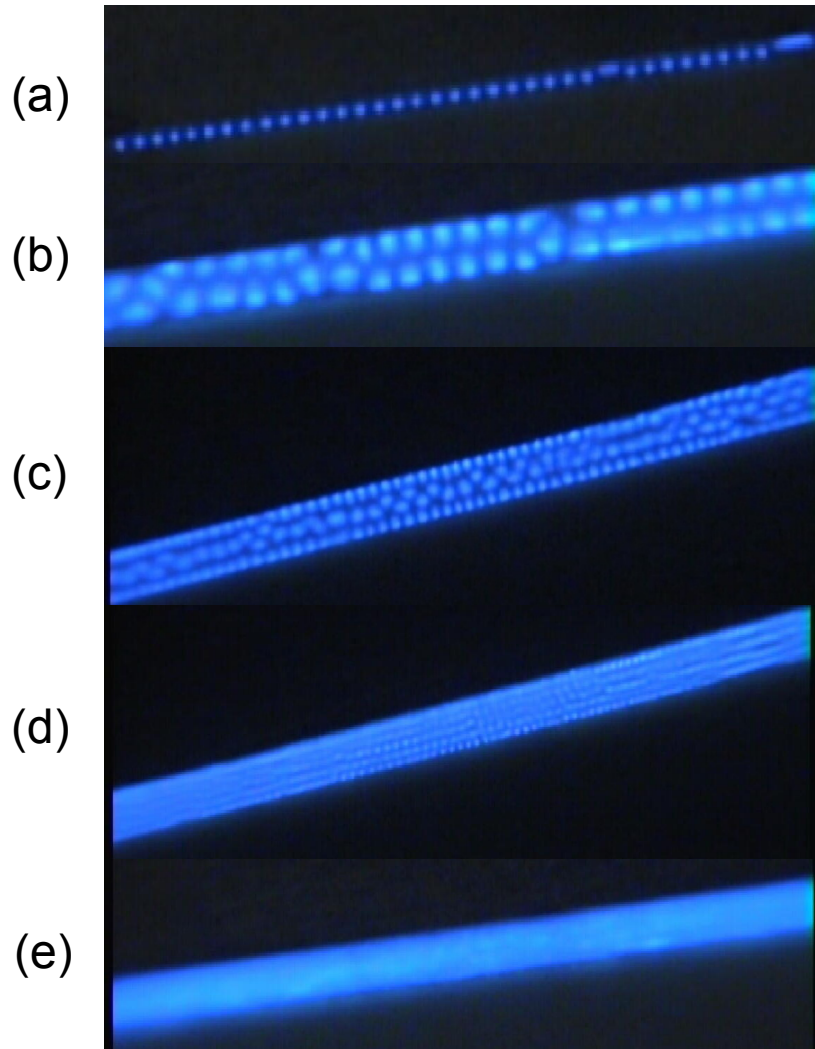


Xenon (250 Torr)  
(ignition assisted with mechanical switch)





# More on Self Organization



Self-organization (Visible images) of a microslit CBL discharge:

(a) 50 Torr;

(b) 150 Torr;

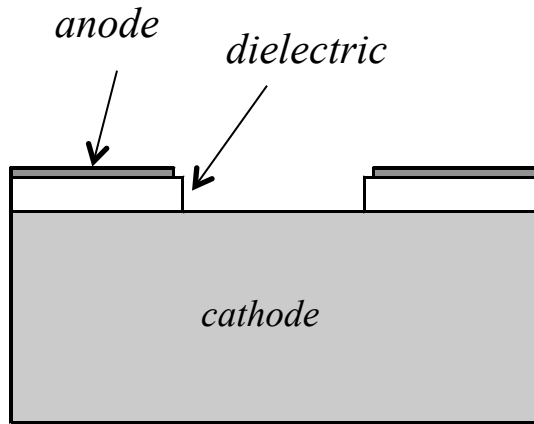
(c) 245 Torr;

(d) 354 Torr and

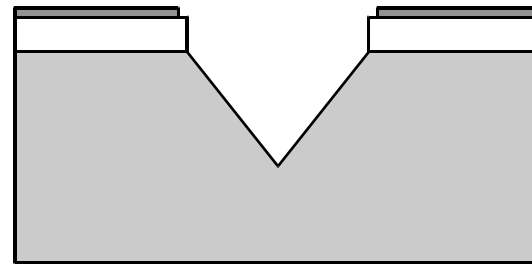
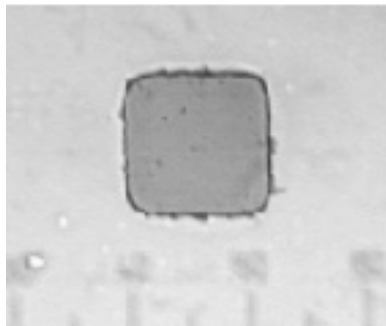
(e) homogeneous discharge at 100 Torr (249V and 4 mA)

(The images are at different magnification for a better demonstration purpose)

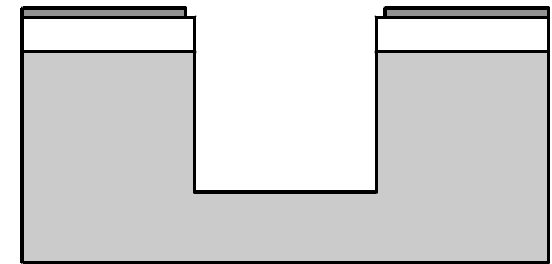
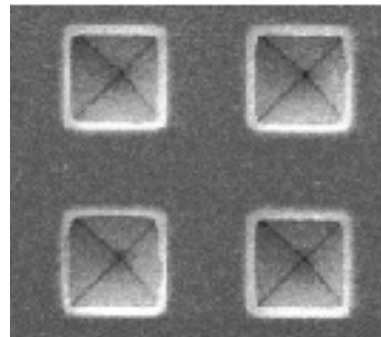
# Si MICROCAVITY DEVICE STRUCTURES



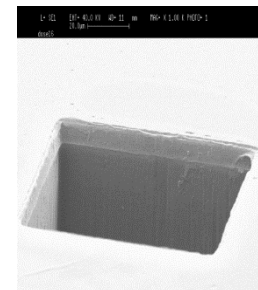
*Planar Si Electrode*



*Inverted Pyramidal Electrode*



*DRIE Electrode*





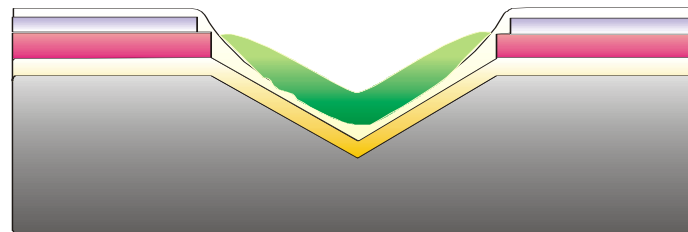
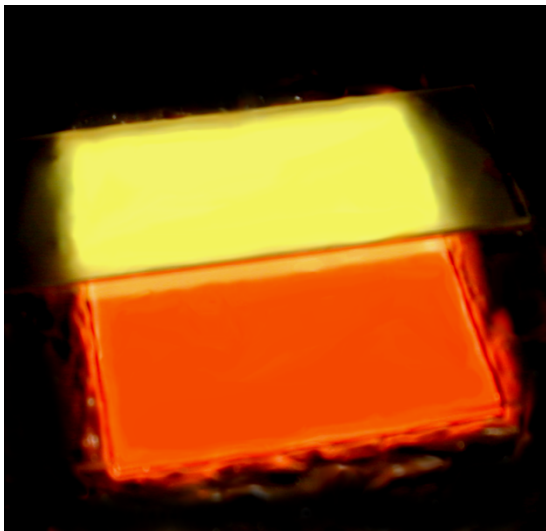
# EXCITATION OF A GREEN PHOSPHOR ( $\text{Mn:Zn}_2\text{SiO}_4$ )



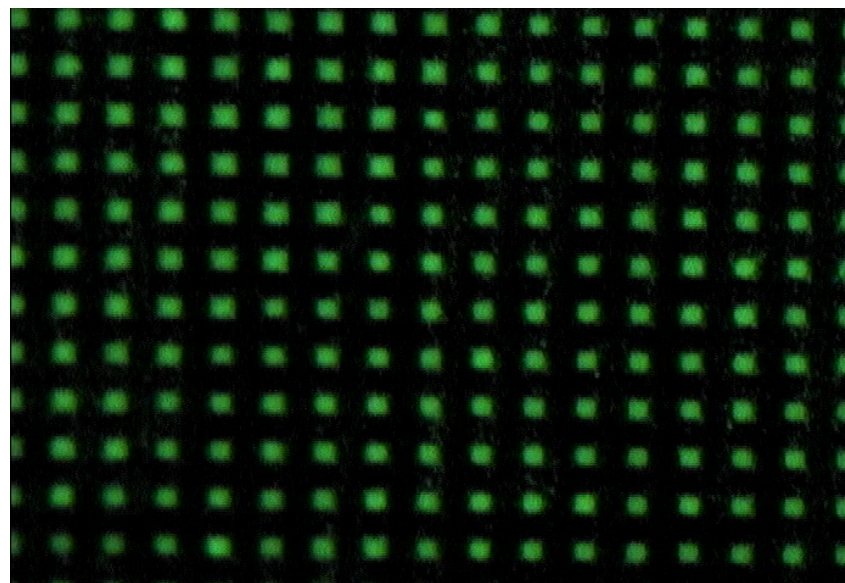
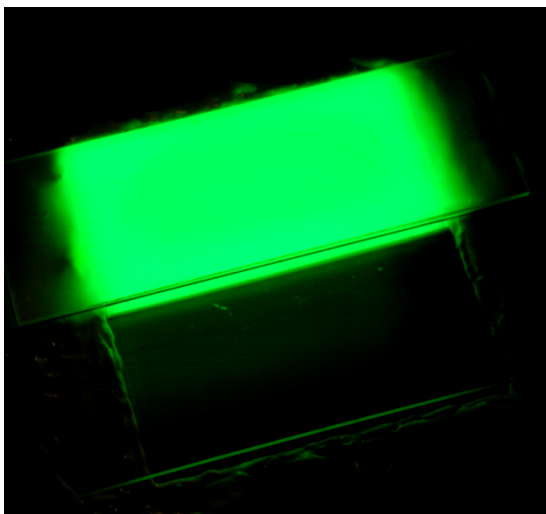
University of Illinois  
Laboratory for Optical Physics and Engineering

## PHOSPHOR EMBEDDED MICROCAVITY

Ne



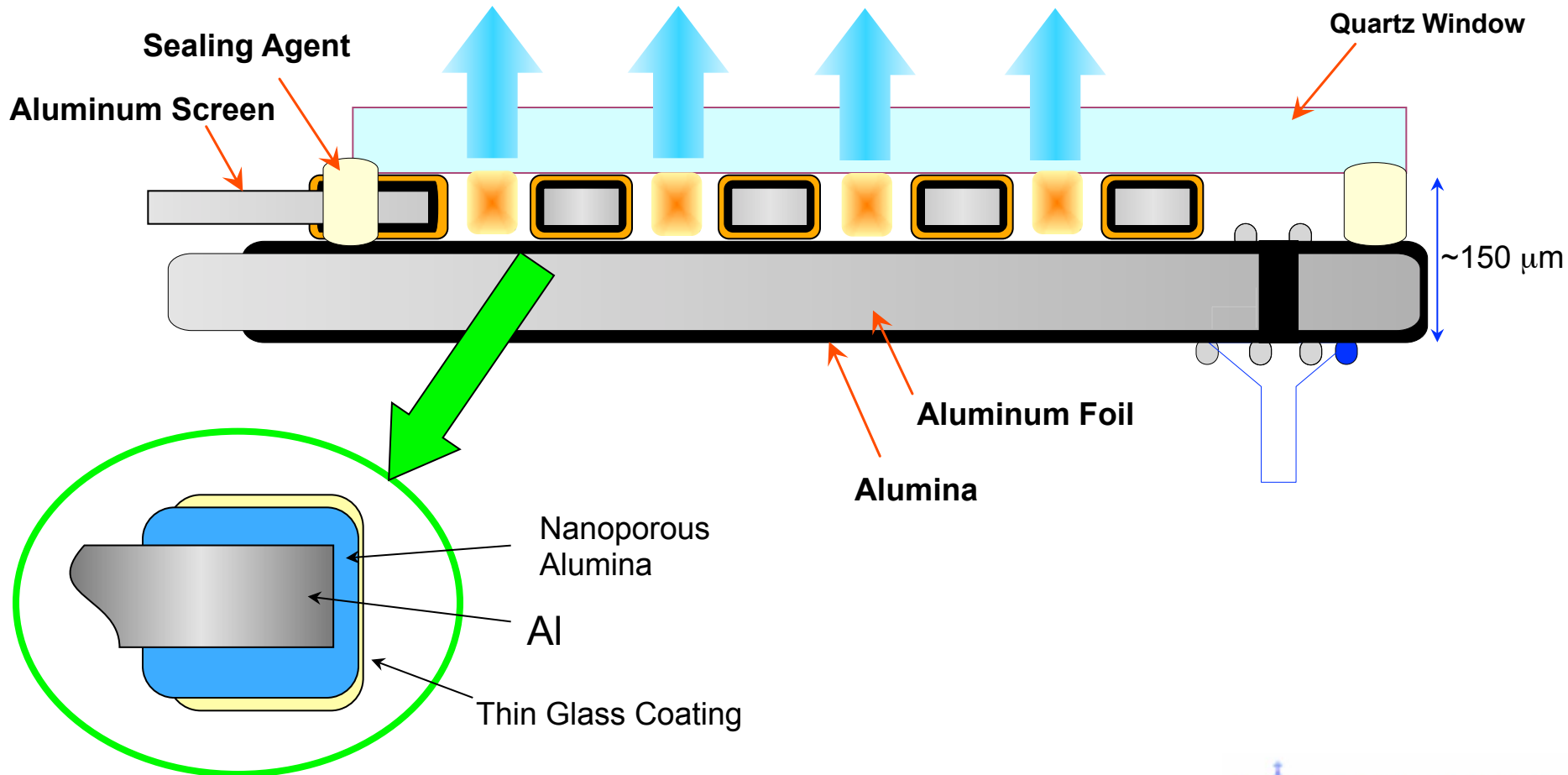
50% Xe/Ne



10 % Xe/Ne, 700 Torr



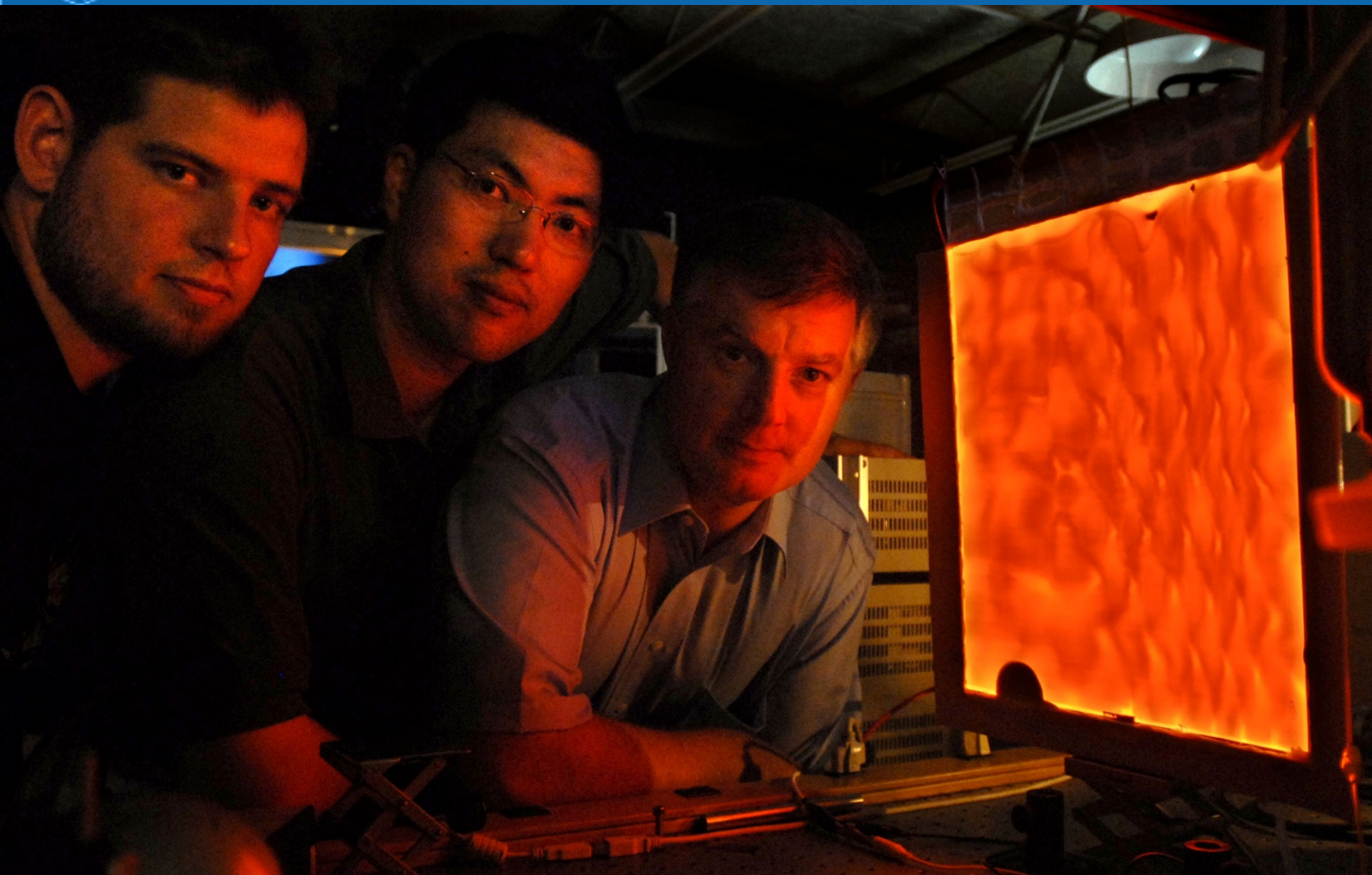
# Microdischarge Array Flat Lamp : Basic Design





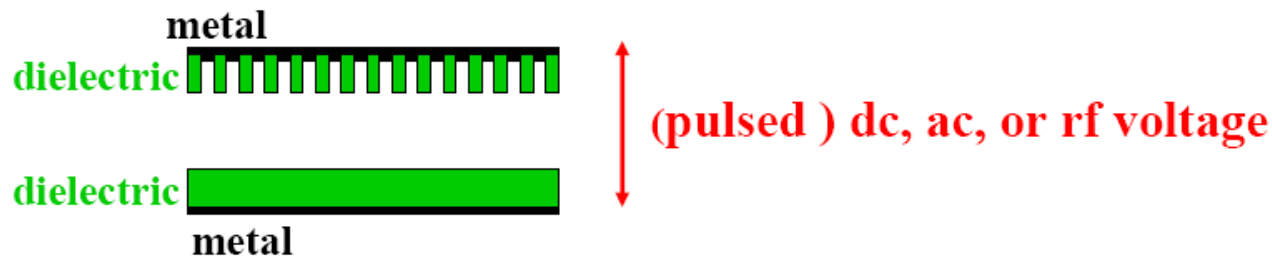


University of Illinois  
Laboratory for Optical Physics and Engineering

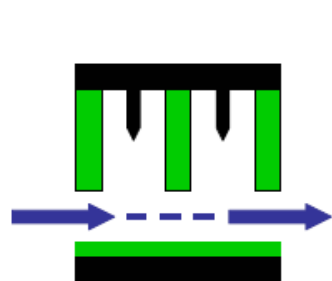




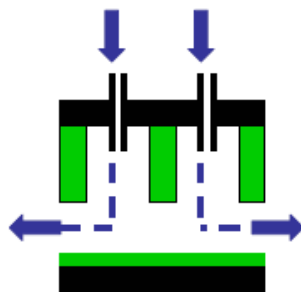
# Capillary Plasma Electrode (CPE)



## Capillary Plasma Electrode (CPE) Realizations



Solid Pin Electrodes  
(Cross Flow)



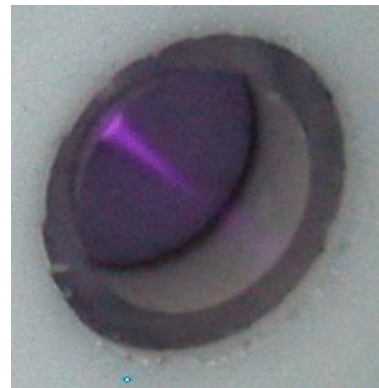
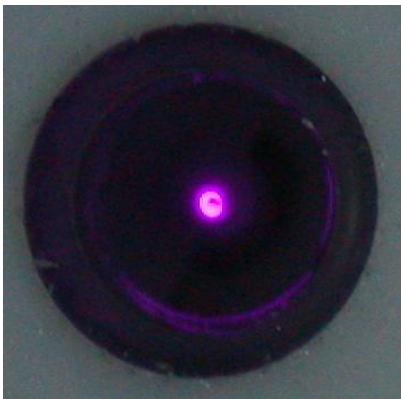
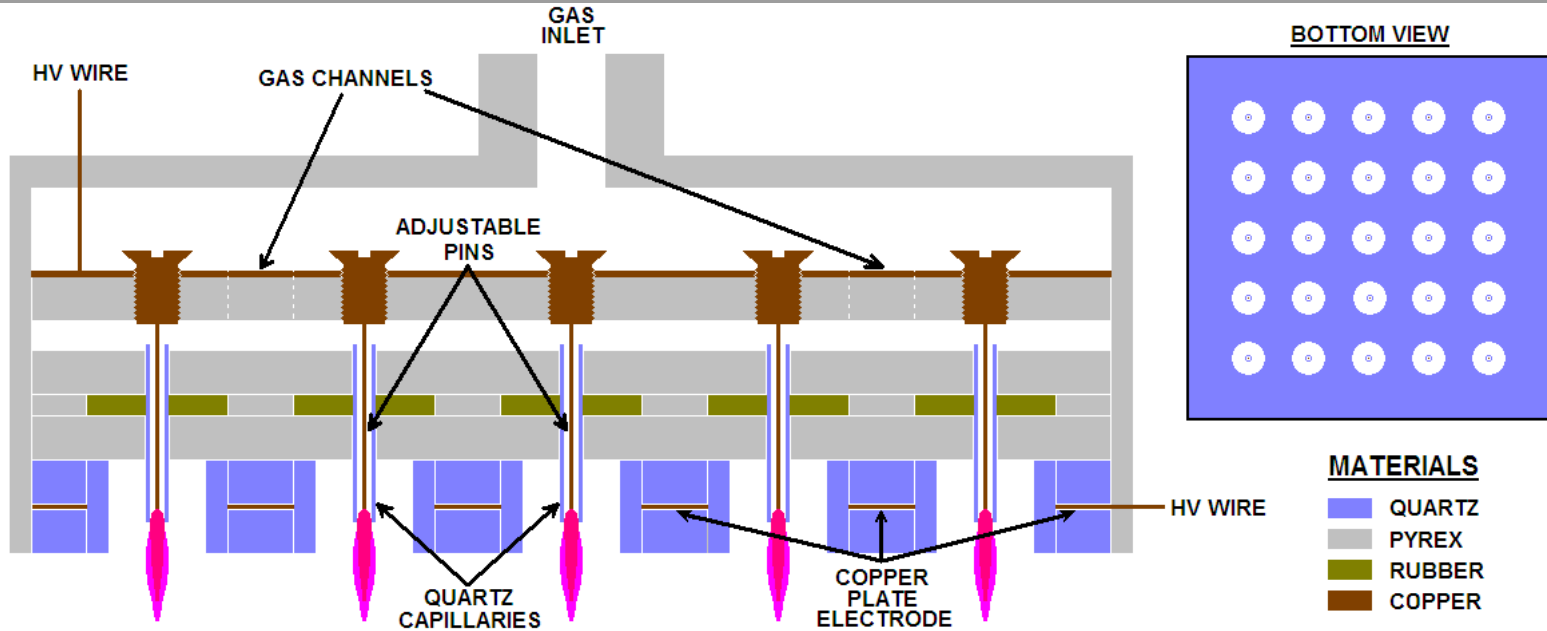
Hollow Pin Electrodes  
(Flow-Through)



Cylindrical Electrodes  
(Longitudinal Flow)



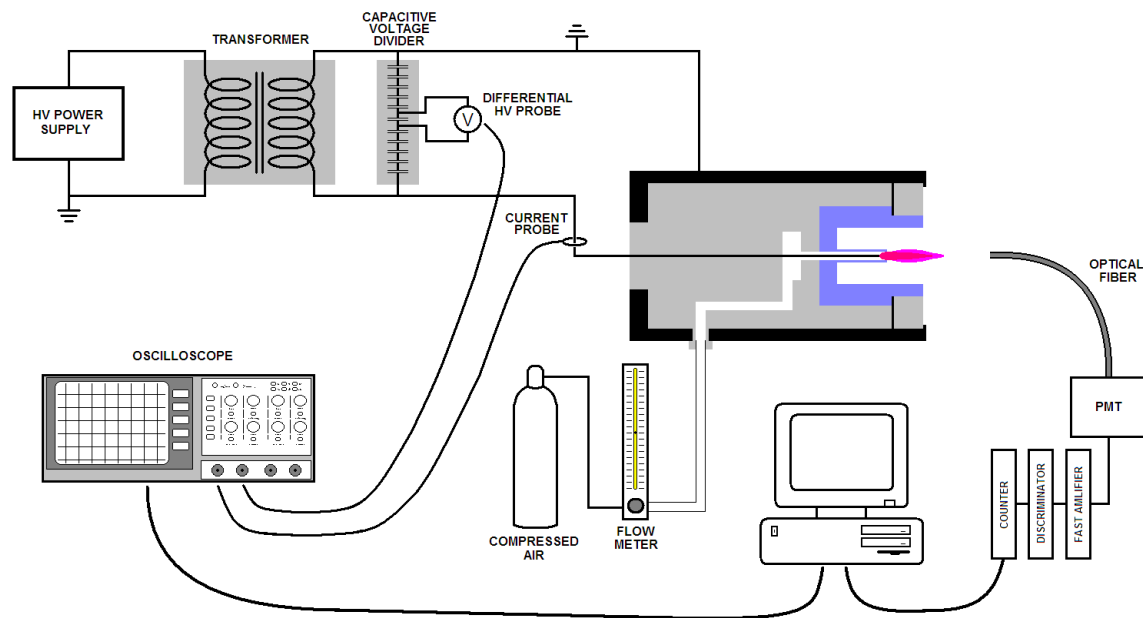
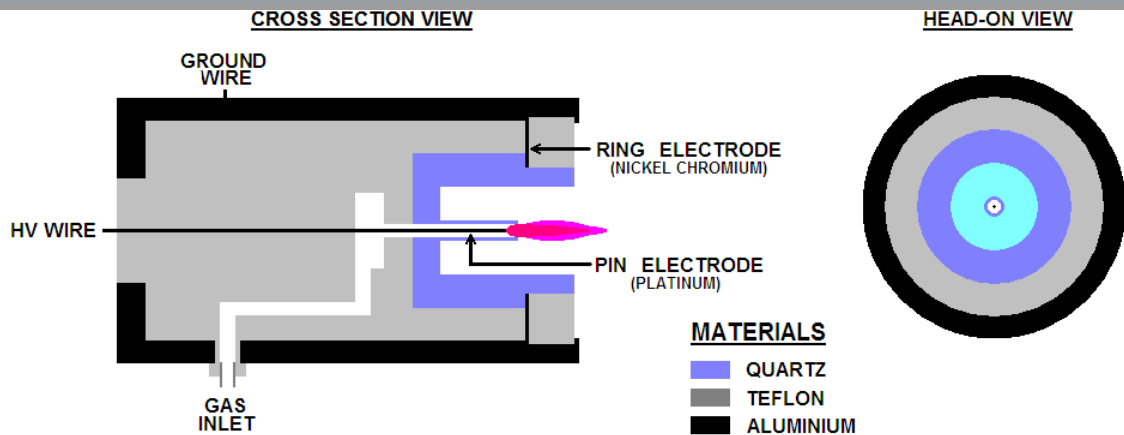
# Multi-Capillary Plasma Electrode







# 1 Capillary Plasma Electrode

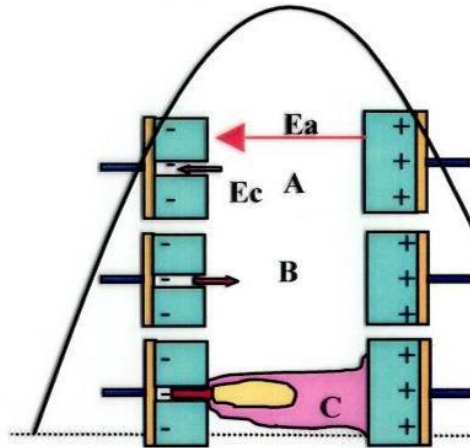






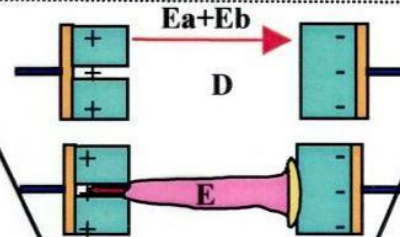
# Capillary Plasma Electrode - Operation

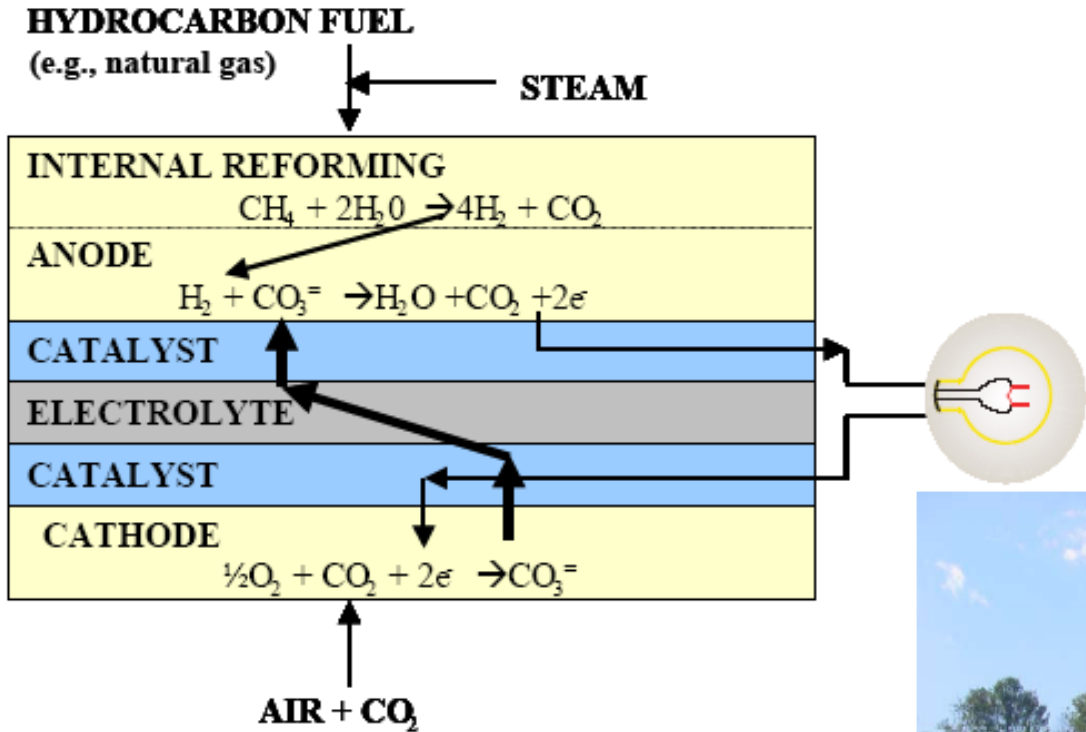
## Atmospheric Pressure Capillary Electrode Plasma



**A:** At the beginning of positive cycle the applied field  $E_a$  establishes a high field  $E_c$  in the capillary  
**B:** A streamer-like discharge forms within the capillary  
**C:** At high applied field  $E_a$  a capillary jet is formed

**D:** At the beginning of the negative cycle the applied field  $E_a$  reverses and adds to the charged barrier field  $E_b$   
**E:** Back-charges are formed which neutralize the barrier charge

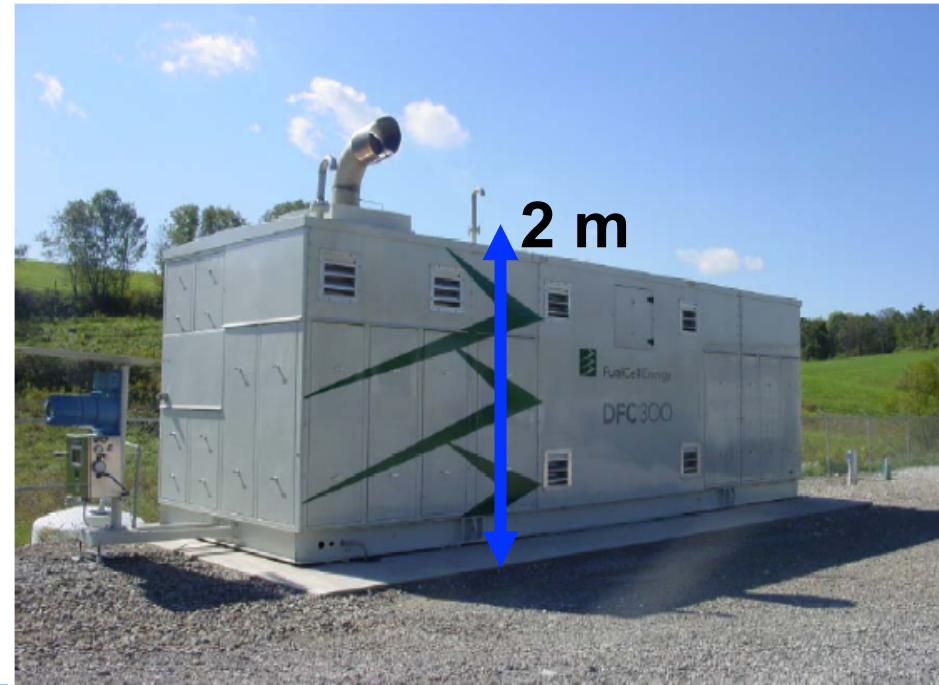




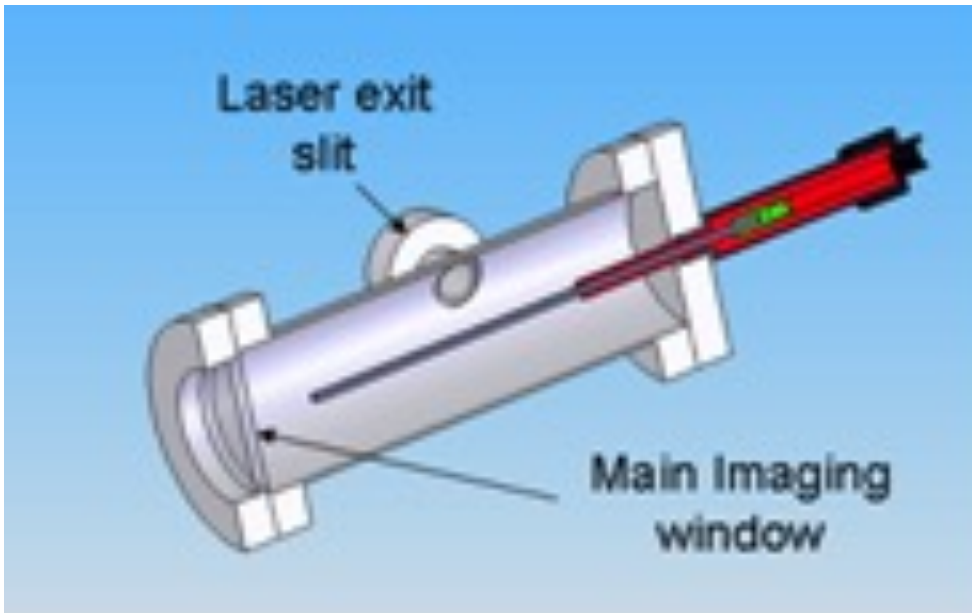
**Solid Oxide Fuel Cell Chemistry**

**300 kW Fuel Cell**

**Idea:**  
Use low-T plasma to generate hydrocarbon feed gas for cell



# Microplasma-Assisted Combustion



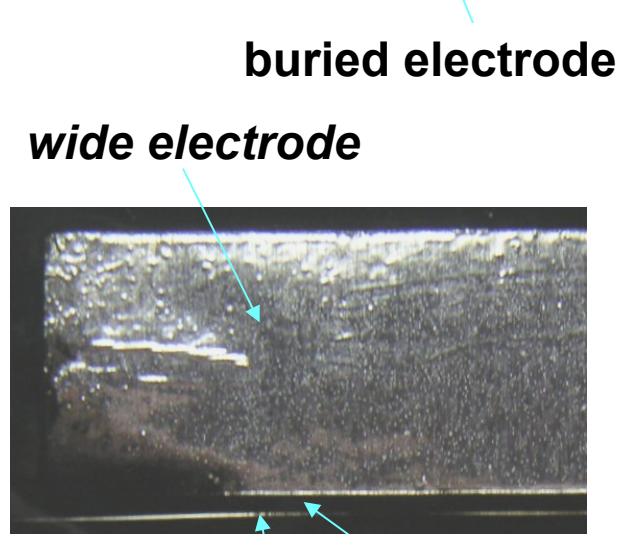
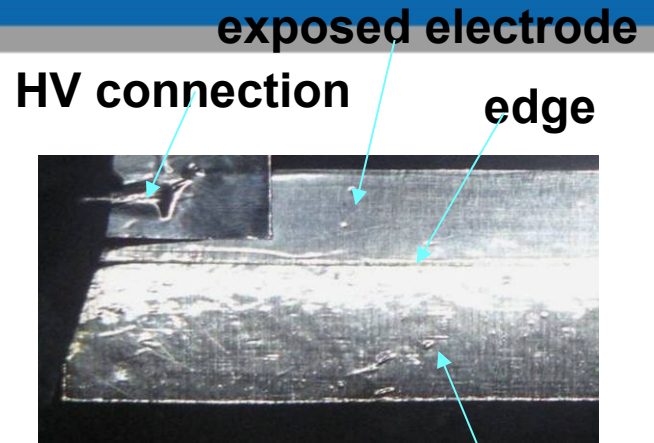
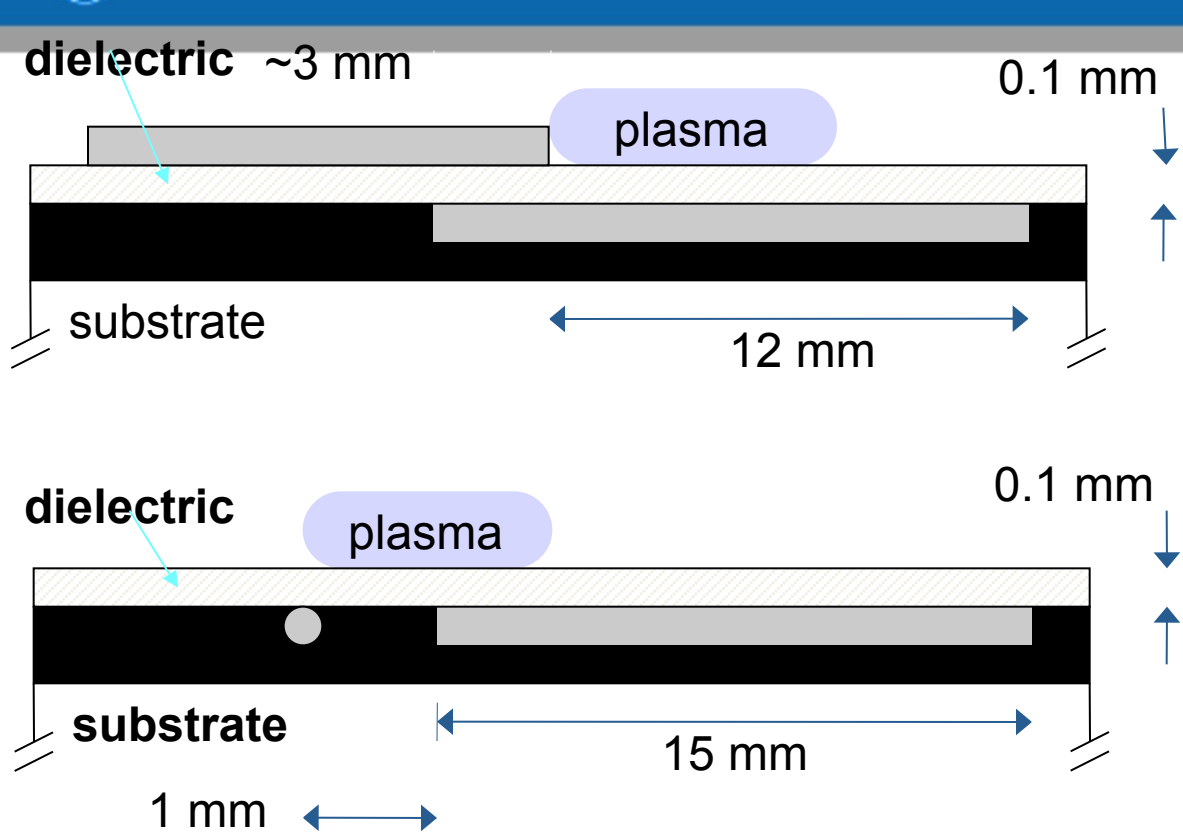
*(Courtesy of M. Gundersen – USC)*

**USC static reactor for studies of pulsed plasma induced ignition**



# Plasma-Aero Experimental System

University of Wisconsin (Madison) - Noah Hershkowitz

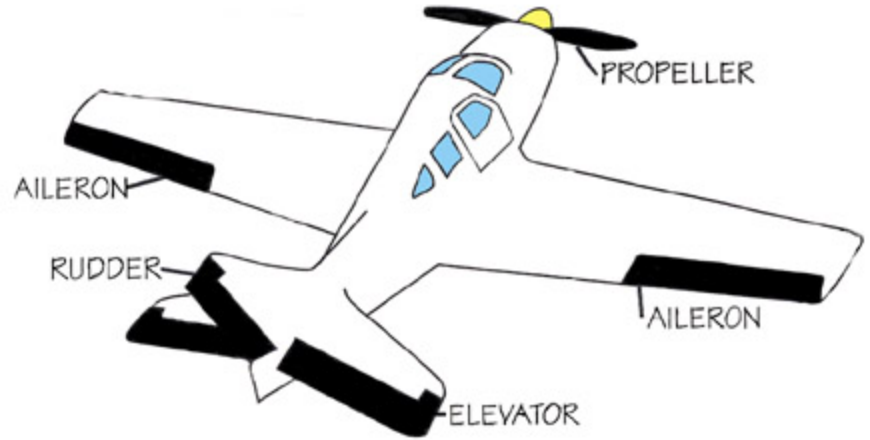
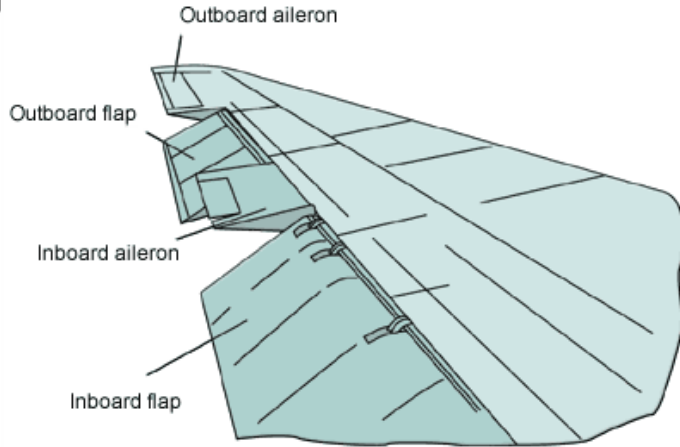


- Planar electrodes are 0.08 mm aluminum tape
- Wire electrode is 0.38 mm diameter copper wire
- Dielectric layer is 0.1 mm polyethylene,  $\epsilon \approx 3.2 \epsilon_0$





# Plasma Actuators – The future of Flying!?!



Applied Physics Group  
Princeton University



1 cm





# Plasma Actuators – The future of Flying!?!



Wing-less planes!!!

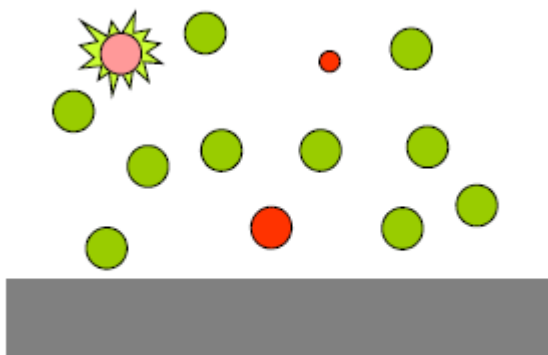


# Surface Effects of Microplasmas

*For instance, if we want to modify the surface of a material (e.g. a silicon wafer)*

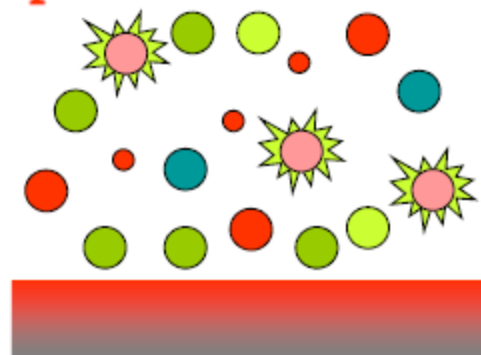
- Molecules
- Excited molecules
- Ions
- Electrons

gas



*Small changes at the surface*

plasma

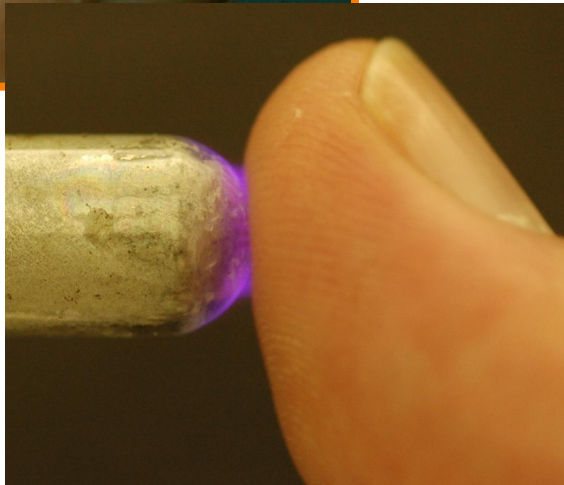
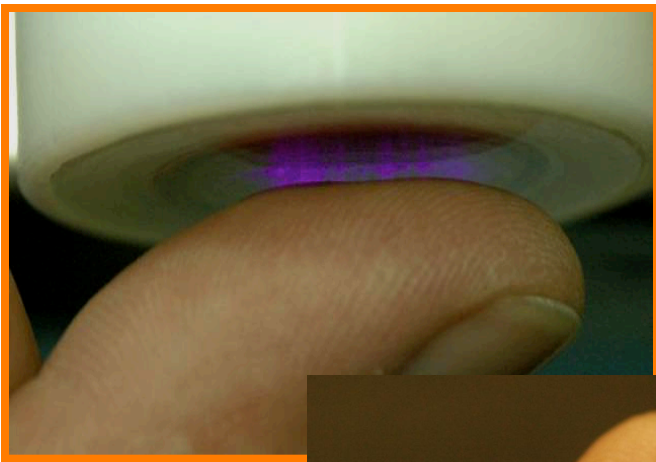


*Energy & reactive species can change the surface*

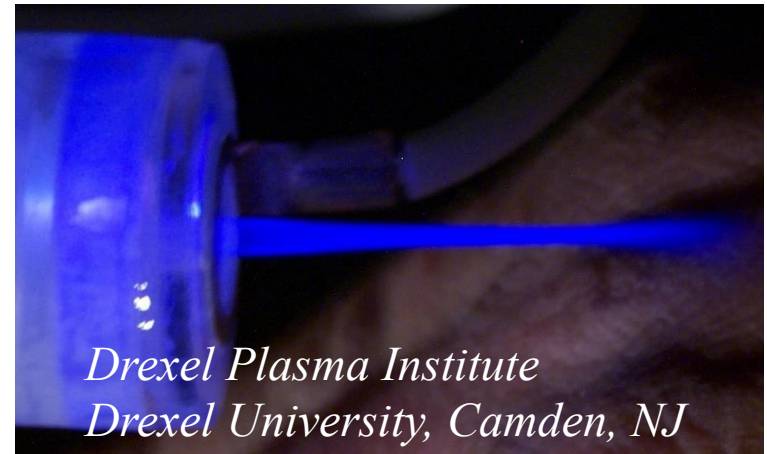


# Plasma Application in Medicine

Direct Plasma – Charges on Tissue,  
Produced In Air or Oxygen



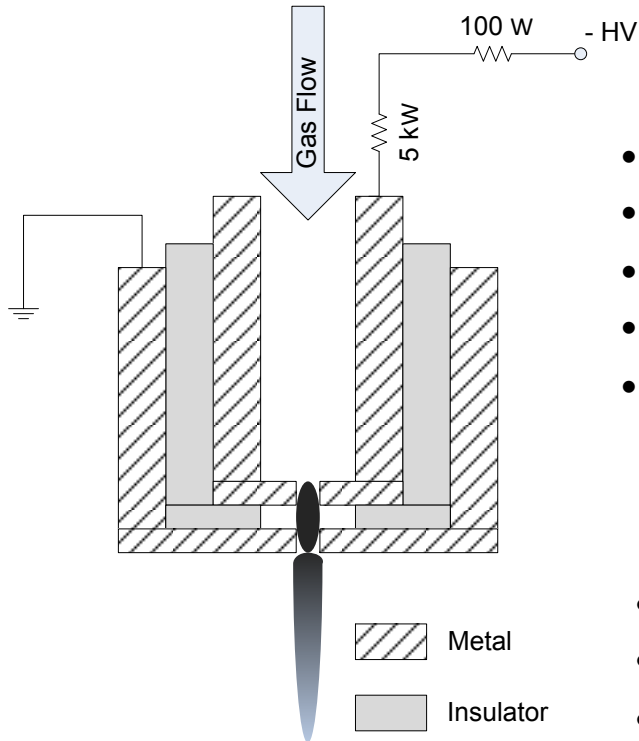
Indirect Plasma – Jet, Often  
NOT in OXYGEN







# DC MHCD Plasma Micro Jet



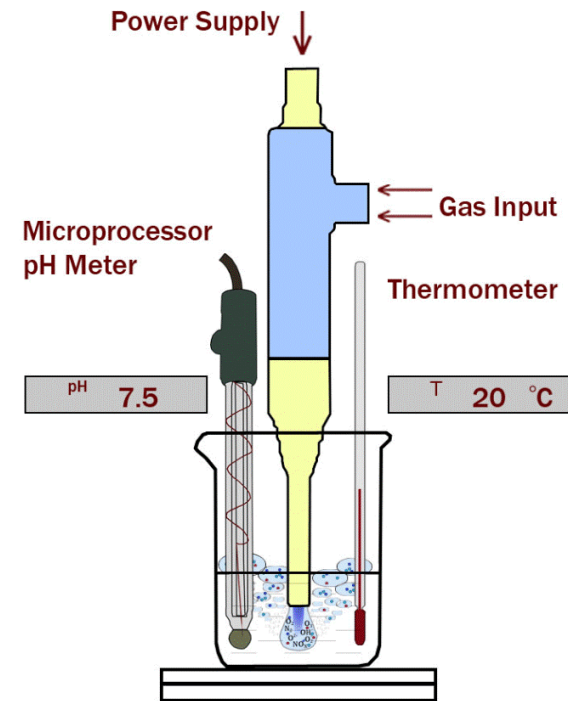
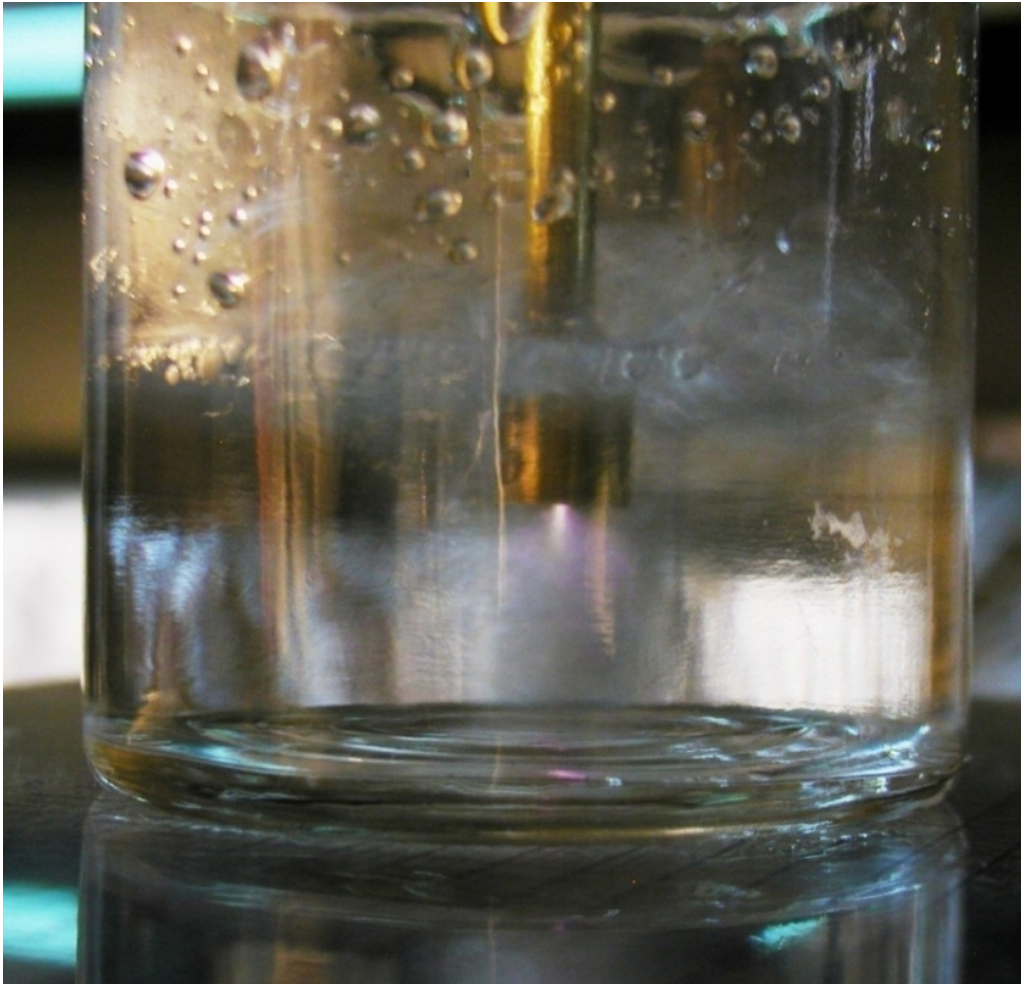
- Dimensions of the device are:
- Opening: 0.8 mm in diameter
- Separation: 0.5 mm
- Depth of exit opening: 1 mm
- Electrode material: copper

- Dimension of the plasma jet are
- ~ 800  $\mu\text{m}$  in diameter
- 8 -10 mm in length
- Flow rate: 2-3 SLM
- Power consumption: 8 W (400 VDC, 20 mA)





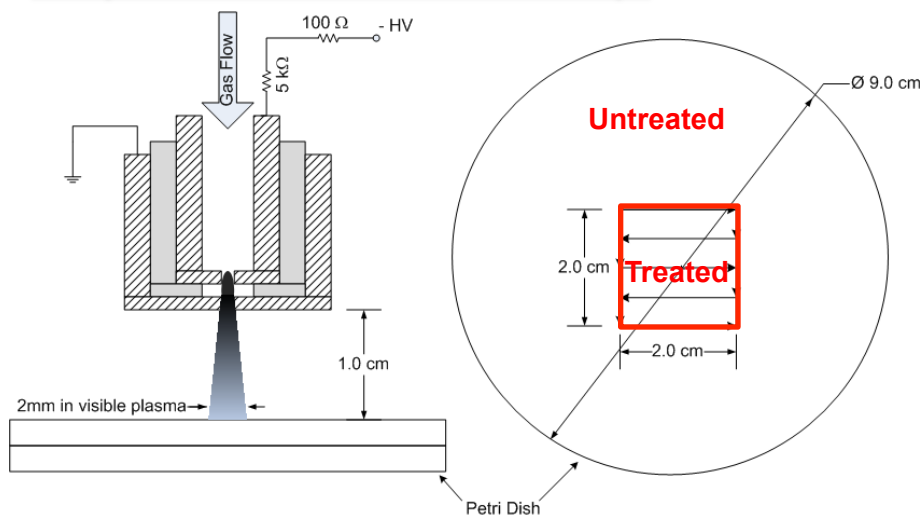
# Plasma Micro Jet Inside Water





# Inactivation of Bacteria

## Experimental Set-up



## Experimental Procedure

- Total path length: 120 mm
- Moving speed: 4 mm/s
- Time per path: 30 s
- Total treatment time: 30s / 60s / 90 s
- Area exposure/path: < 1 s (visible plasma), ~10 s (radical exposure)

	Bacteria	Gram stain
<b>A</b>	Escherichia coli	Negative
<b>B</b>	Staphylococcus aureus	Positive
<b>C</b>	Micrococcus luteus	Positive
<b>D</b>	Bacillus megaterium	Positive
<b>E</b>	Bacillus subtilis	Positive
<b>F</b>	Bacillus natto	Positive

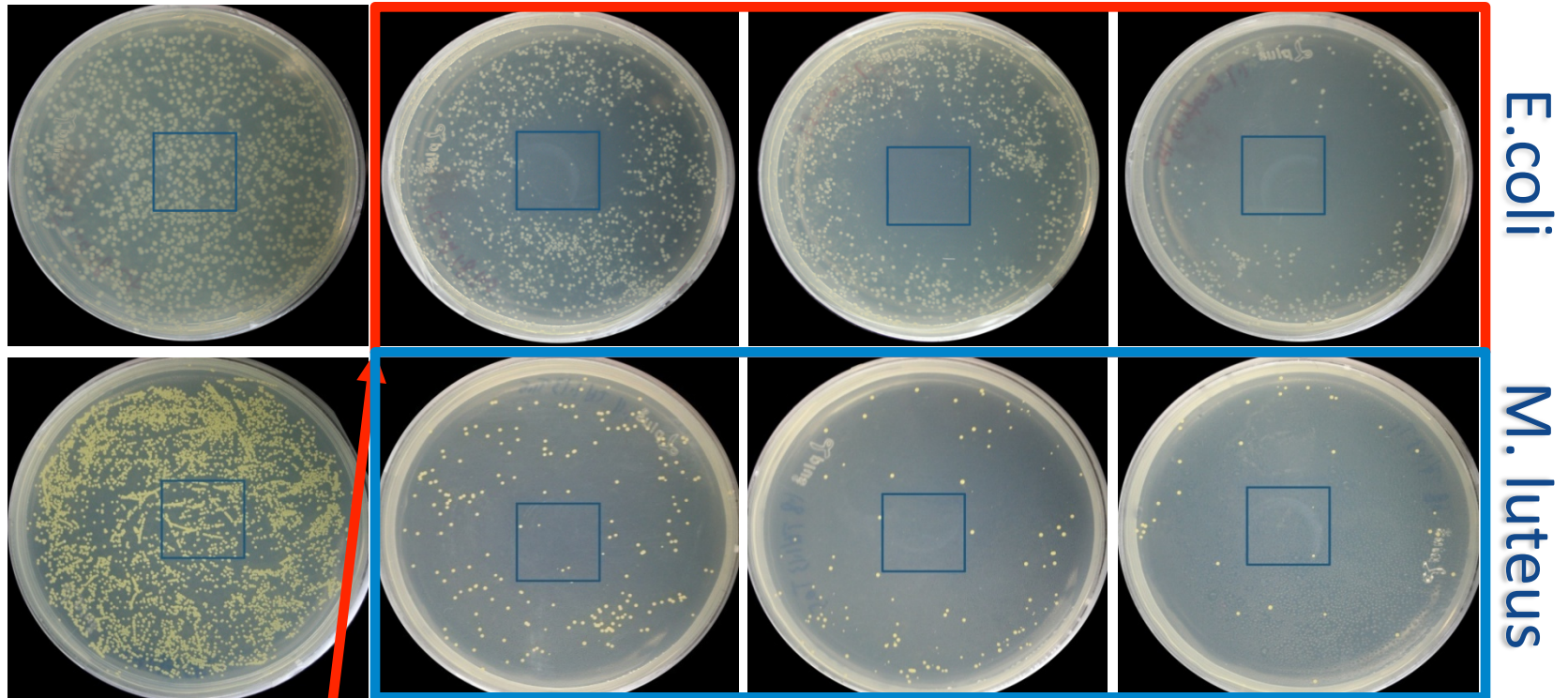
List of bacteria cultures studied







# Plasma Dose Effect



E.coli

M. luteus

Control

30 seconds

60 seconds

90 seconds

radially decreasing survival rate

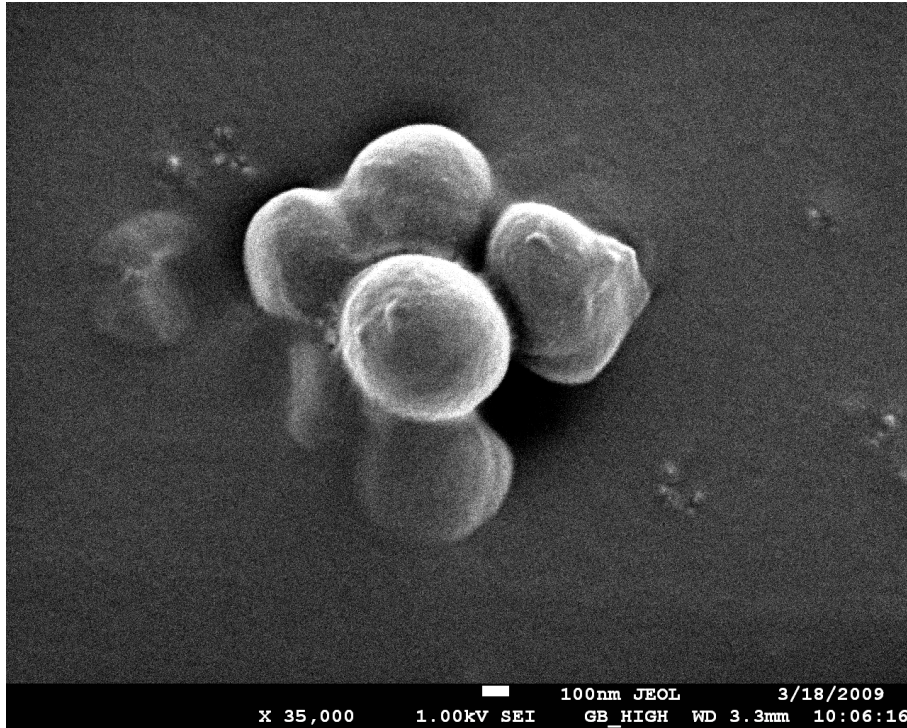
uniform decreasing survival rate



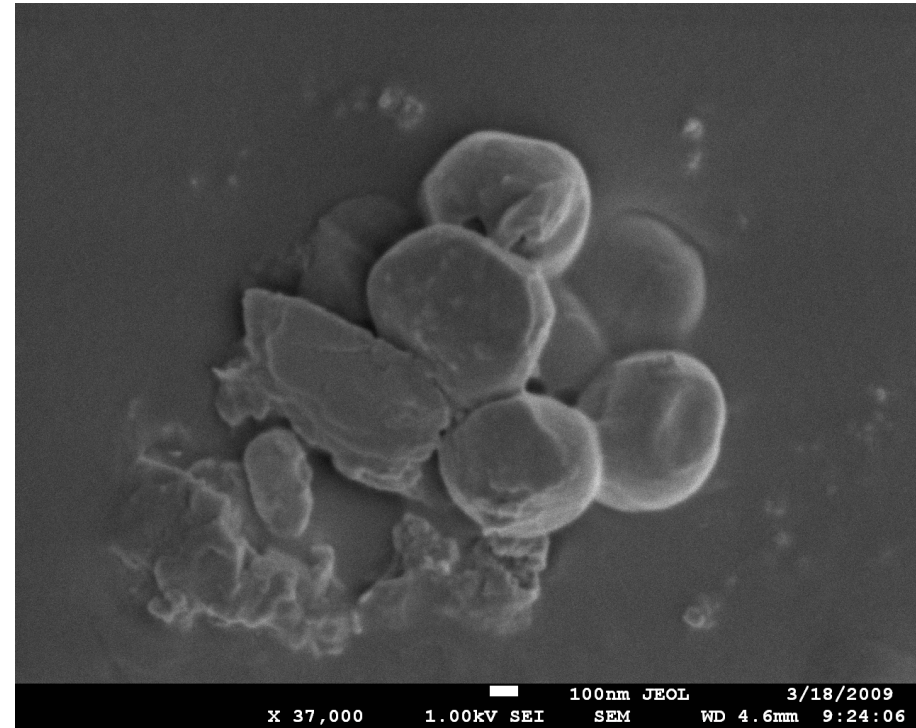


# SEM Pictures

SEM pictures of *S. aureus* before and after PMJ treatment



Control



PMJ treatment

SEM of PMJ treated *S. aureus* show clear poration on cell membrane as well as the change of the cell morphology.



# Living tissue sterilization without harm: Recent pig experiments



*Courtesy: Drexel Plasma Institute*





# Hemostasis and coagulation in Hairless mice, not immunocompromised (SKH<sub>1</sub>)



Saphenous vein cut: without plasma animal continues to bleed for 10-20 minutes.

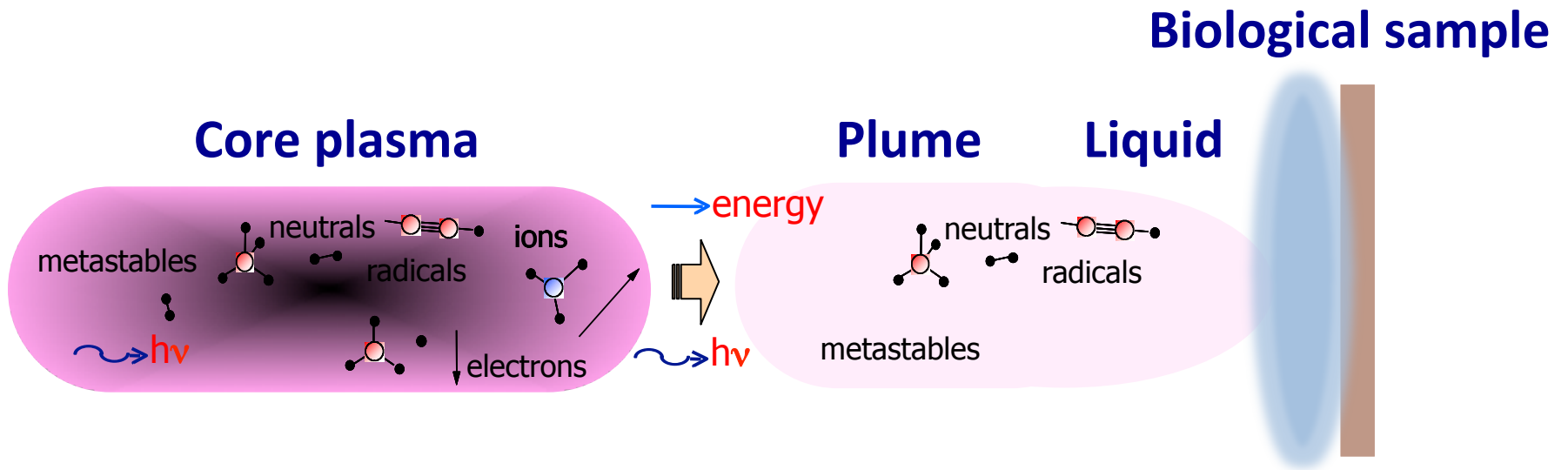
15 seconds of FE-DBD clots the blood and seals the vessel without damaging tissue, preventing additional bleeding.

*Courtesy: Drexel Plasma Institute*





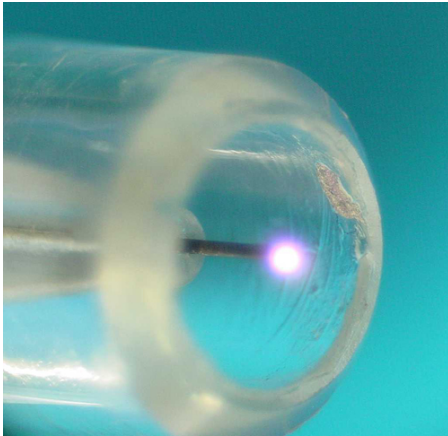
# Biological Mechanisms: Plasma Interference into Natural Intracellular Biochemistry







# Dental Application



## Cleaning of Dental Cavities

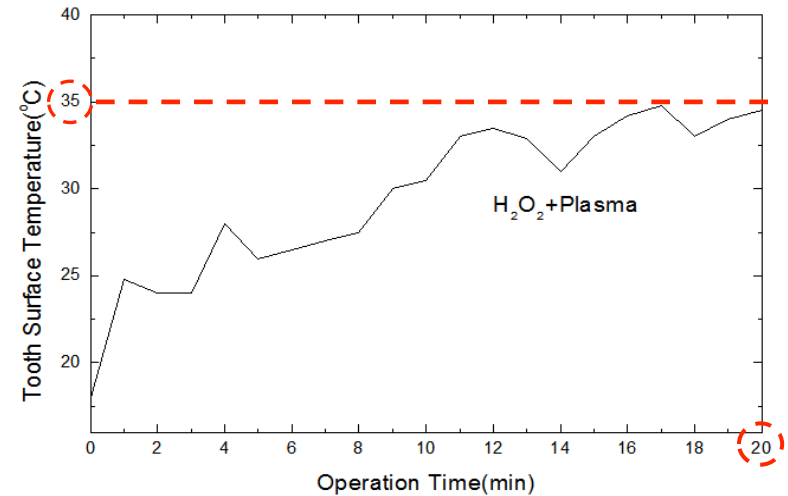
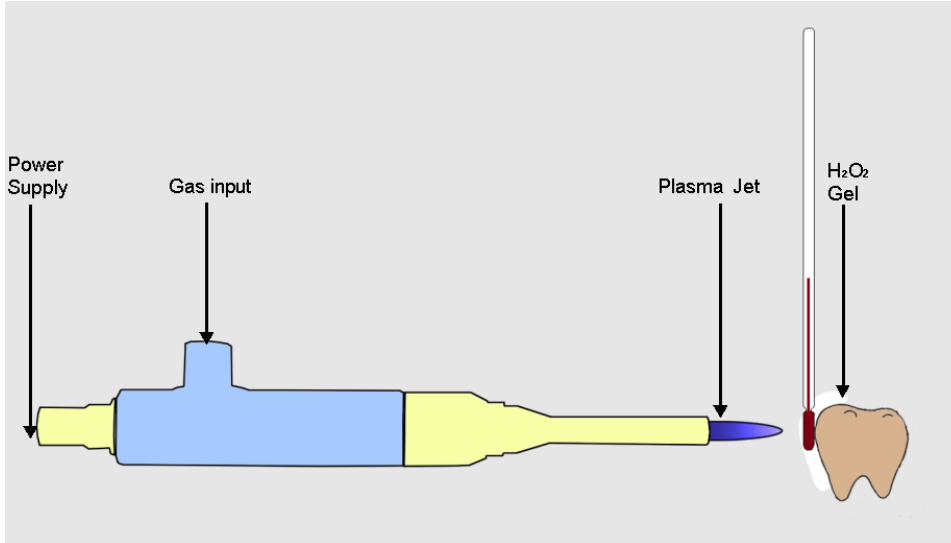
### Other Applications

- Bio Decontamination
- Sterilization of Medical Instruments and Wounds





# Teeth Whitening with non-thermal plasma



- The plasma jet did not heat tooth surface over **37 degrees**.
- Heating the tooth over **42 degrees** can causes severe damages to the nerves inside a tooth.

**“No thermal-damages”**



# Teeth Whitening with non-thermal plasma



H<sub>2</sub>O<sub>2</sub>  
before

20min

H<sub>2</sub>O<sub>2</sub>  
after



Plasma+H<sub>2</sub>O<sub>2</sub>  
before

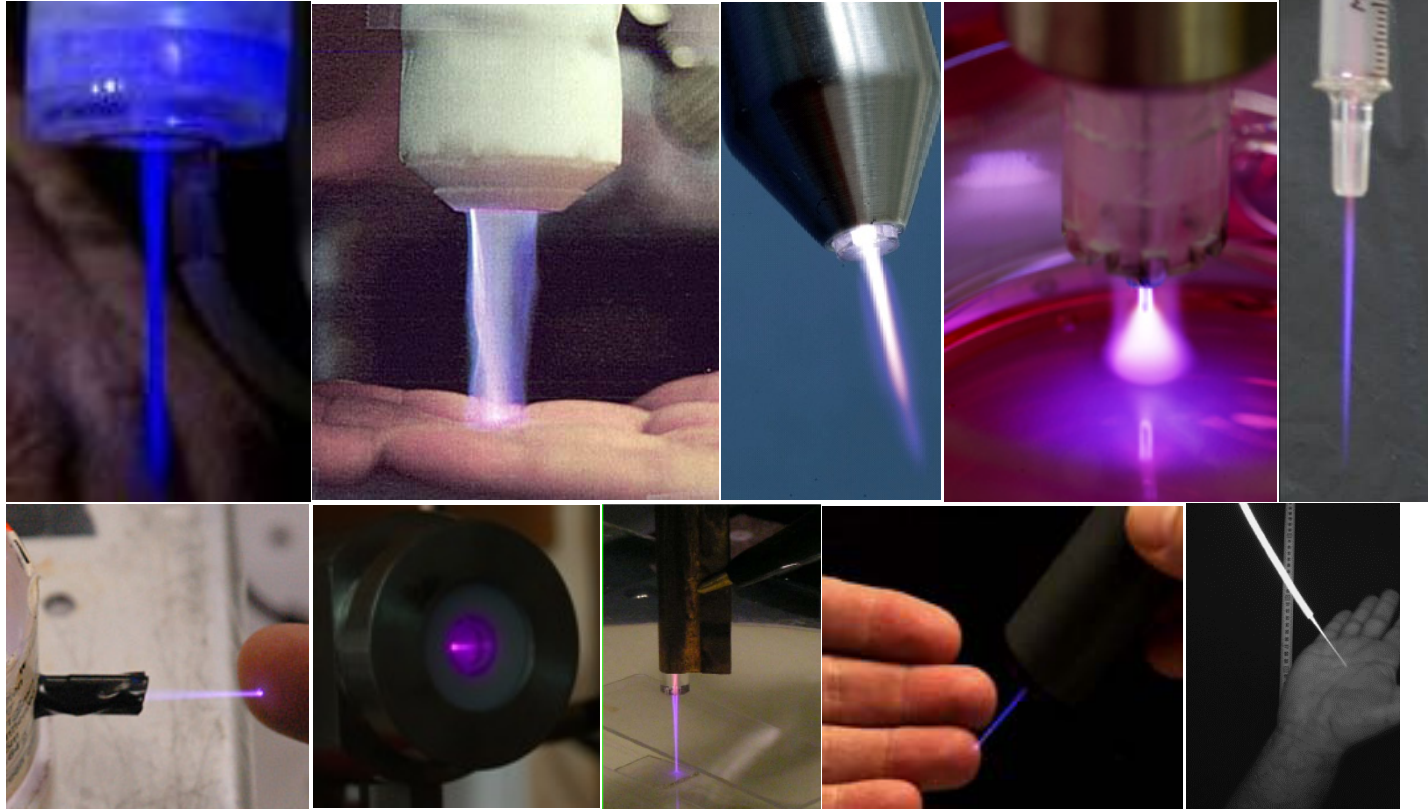
20min

Plasma+H<sub>2</sub>O<sub>2</sub>  
after





# A Brief Collection of Atmospheric Pressure Plasma Jets (APPJ)



Gases used: Helium, Argon... or mixed with reactive gases ( $O_2$ ,  $CH_4$ ...)

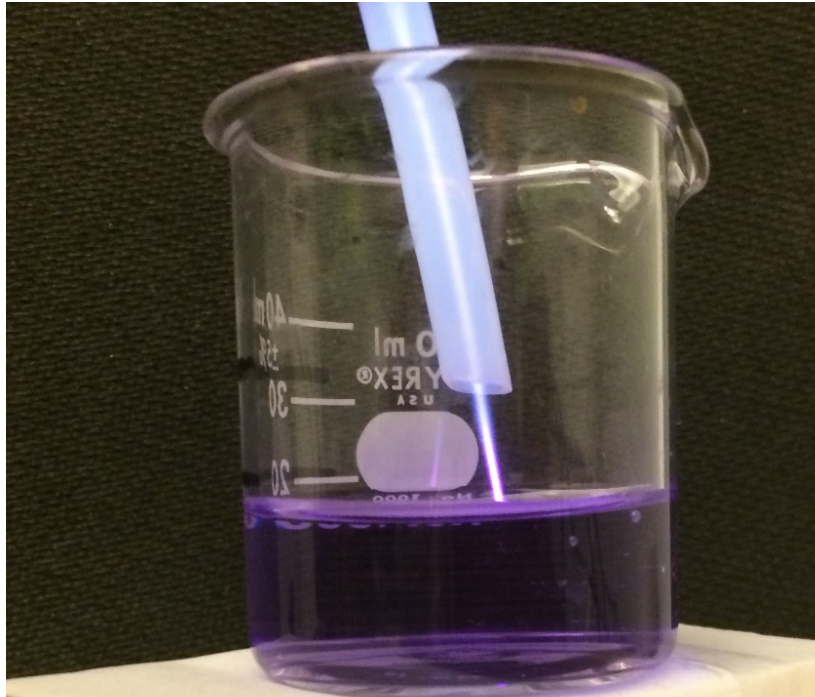
AC, pulsed DC, rf or microwave



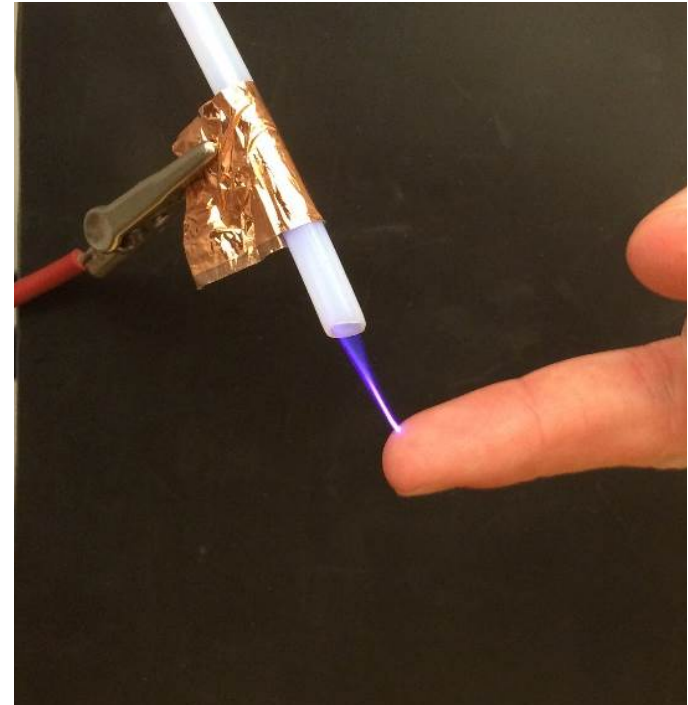




# Our Version of the Atmospheric Pressure Plasma Jet



Interaction with aqueous environments



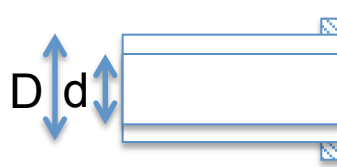
Interaction with organic surfaces



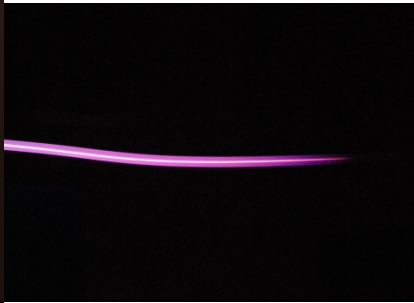
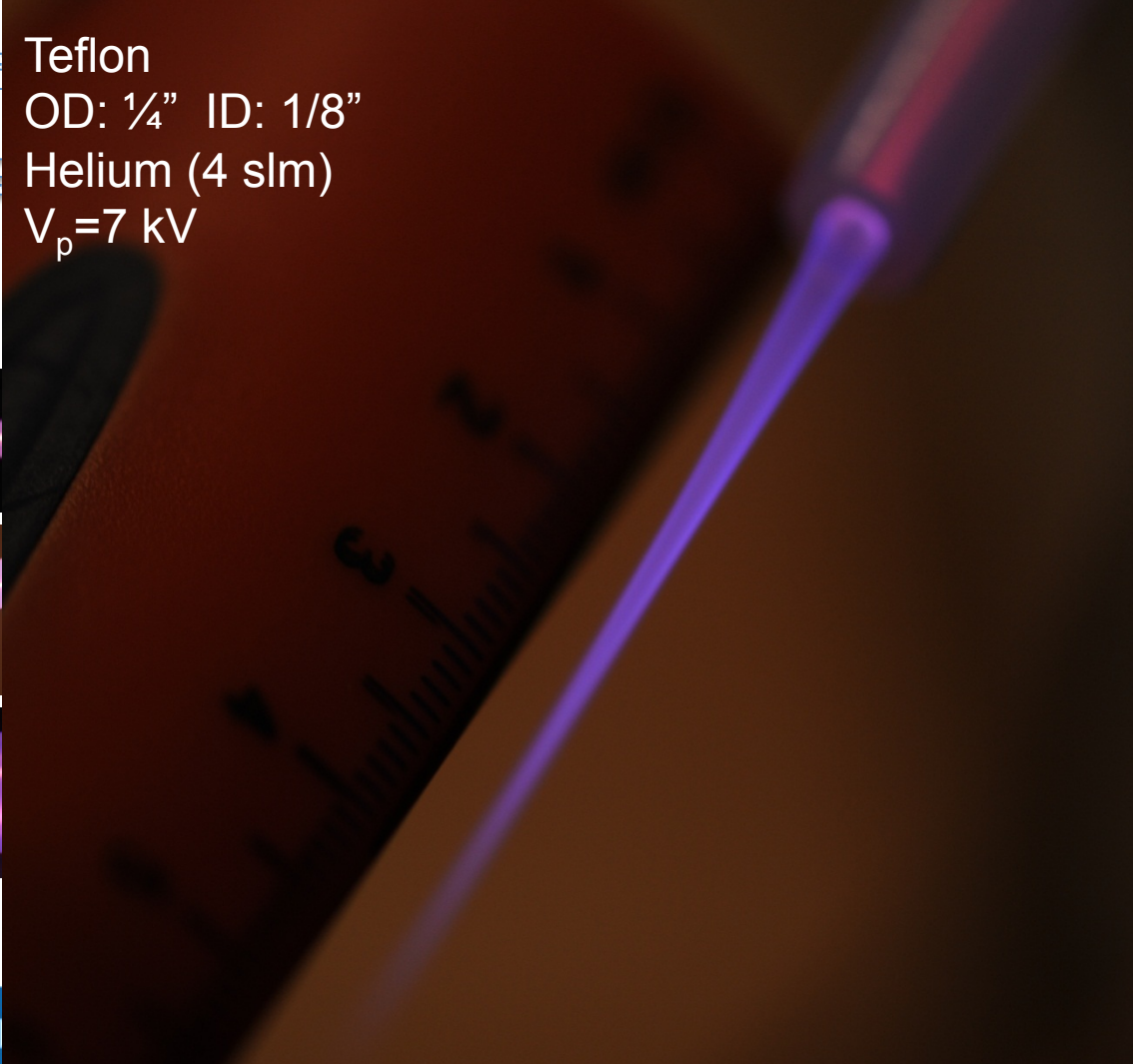
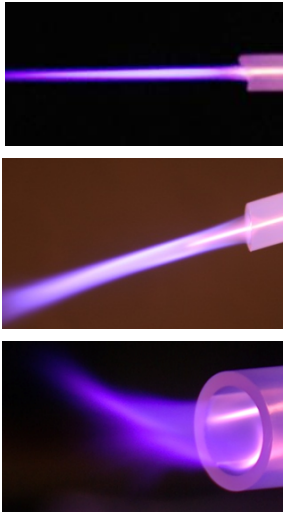
# Our Version of Atmospheric Pressure Plasma Jet

We couldn't resist to try it out...

- Tubing material: Glass, Teflon, Peek (D: 0.0625-0.5")
- Tape (1" wide)
- 96%),
- 6%)
- -15 kV



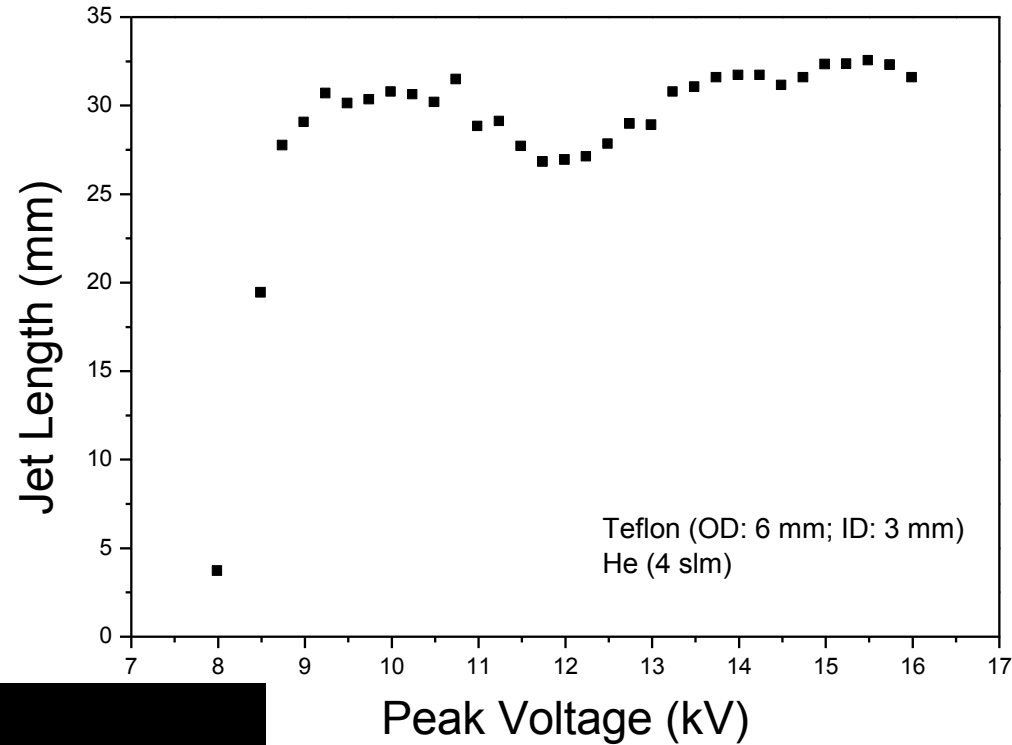
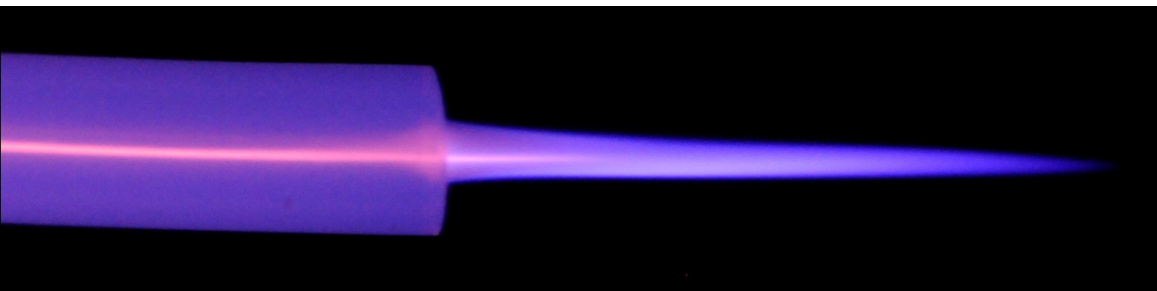
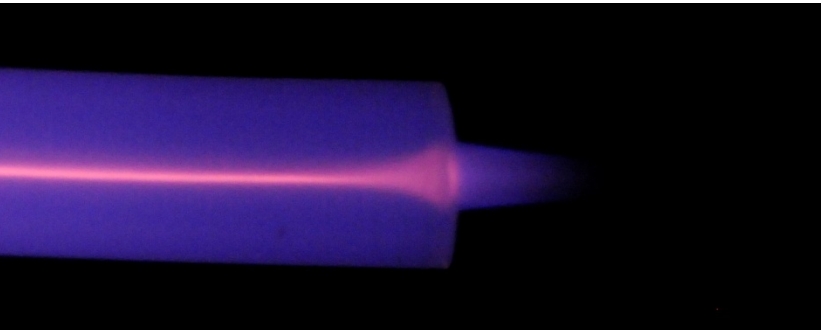
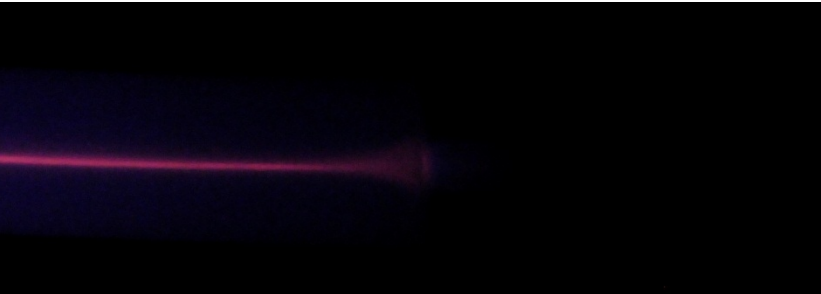
Teflon  
 OD: 1/4" ID: 1/8"  
 Helium (4 slm)  
 $V_p = 7$  kV



and downstream



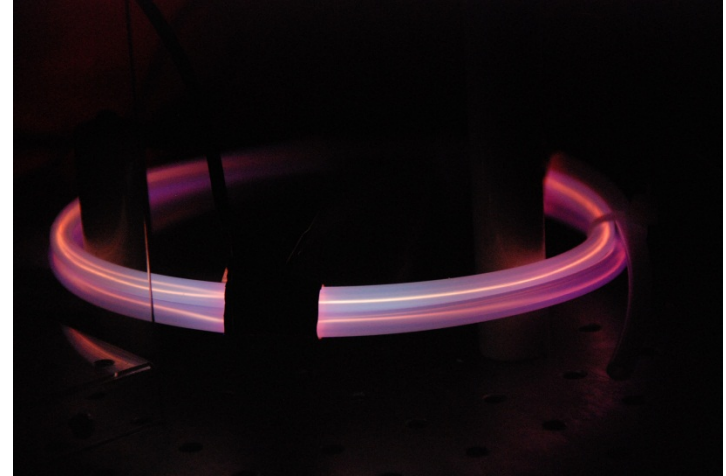
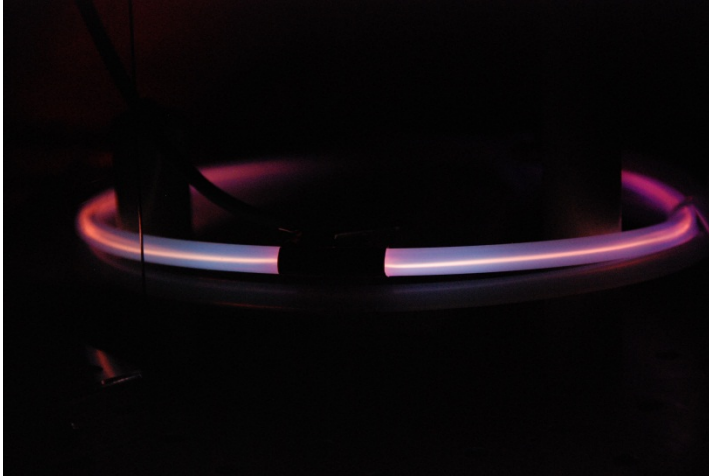
# Jet Length vs. applied voltage







# Plasma in a Curved Teflon Tubing

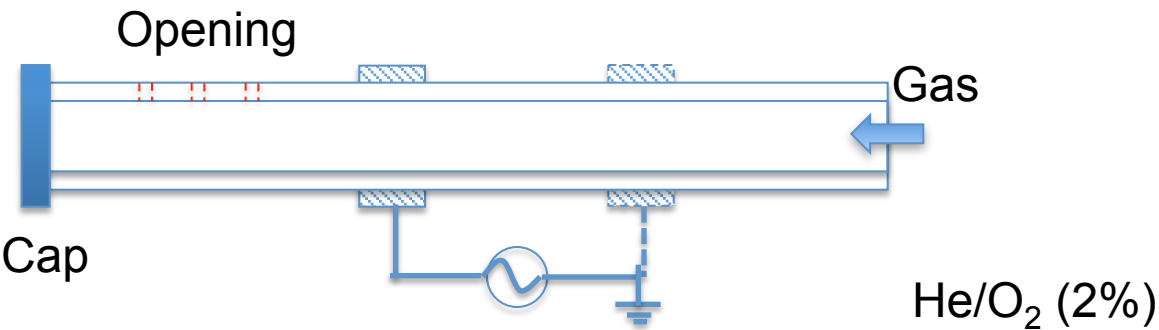


Distance the streamer can travel inside the insulating tubing depends on applied voltage, location of the powered electrode, type of working gas.

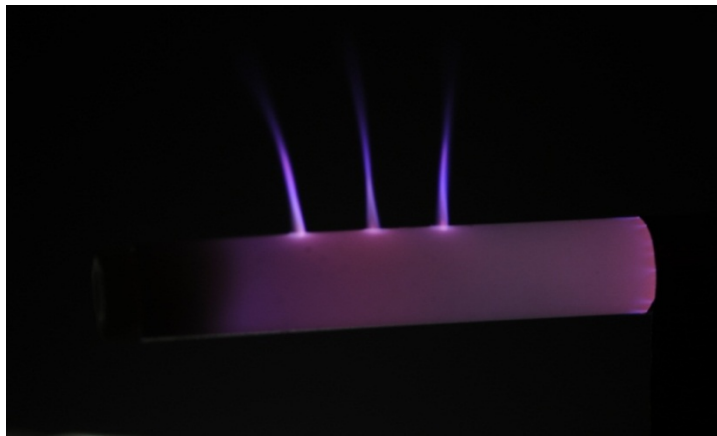




# Move plasma jets in multiple directions

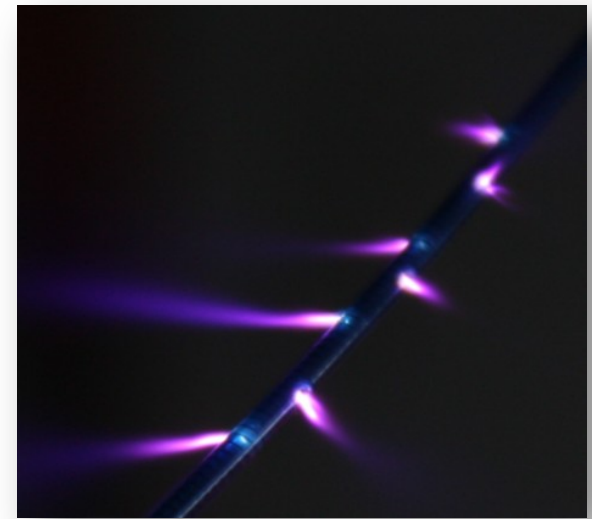


He/O<sub>2</sub> (2%)



Pure helium (8 slm);  
Teflon tube (OD=1/2"; ID=1/4")  
3 holes (diameter: 1/16") on side wall

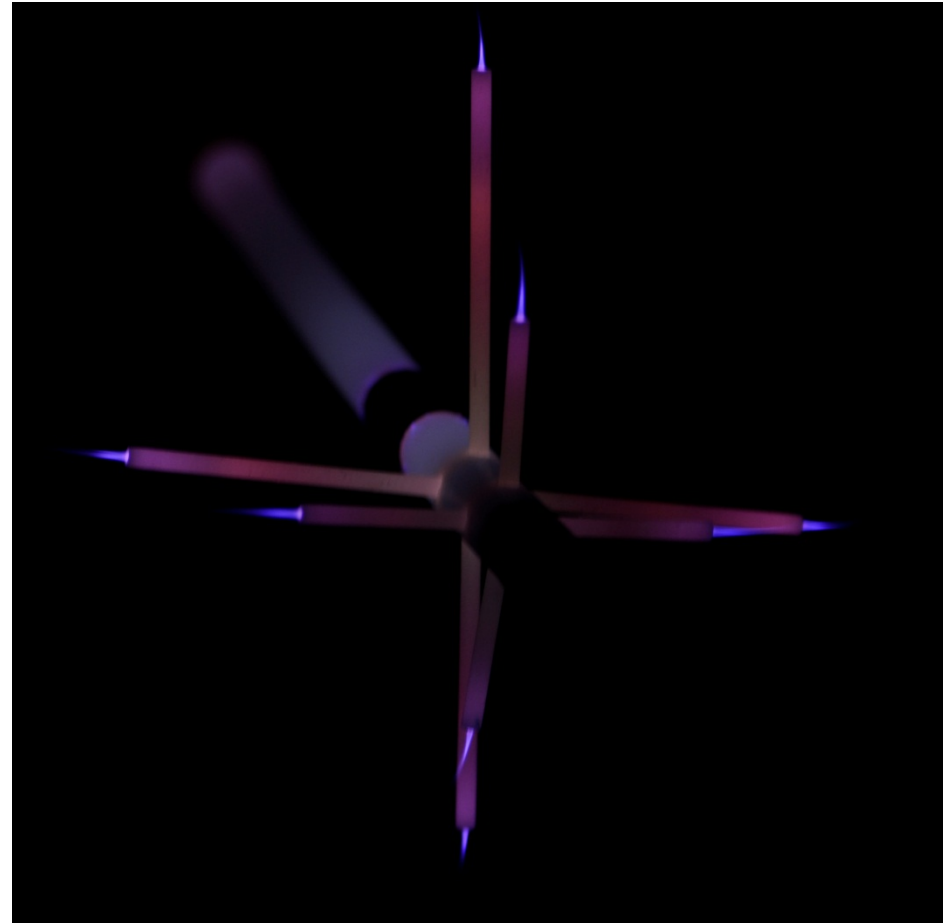
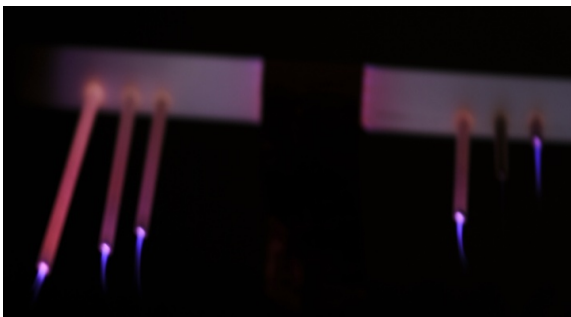
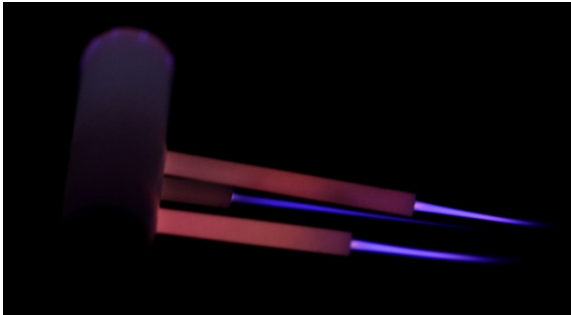
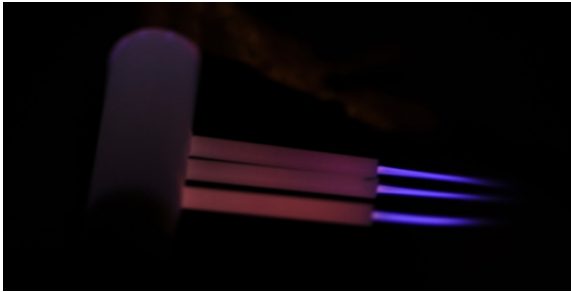
3-D Arrays!



Plasma Jet Array



# Further Extension of these Plasma Jets

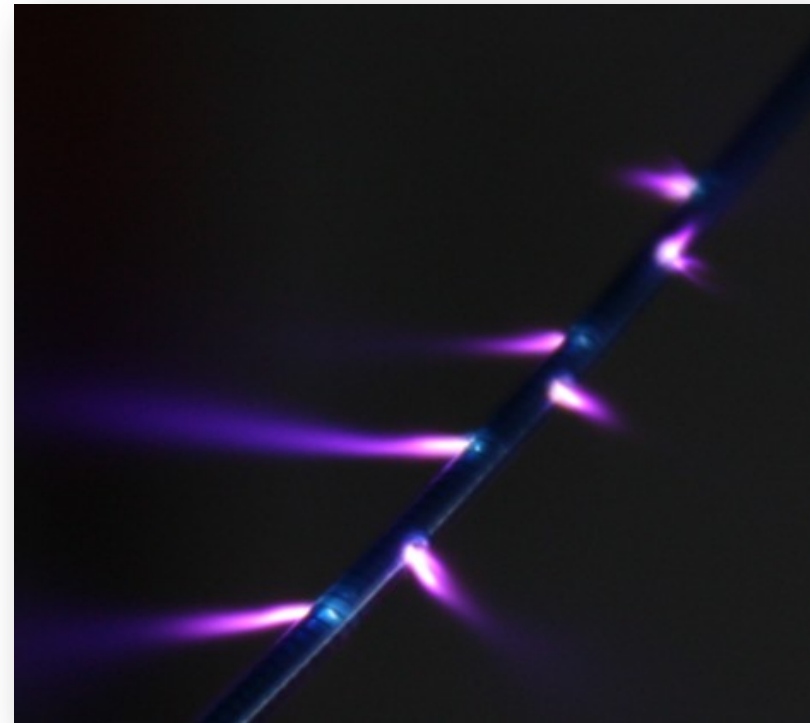




# Irrigation: Water & Plasma



**Water irrigation** in fields and greenhouses



**Plasma irrigation** for agriculture



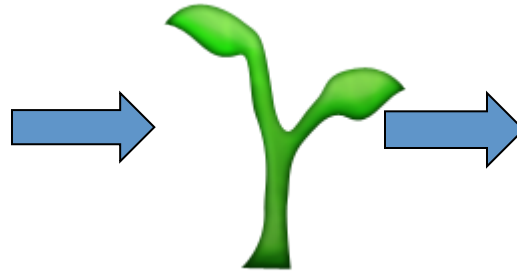




# Plasma Processing: Experimental Plan

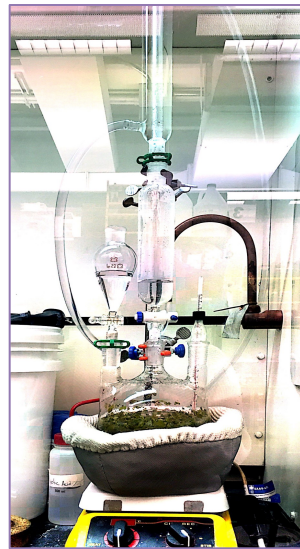


Harvest



Plasma  
Treatment

Measure  
Plants



Distillation

Antioxidant Testing

GC-MS





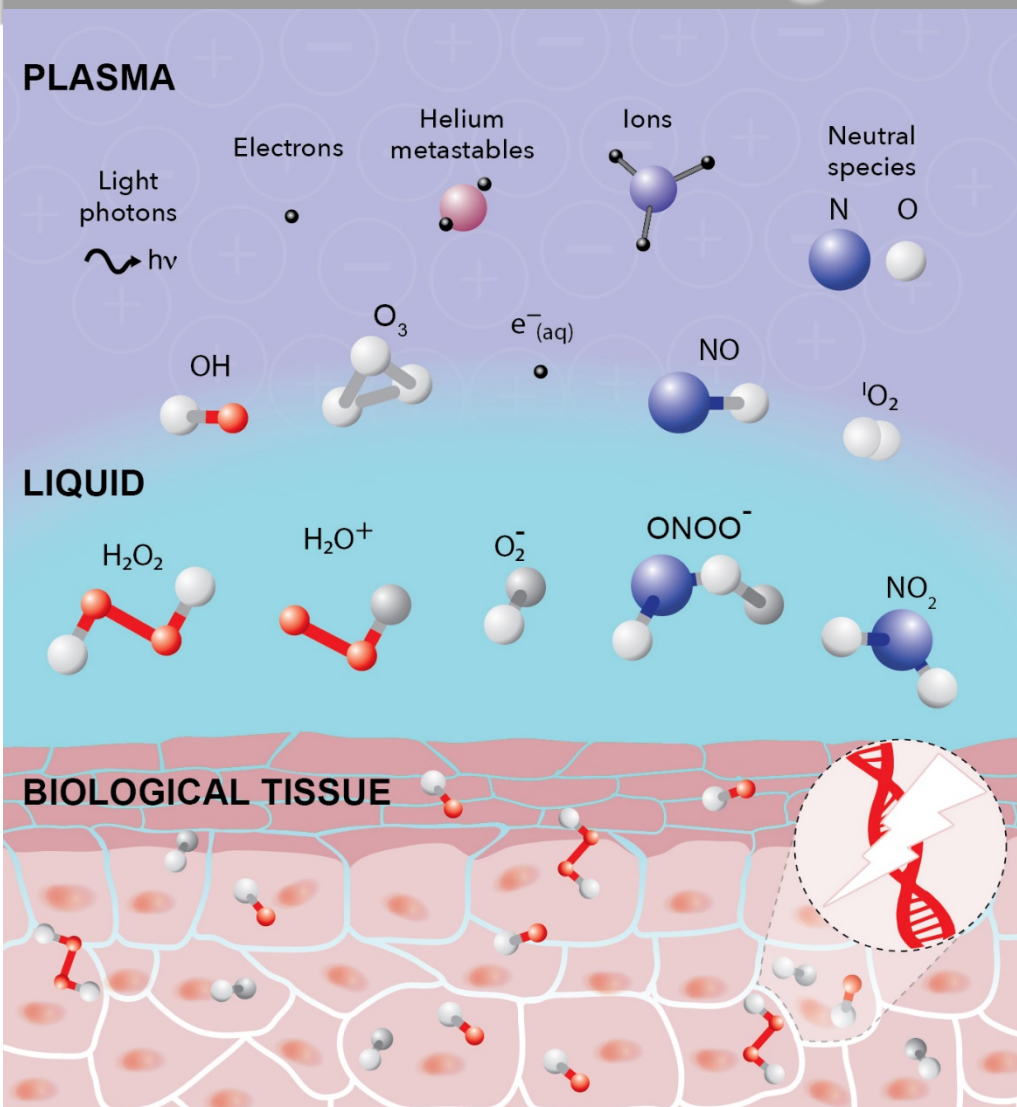


# Basil: Plasma Treated vs. Untreated





# Microplasma interaction with biological materials???



Many unanswered questions as to the role of plasma in the biological interactions with biological materials.

- What are the microplasmas doing to the live biological materials?
- Can microplasma sources be tailored to better control interactions with biological materials?





# Many, many Innovative Technologies...



Gas Laser



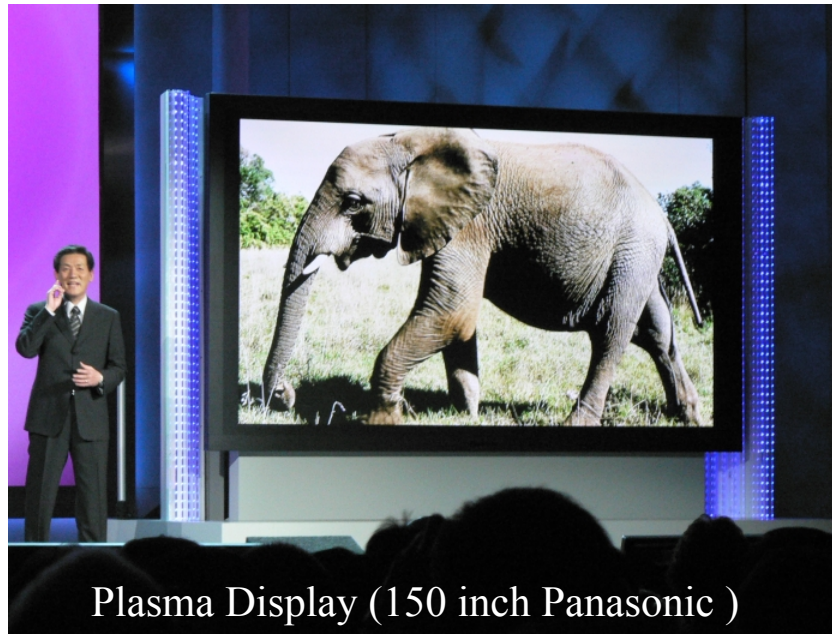
Ozone generator



High Intensity Plasma Arc Lamp



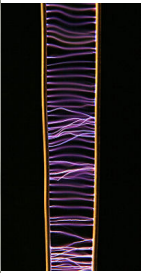
Plasma Surface Treatment



Plasma Display (150 inch Panasonic )



Fluorescent Lamp



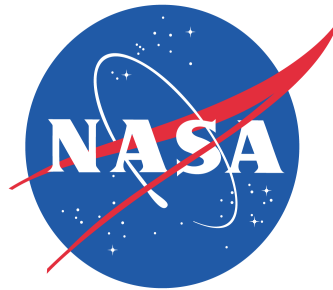
Spark Gap





# Acknowledgements

## Funding Partners:







# *8<sup>th</sup> International Workshop on Microplasmas (IWM 2015)*



**Seton Hall University – May 11-14, 2015**



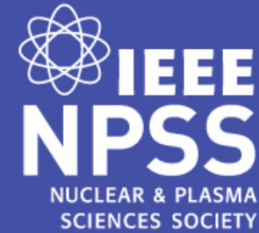
# ICOPS<sup>44<sup>TH</sup></sup>

INTERNATIONAL CONFERENCE ON PLASMA SCIENCE

General Chair - Jose Lopez, Seton Hall University

Technical Chair - Kurt Becker, New York University

ICOPS2017@ieee.org



May 21-25  
2017







# The future ain't what it used to be...

....Yogi Berra





# Questions???







# *Thank You!*

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